

# Probing Functional Interfaces

## Lesson 10

MSE 304

Nako Nakatsuka

Nako.Nakatsuka@epfl.ch

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# Plan of the Course: Fundamentals, Characterization, and Applications

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1: Intro to Surfaces & Interfaces

2: Surfaces in the Real World - Adsorption

3: Surface Energetics & Interfacial Phenomena

4: Atomic Structure of Real Surfaces

5: Solid-Solid Interfaces

6: From Ideal Planes to Real Materials (Recap)

7: Characterization of Surfaces & Interfaces

8: Surface Chemistry

9: Surface Patterning and Polymer Chemistry

10: Probing Functional Interfaces

11: Applications of Surfaces & Interfaces

12: Biosensor Fundamentals

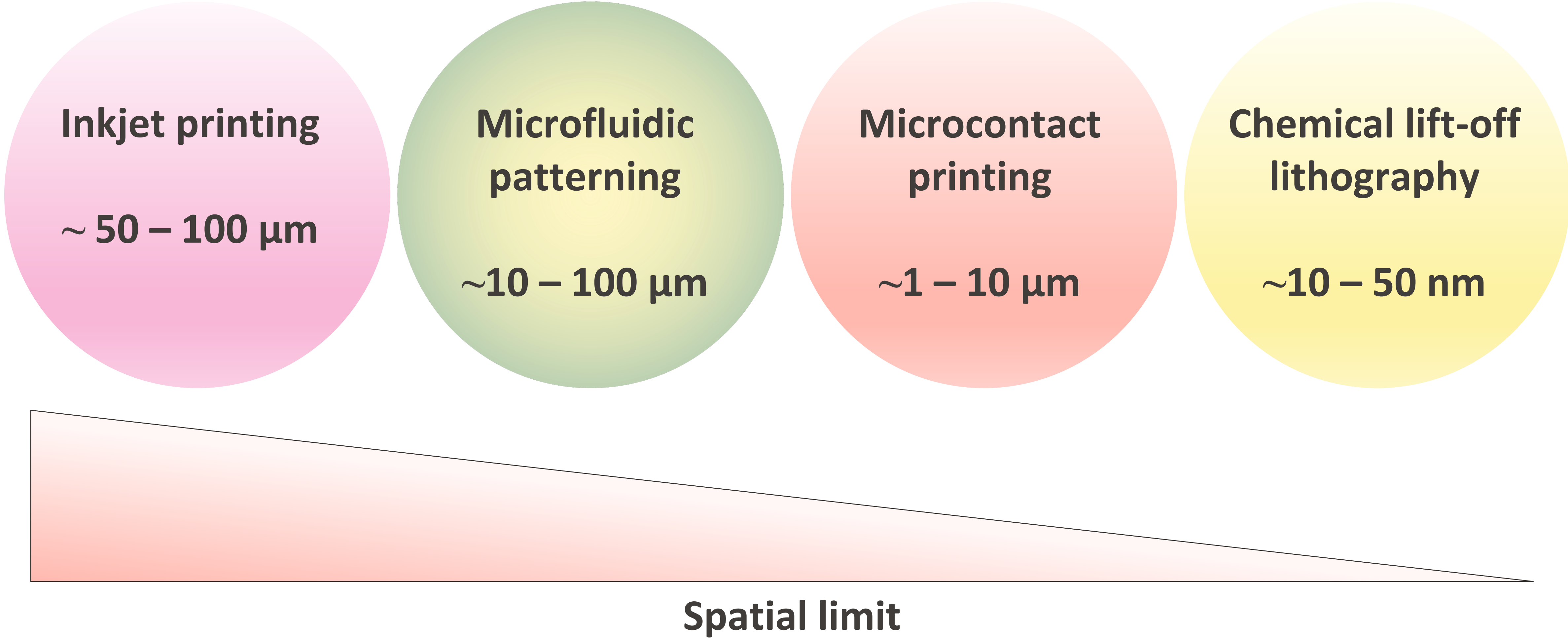
13: Biosensing applications

14: Chemistry of Semiconductor Surfaces & Beyond



# Recap from Lesson 9: Patterning for Spatial Control

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# Recap from Lesson 9

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- Functional groups on assembled monolayers (SAMs) can be coupled to other biomolecules
- Nonspecific protein binding on surfaces governed by thermodynamic mechanisms that is surface dependent (neutral, charged, zwitterionic)
- We can control protein adsorption through polymer brushes with specific properties
- We discussed the challenges (biosensing) and opportunities (lubricant) of protein adsorption



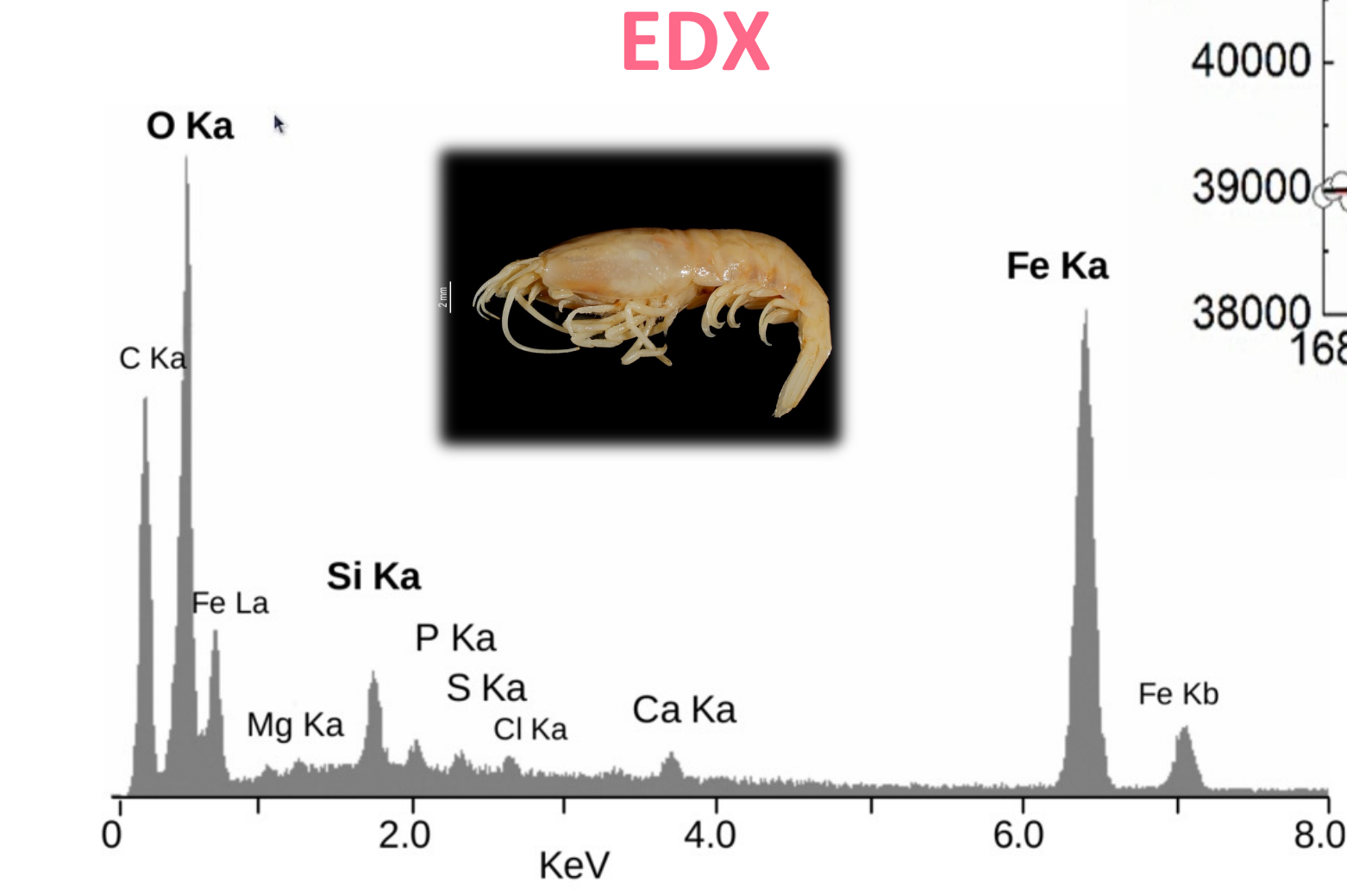
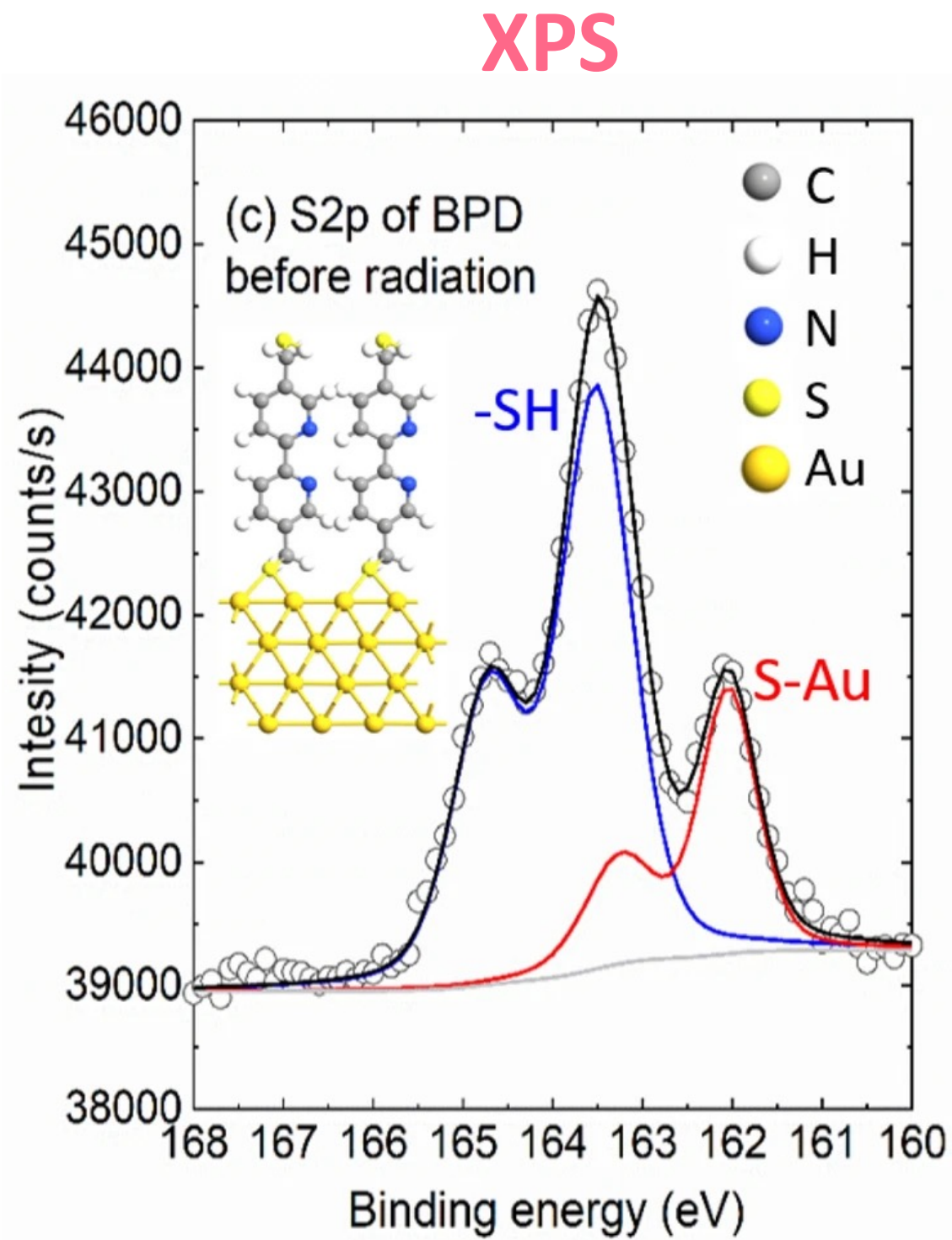
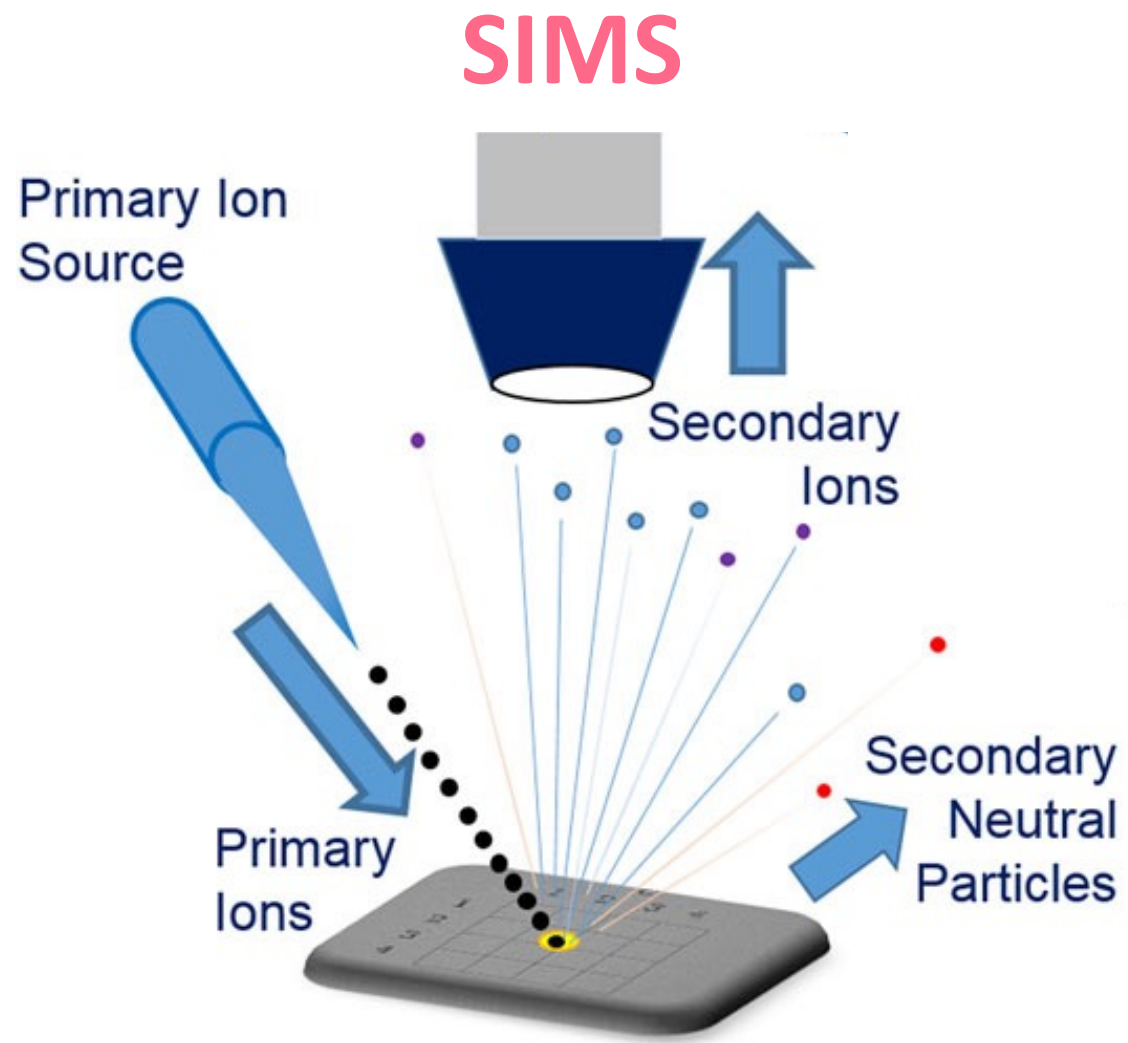
# Outline of Lesson 10

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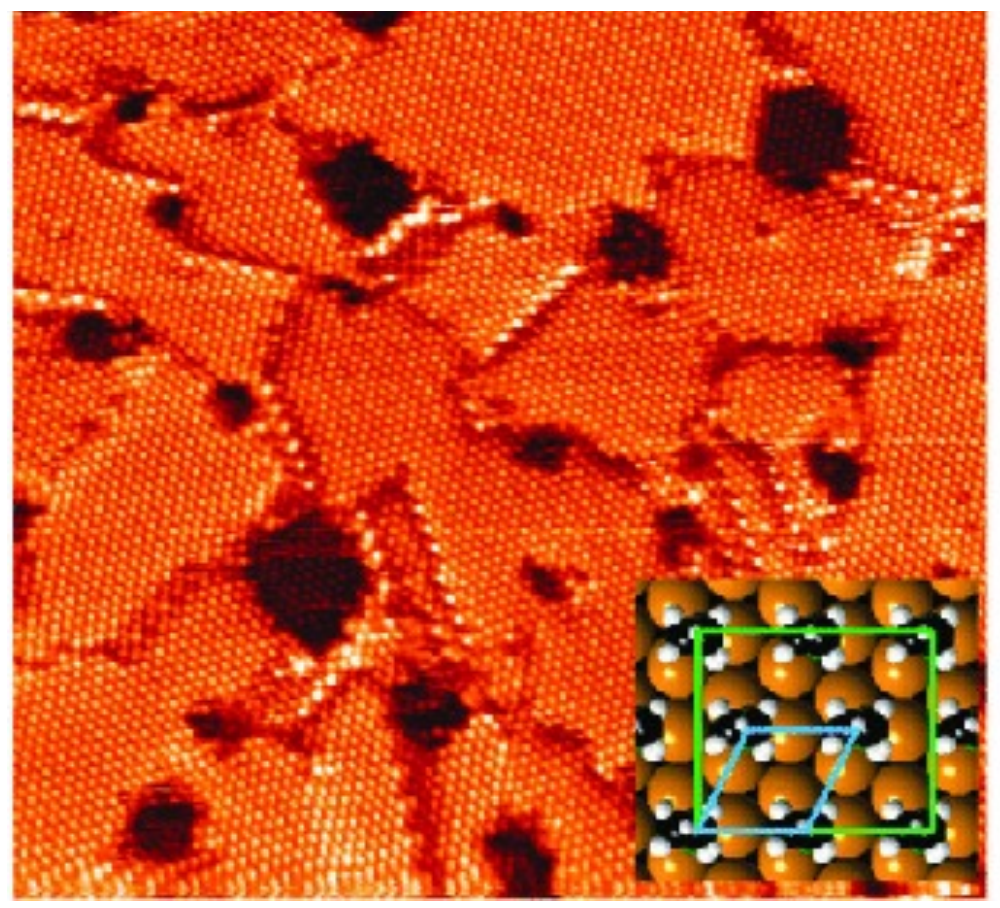
- Characterization techniques that enable extraction of surface properties
- **Atomic force microscopy** – from images to mechanical interactions
- **Fluid force microscopy** – interacting with cells
- **Quartz crystal microbalance** – monitoring surface dynamics
- **Ellipsometry** – measuring thickness of surface layers
- **Surface plasmon resonance + optical waveguide lightmode spectroscopy**



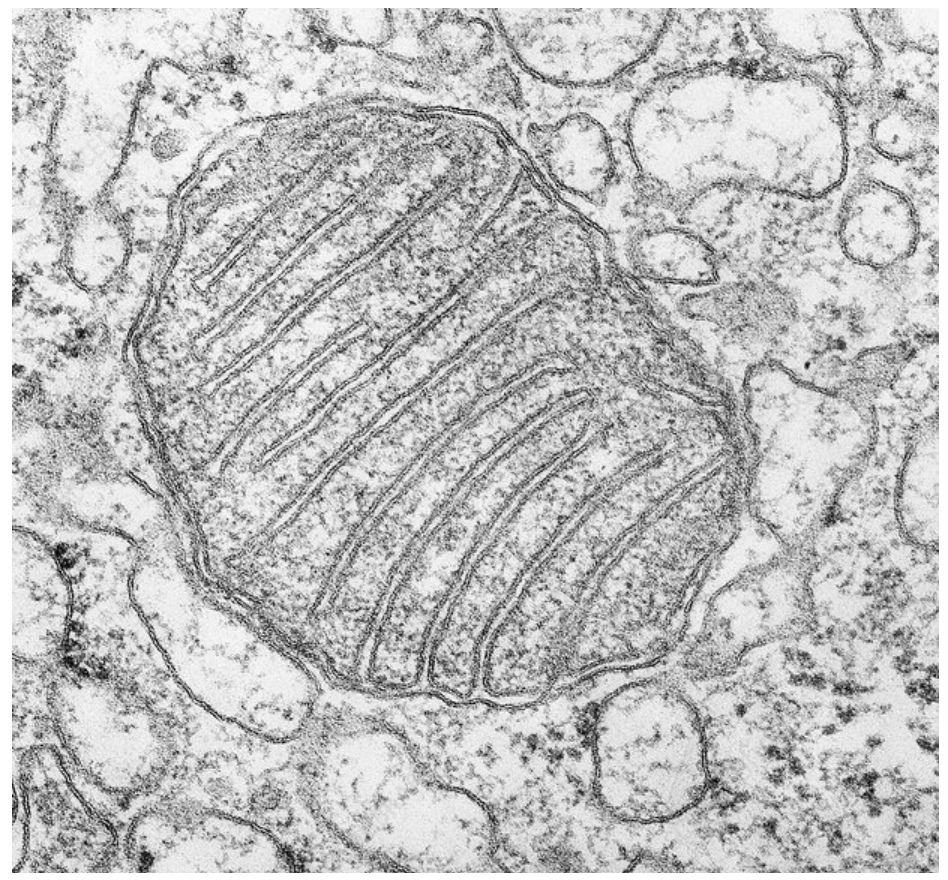
# We Have Seen Many Surface Characterization Tools So Far...



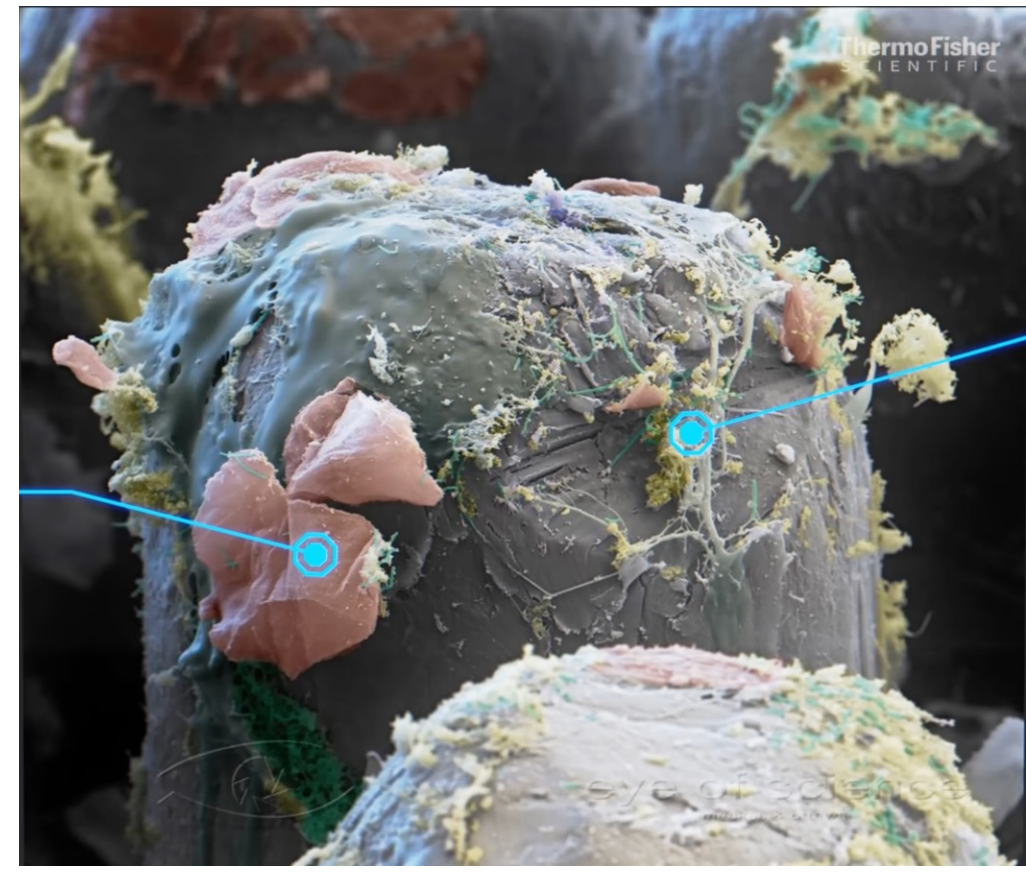
**STM**



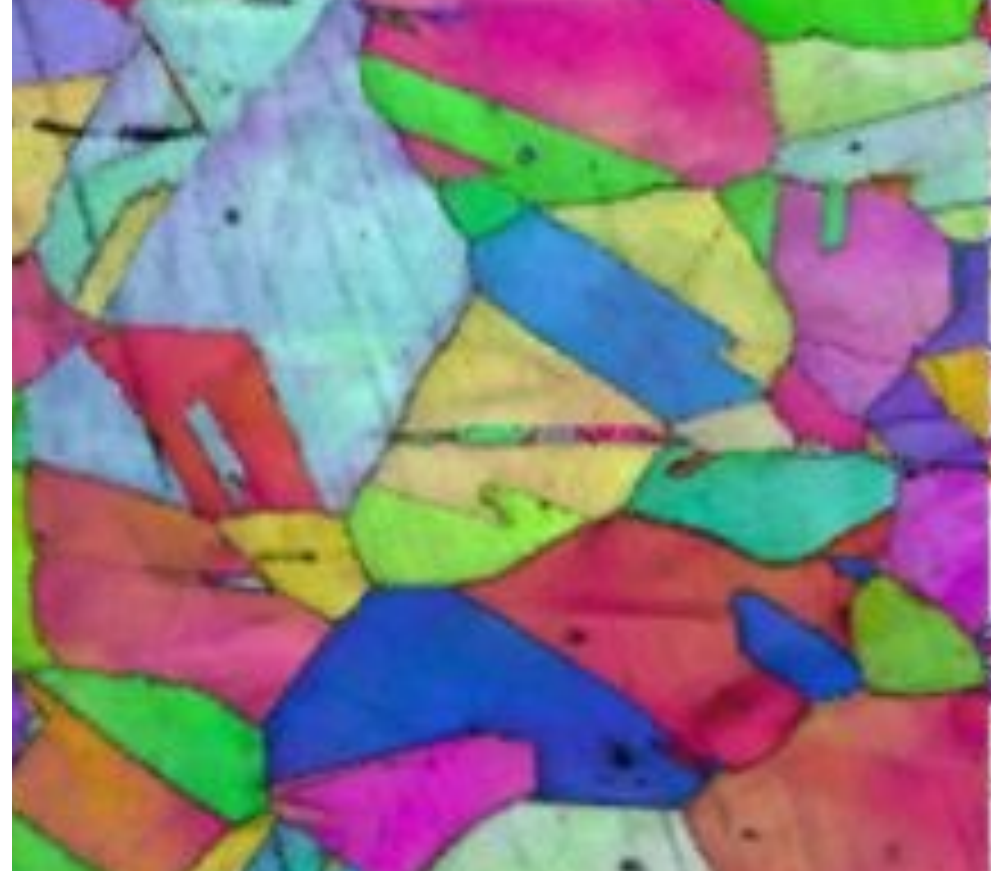
**TEM**



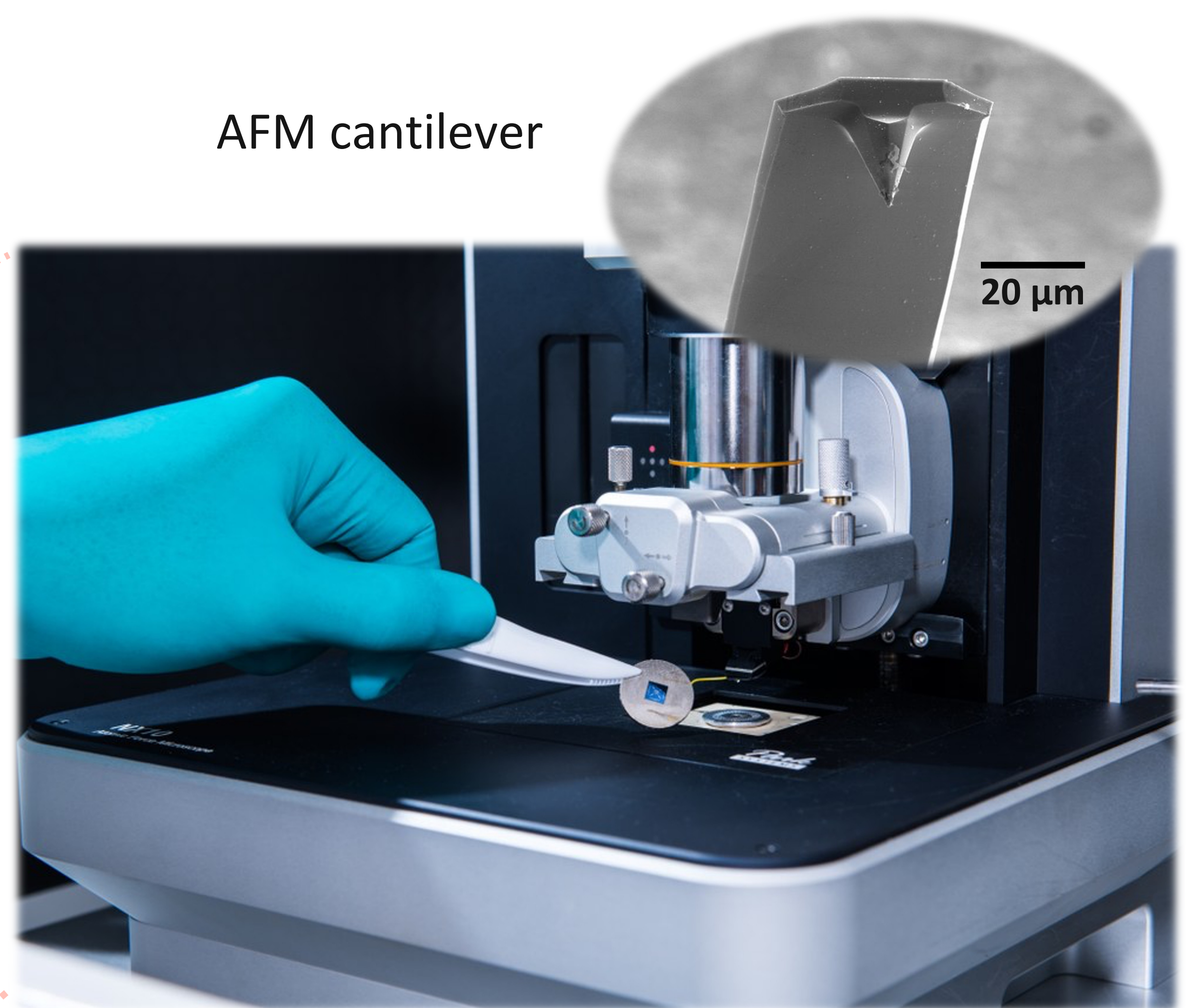
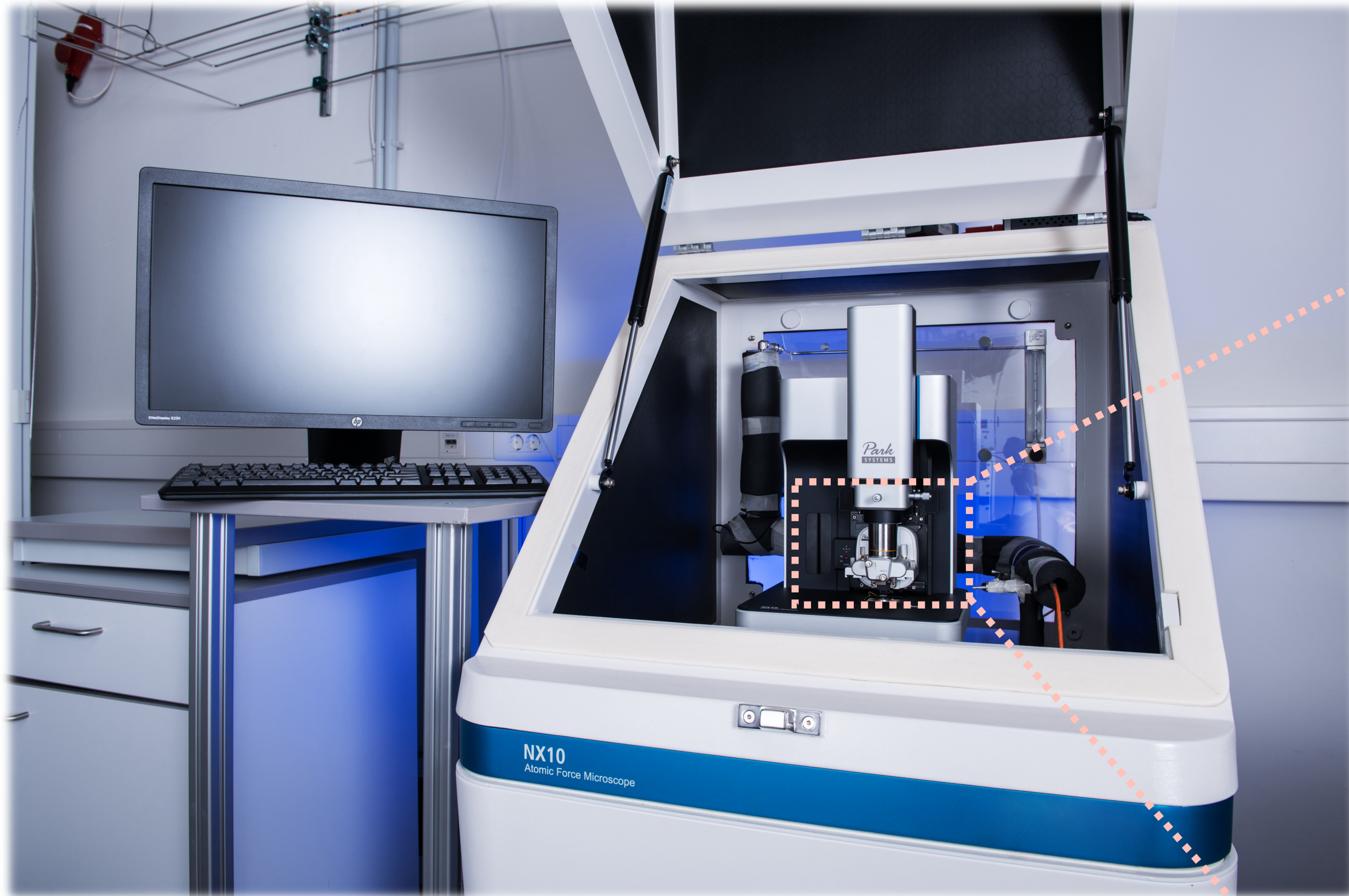
**SEM**



**EBSD**



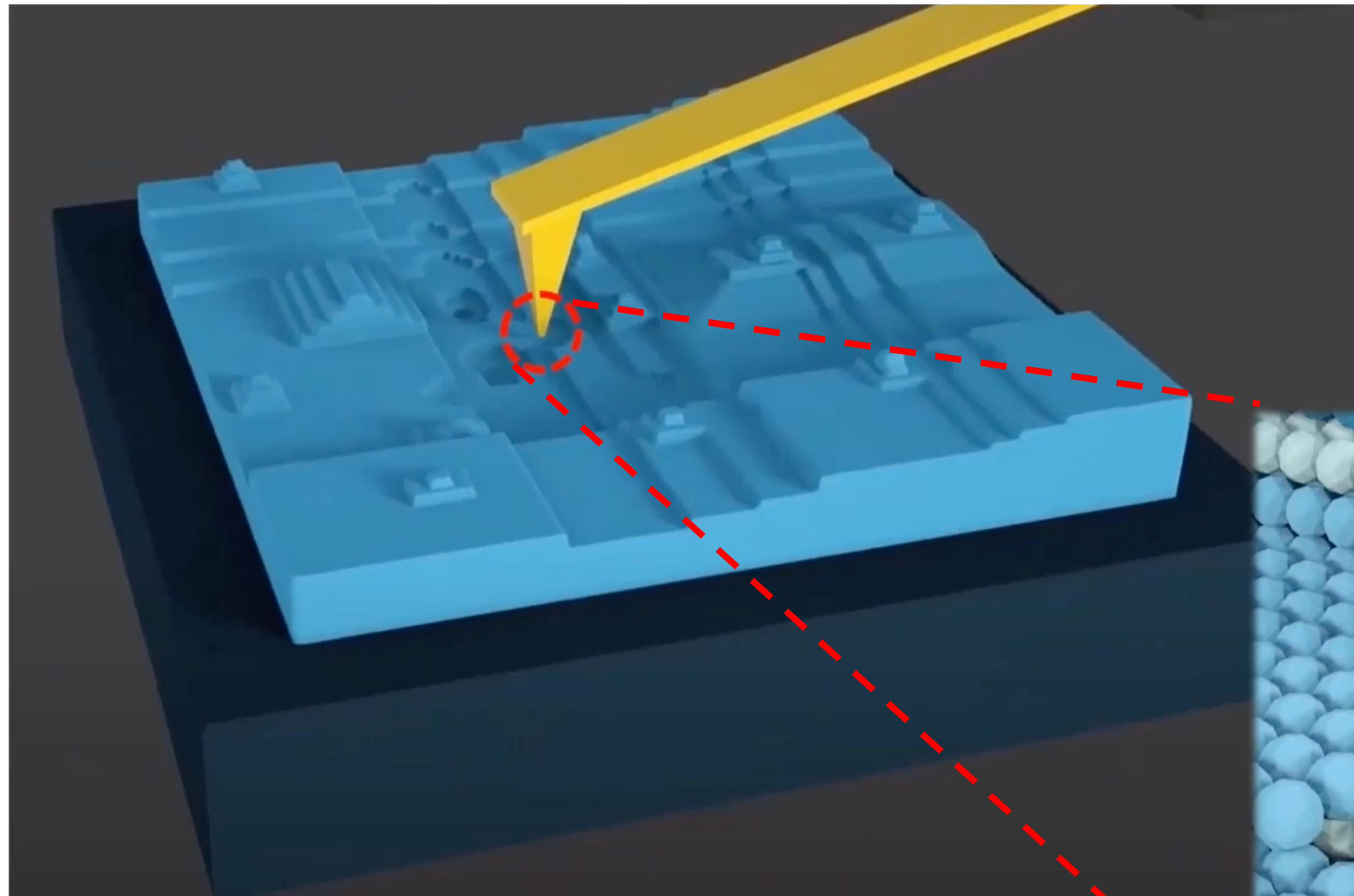
# Atomic Force Microscopy (AFM): From Images to Interactions



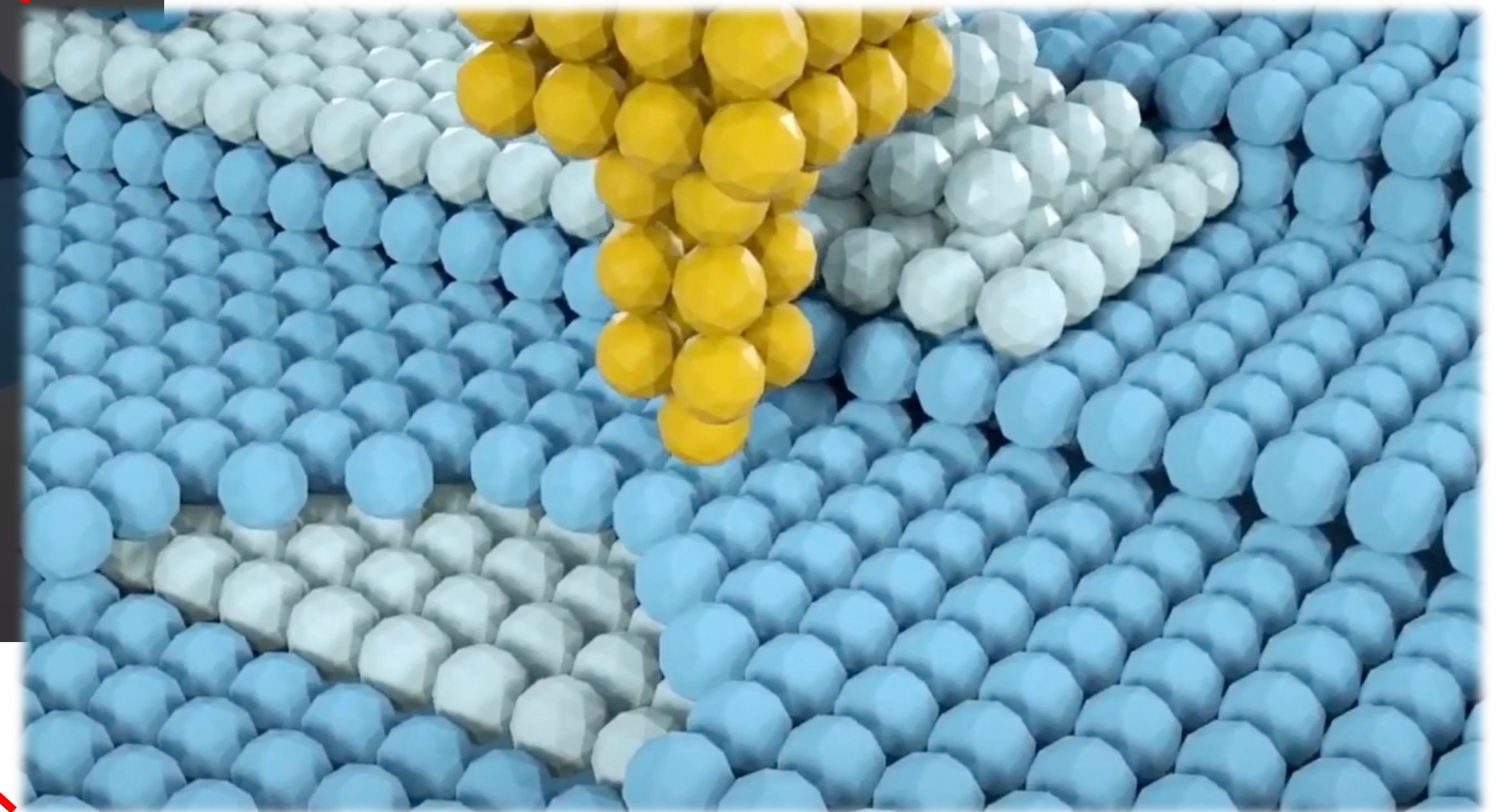
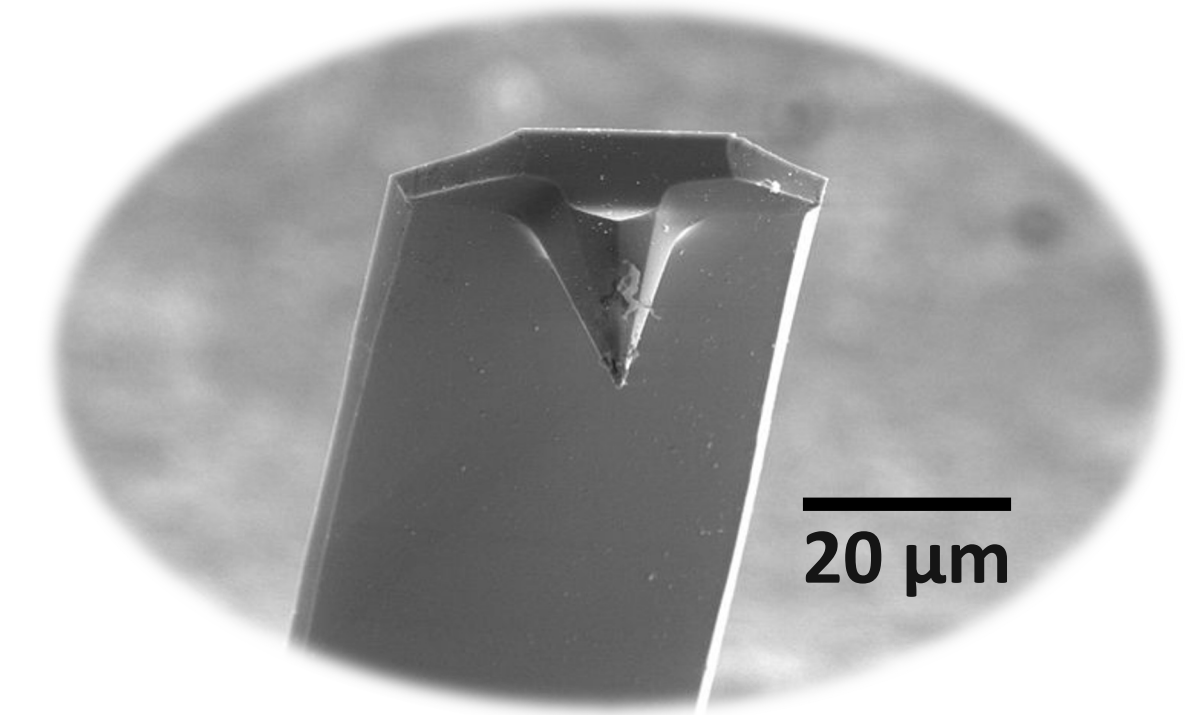
AFM measurements are extremely sensitive to vibrations:

- Vibration isolation in heavy enclosed box
- Acoustic isolation from sound waves
- Thermal stability (constant temperature)
  - Airflow control with closable box

# Atomic Force Microscopy (AFM): From Images to Interactions

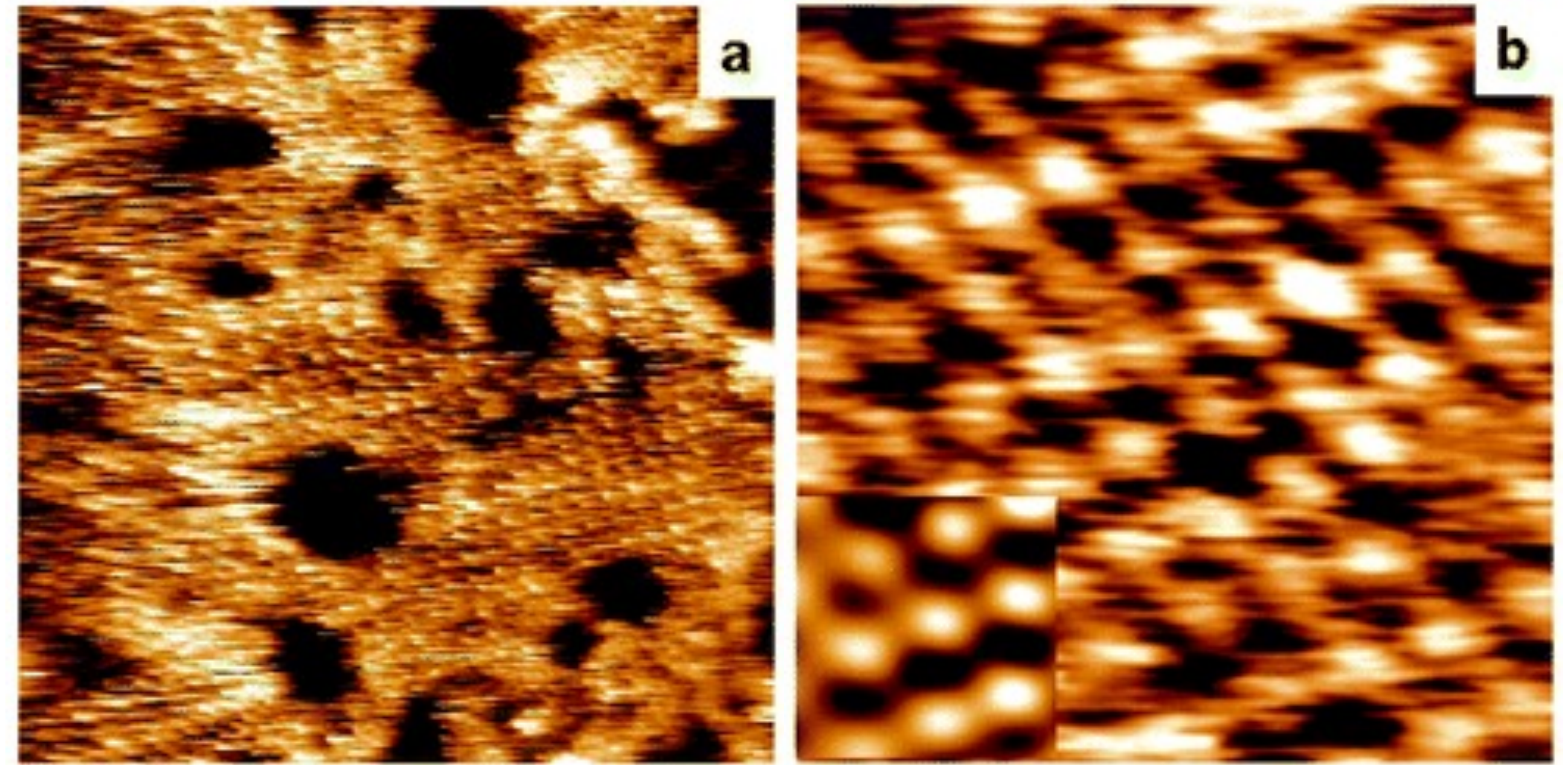
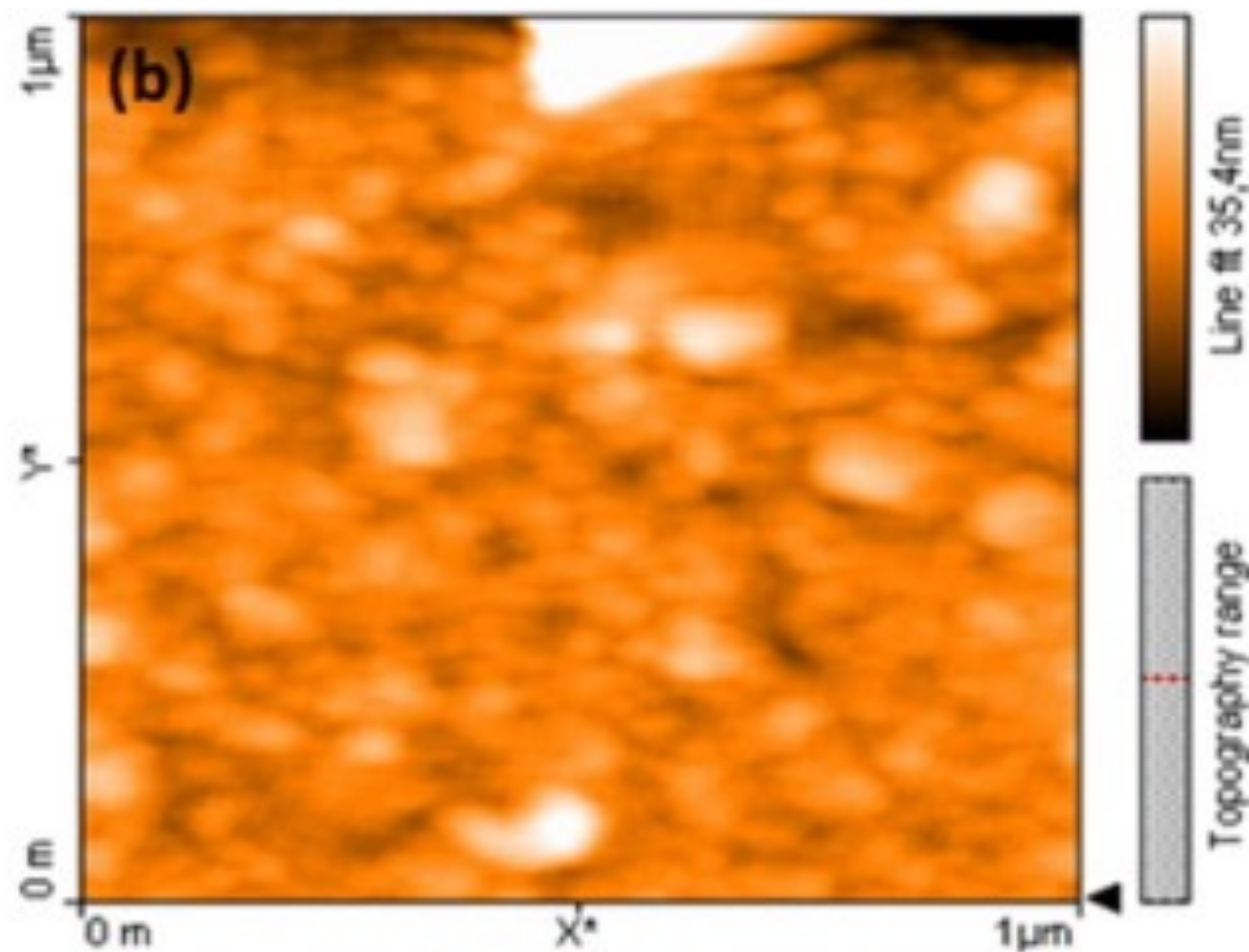


AFM cantilever



Interactions between two atoms enable measurements of nanomechanical properties

# Comparing AFM vs. STM – Hexadecanethiol (C16) on Au (111)



30 nm

4 nm

Simpler – works in air and liquids

Conducting/non-conducting surfaces

0.1-10 nm (0.1 is ultimate best equipment)

Topography, **force measurements,**  
**mechanical properties**

Uddin *et al.* | *Res. Phys.* | 2017

More complex (requires UHV and low temp.)

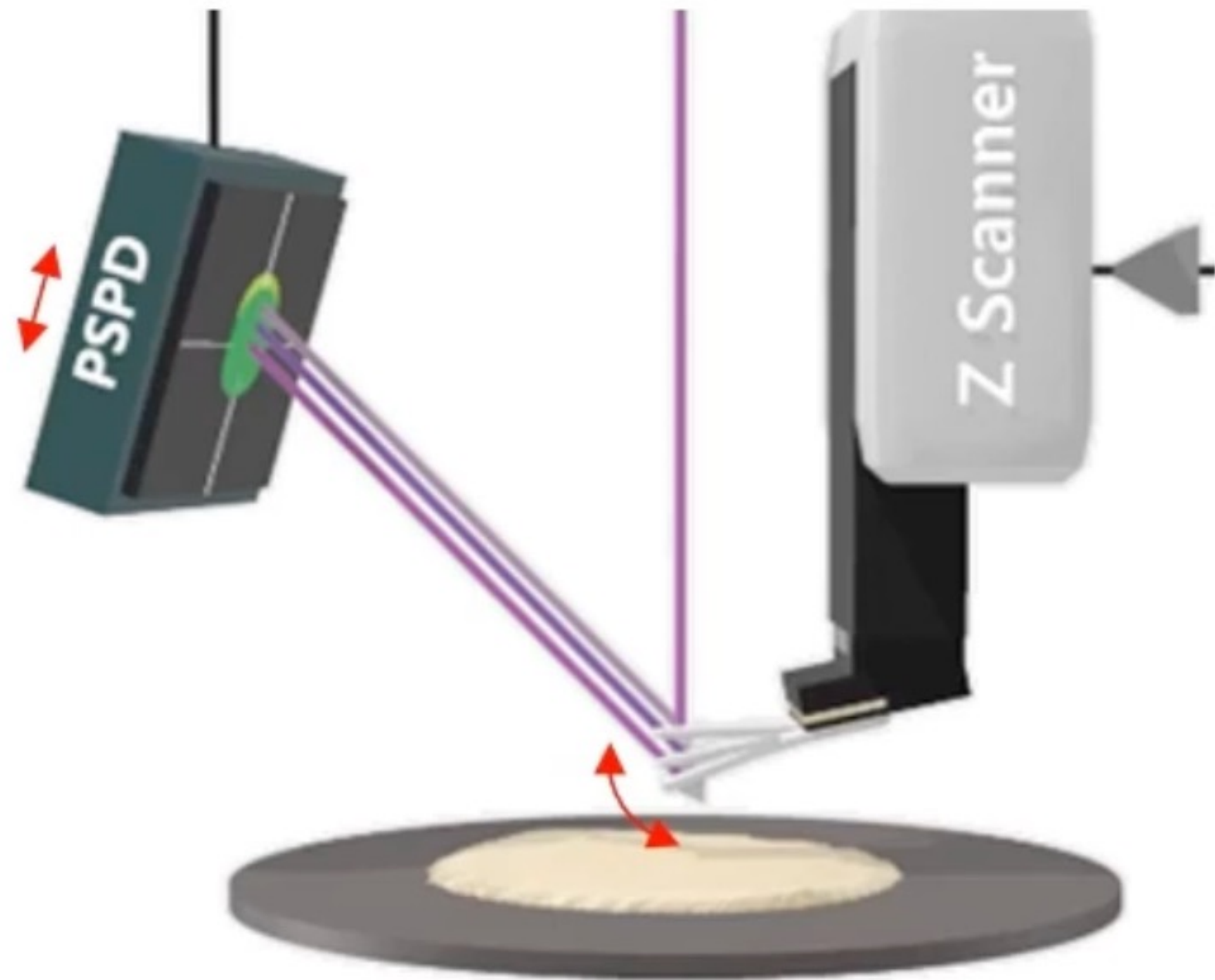
Only conducting surfaces

0.1 nm (0.01 nm in vertical direction)

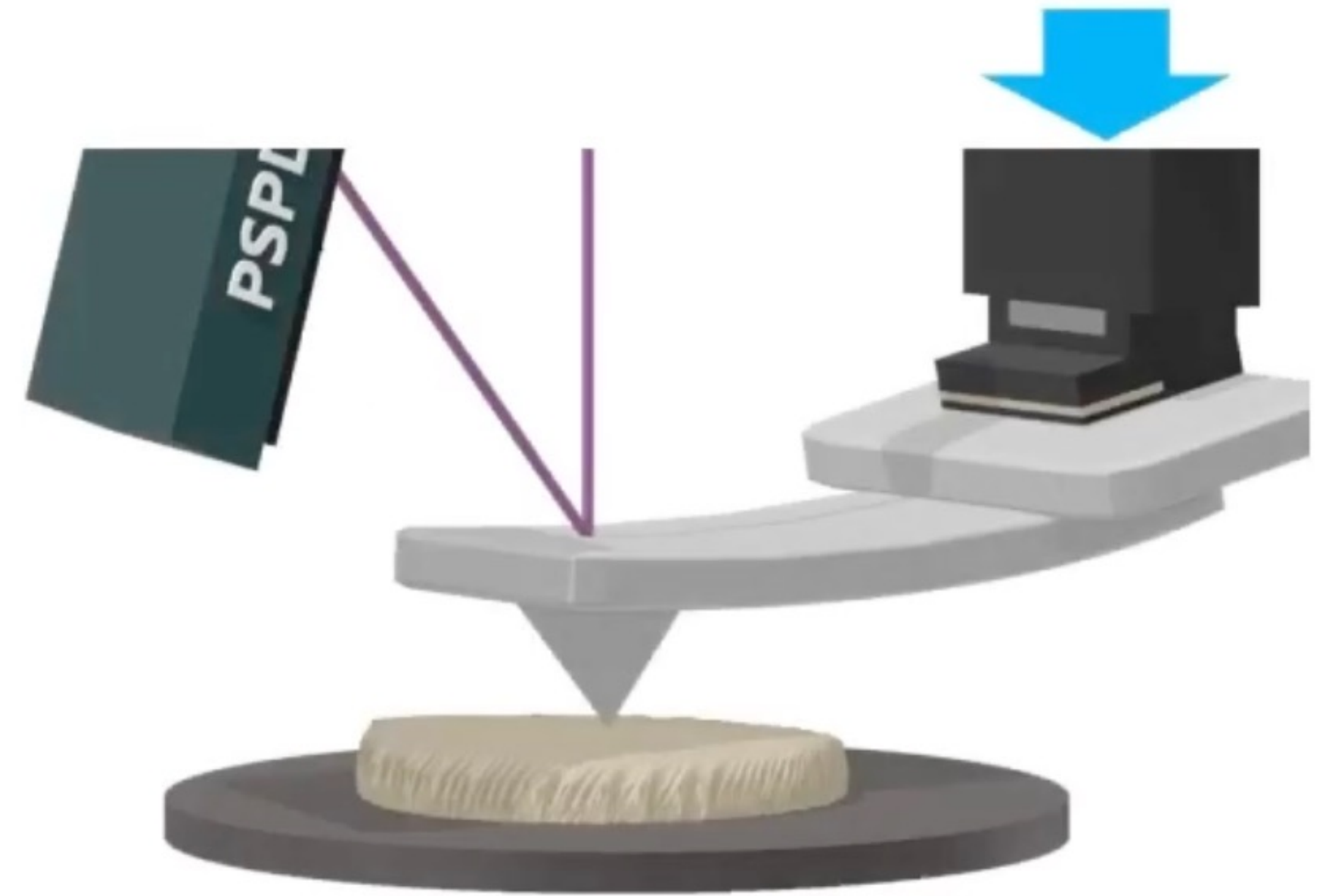
Topography, electronic properties

Mendoza *et al.* | *Langmuir* | 2006

# Atomic Force Microscopy (AFM): From Images to Interactions

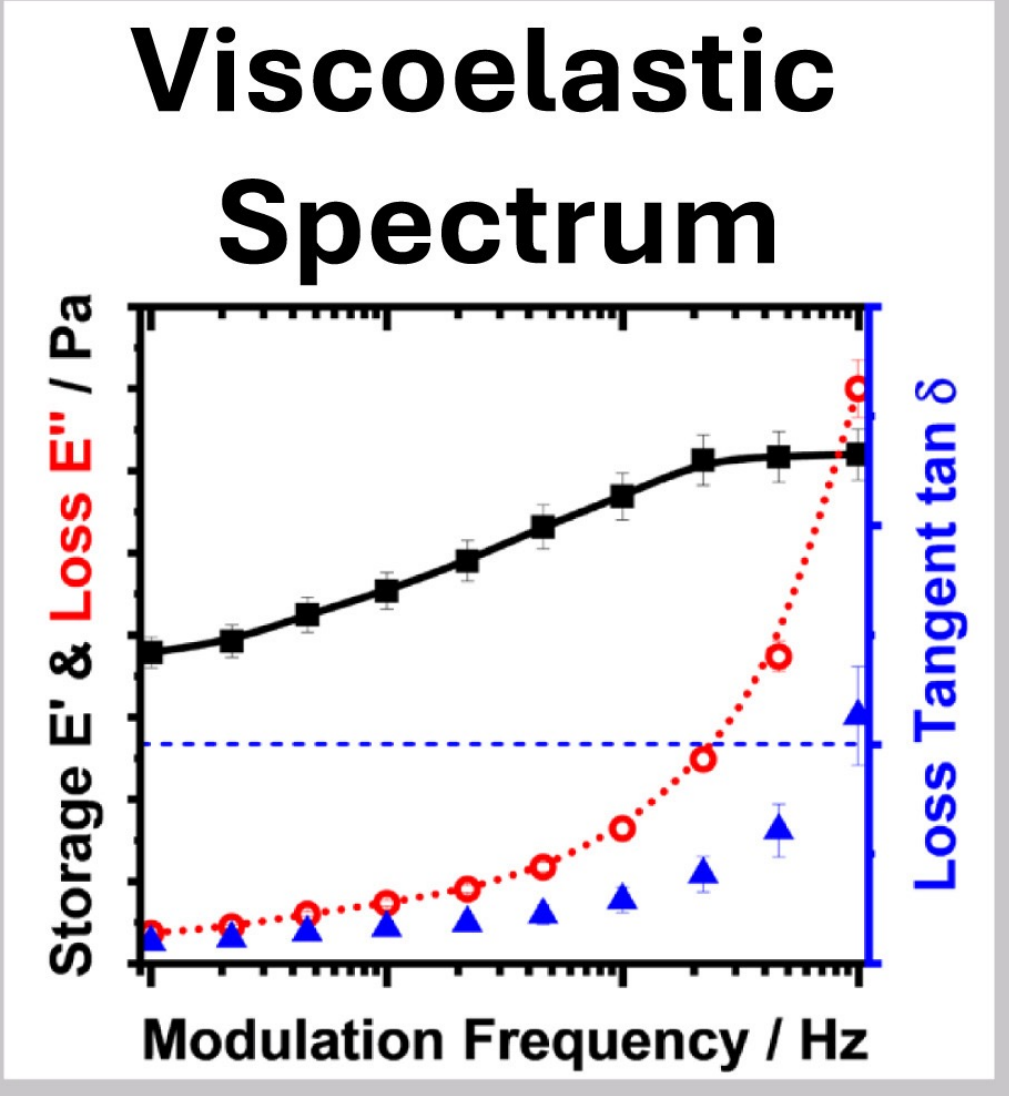
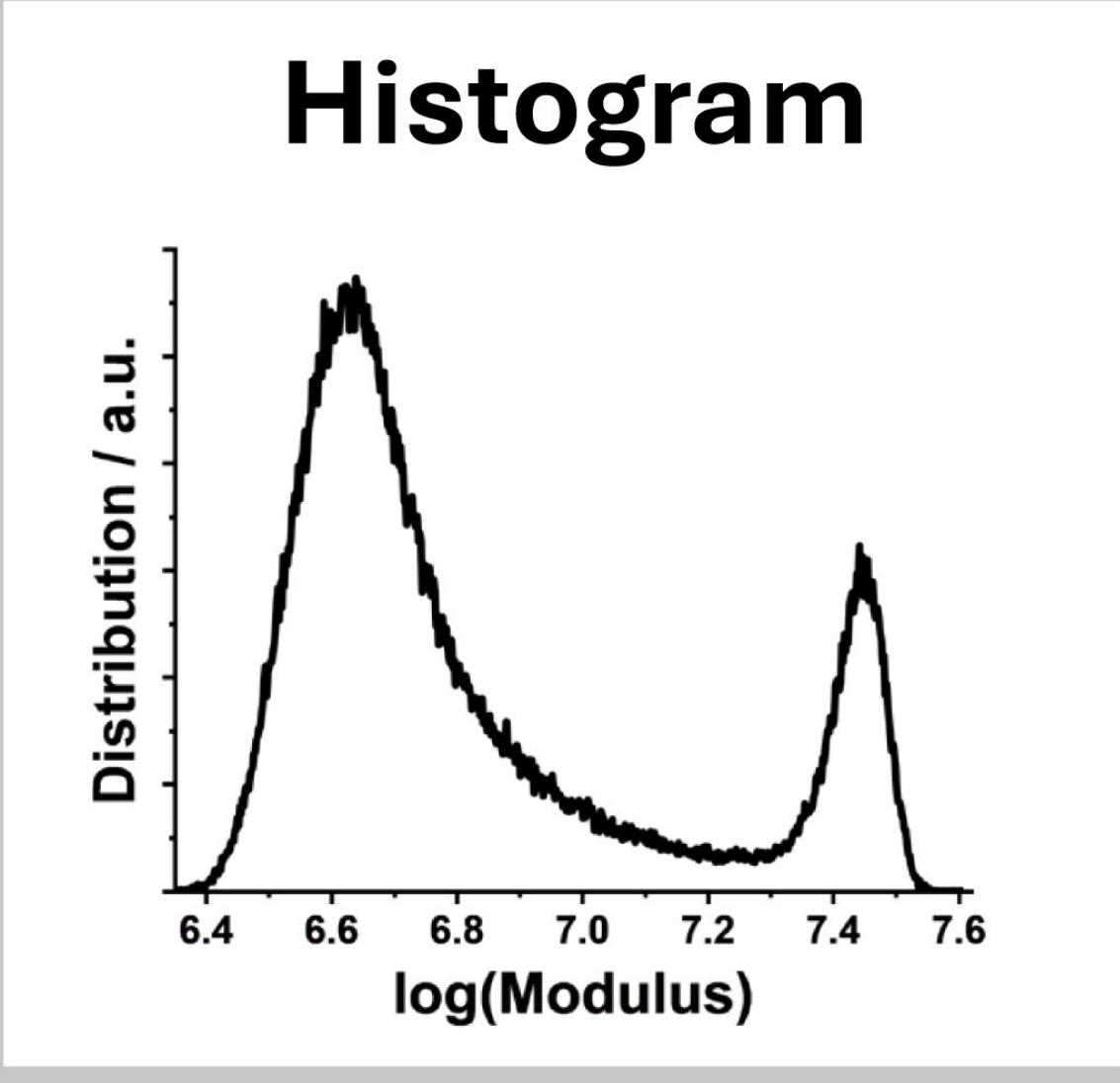
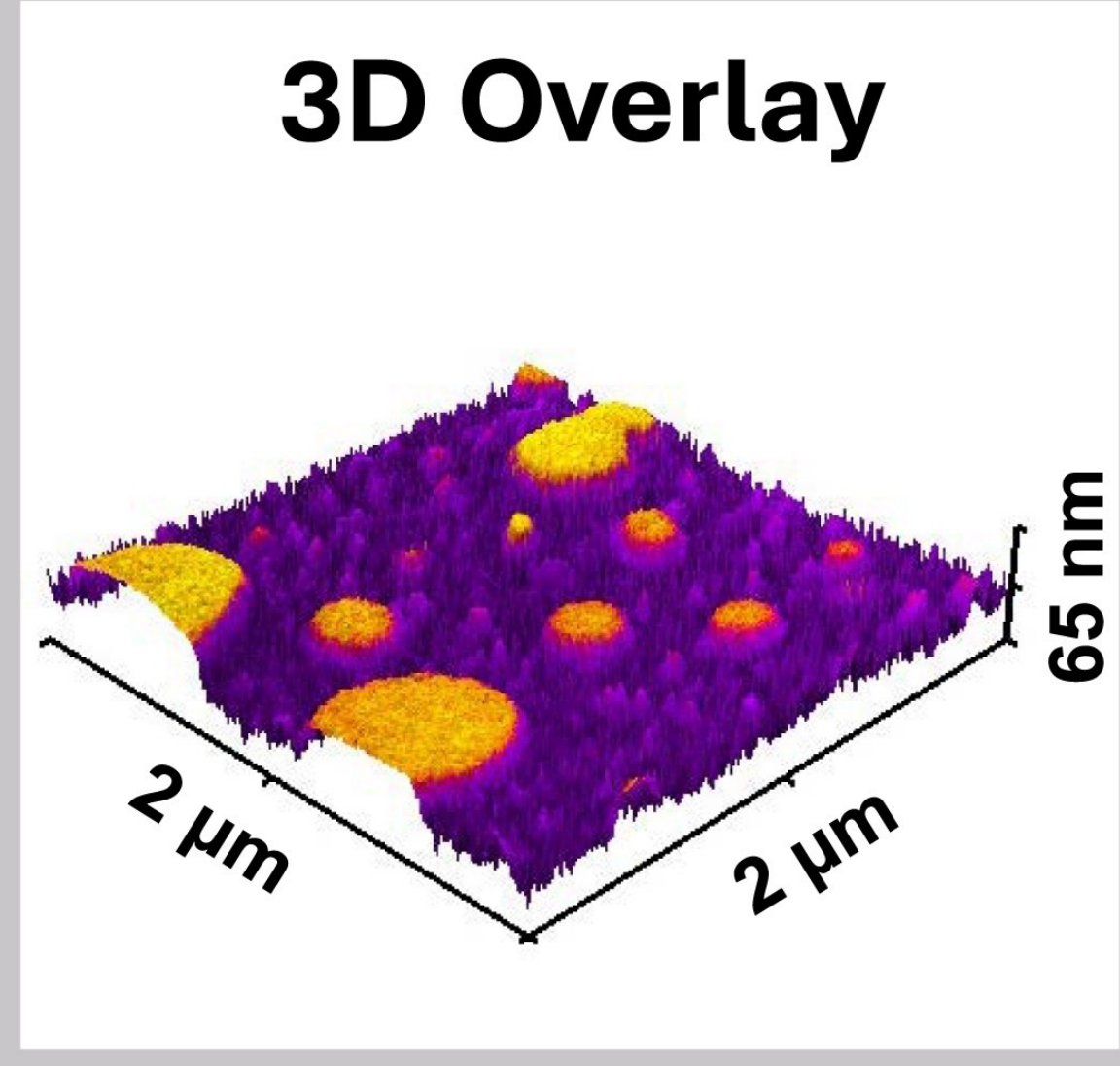
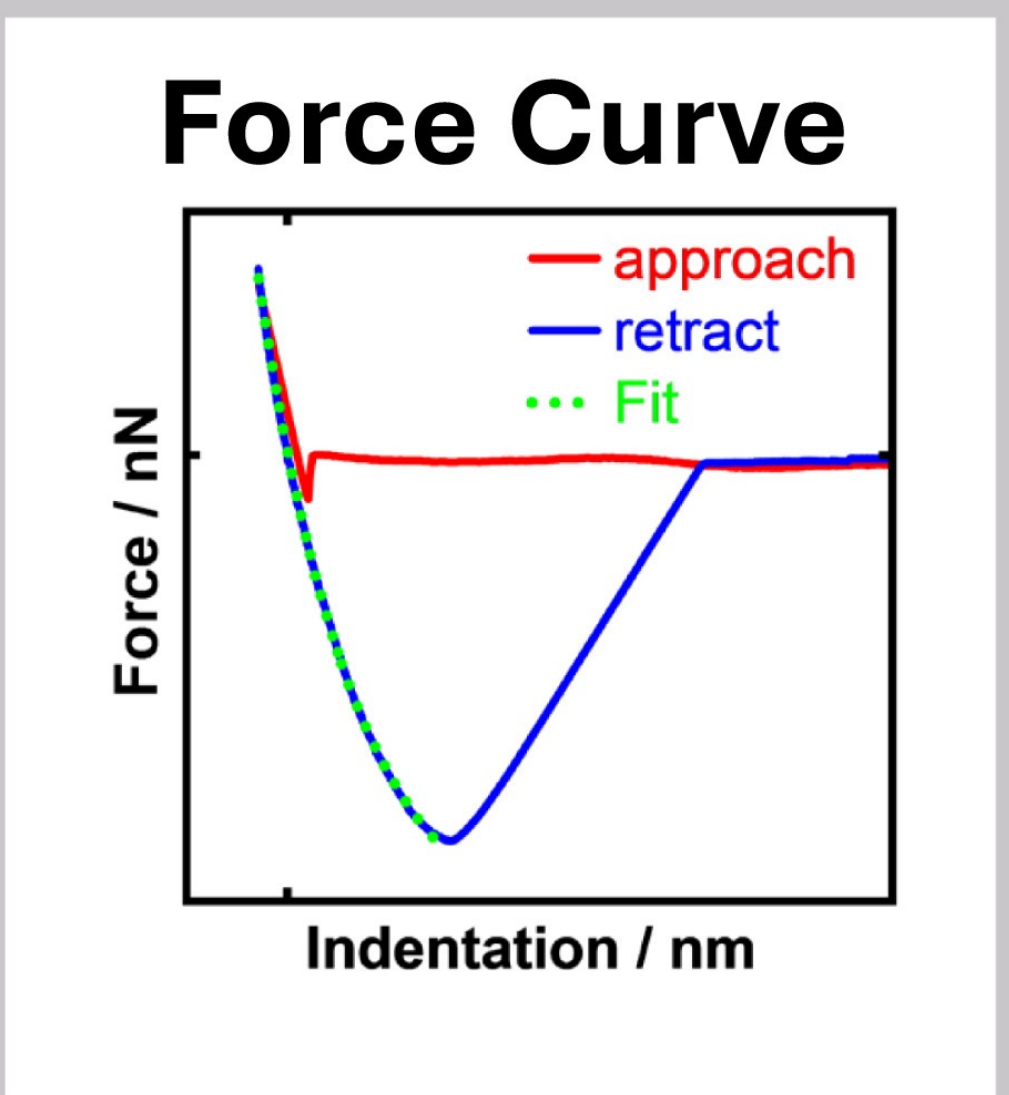
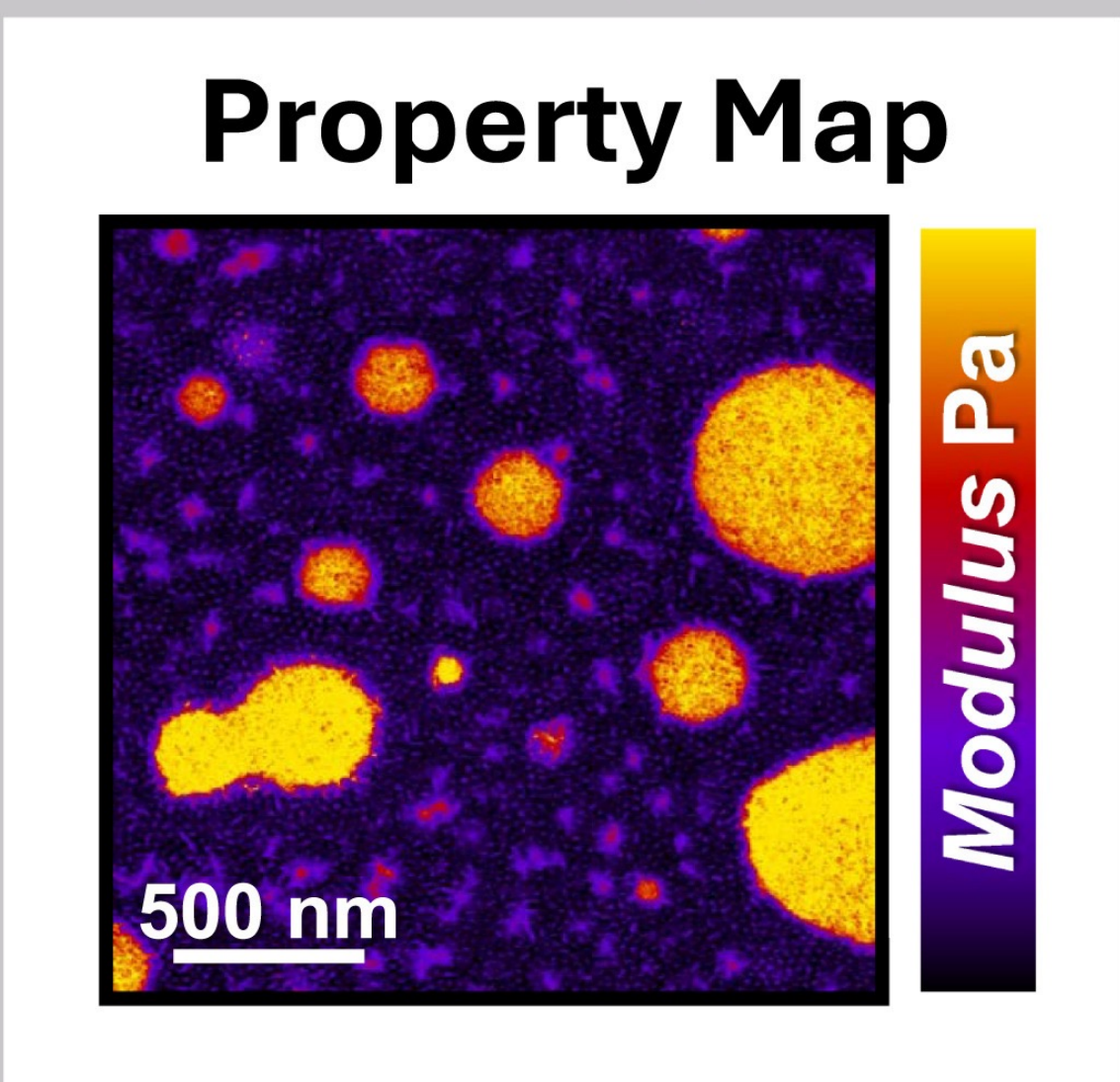
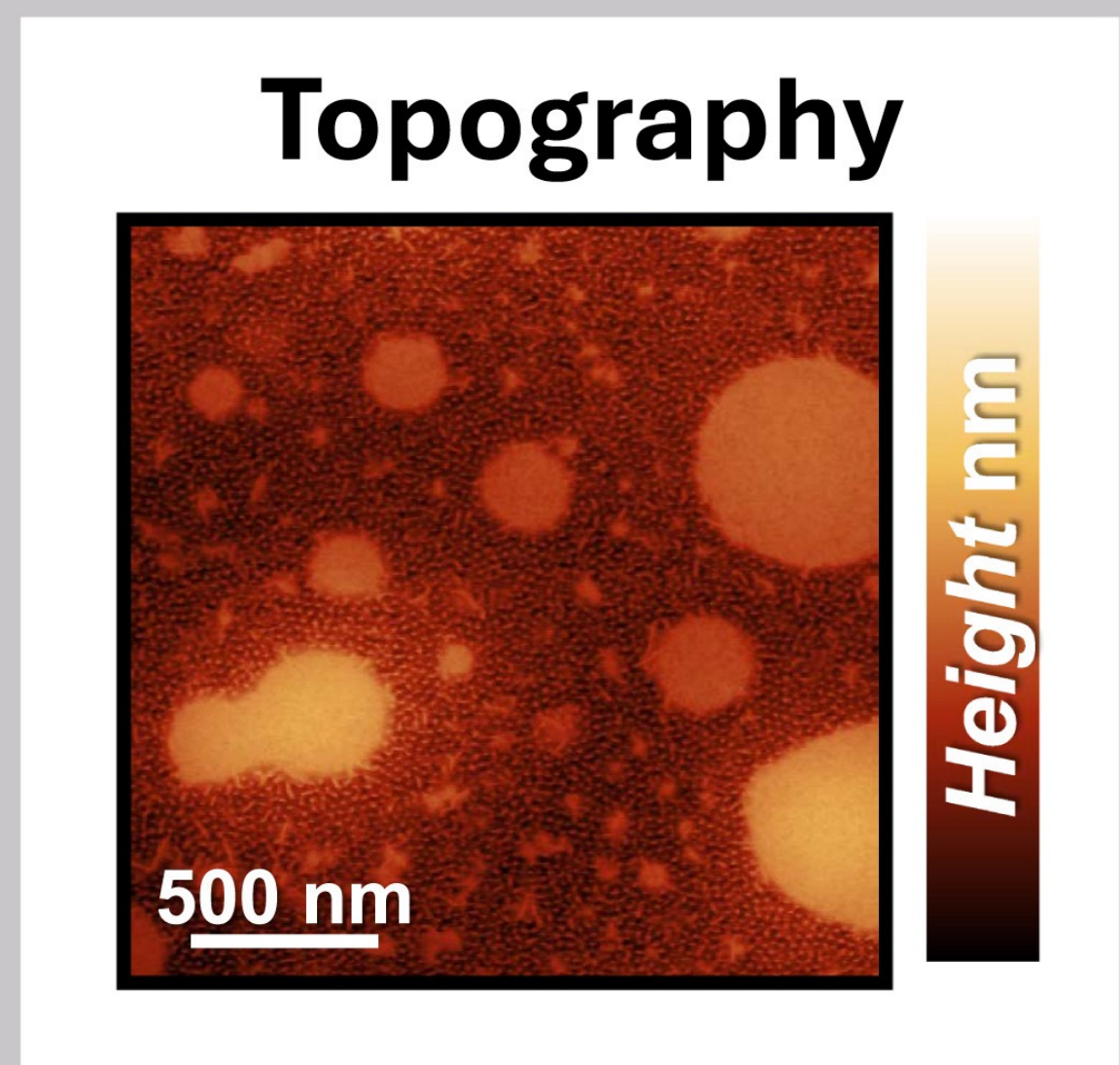


**Surface Imaging**  
Height information



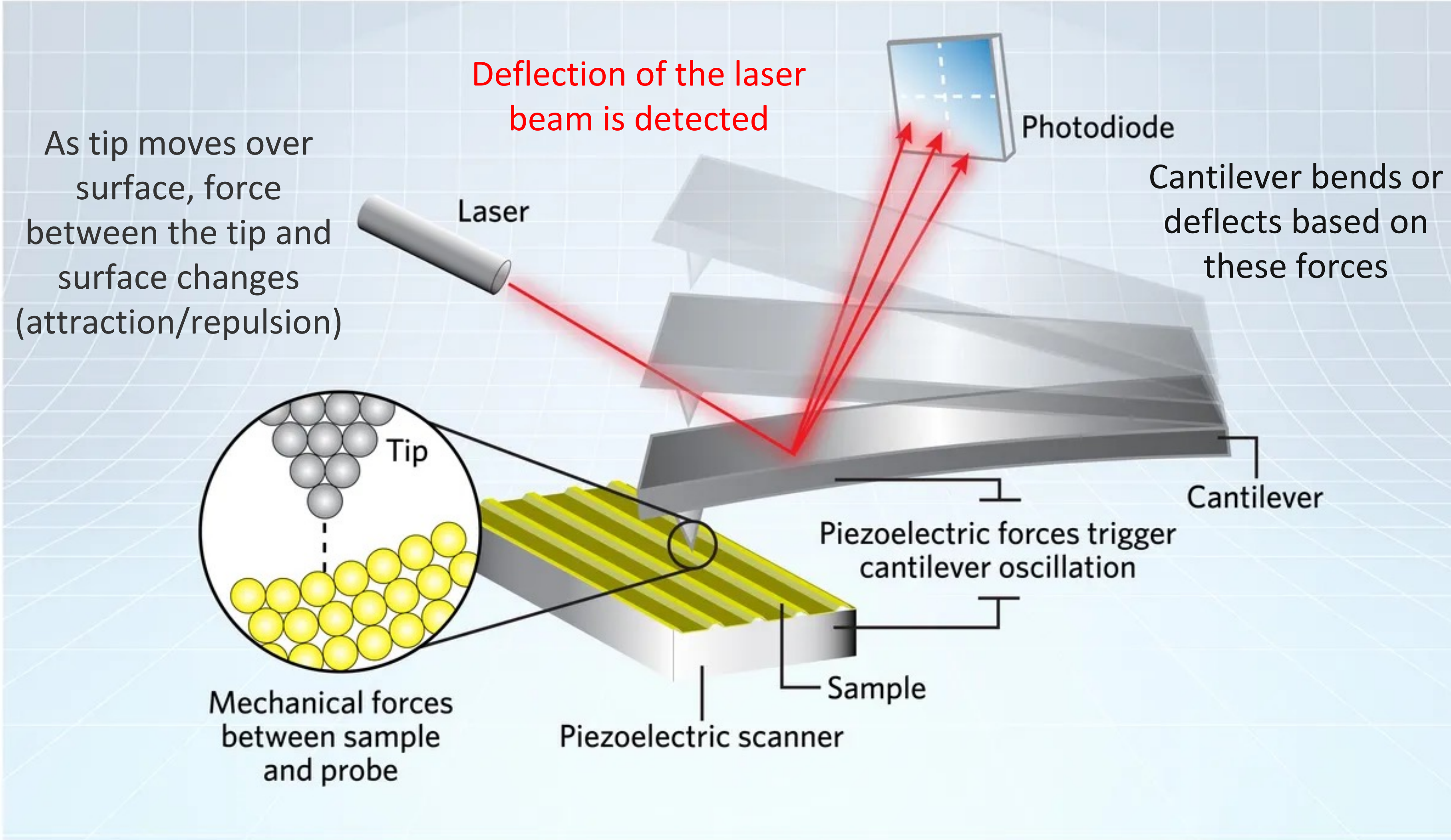
**Mechanical properties**  
Force spectroscopy

# Measuring Force/Mechanical Properties of Surfaces



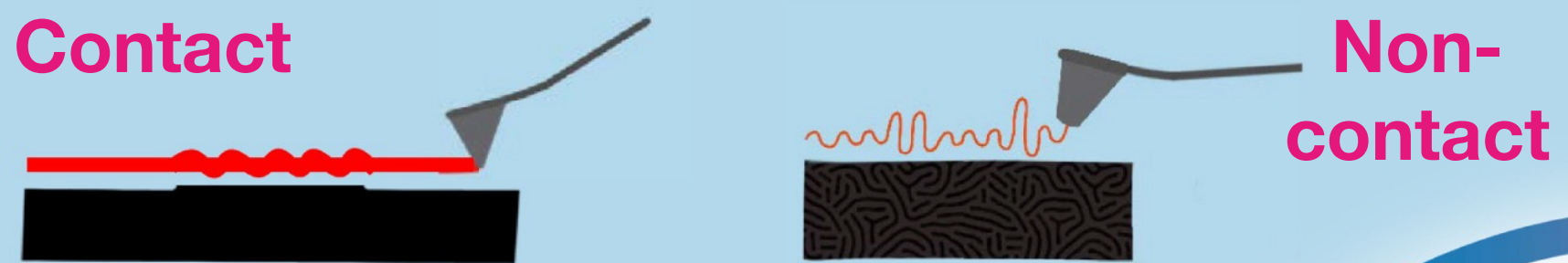
# How Can We “See” What is Happening on Surfaces?

## Atomic Force Microscopy (AFM)

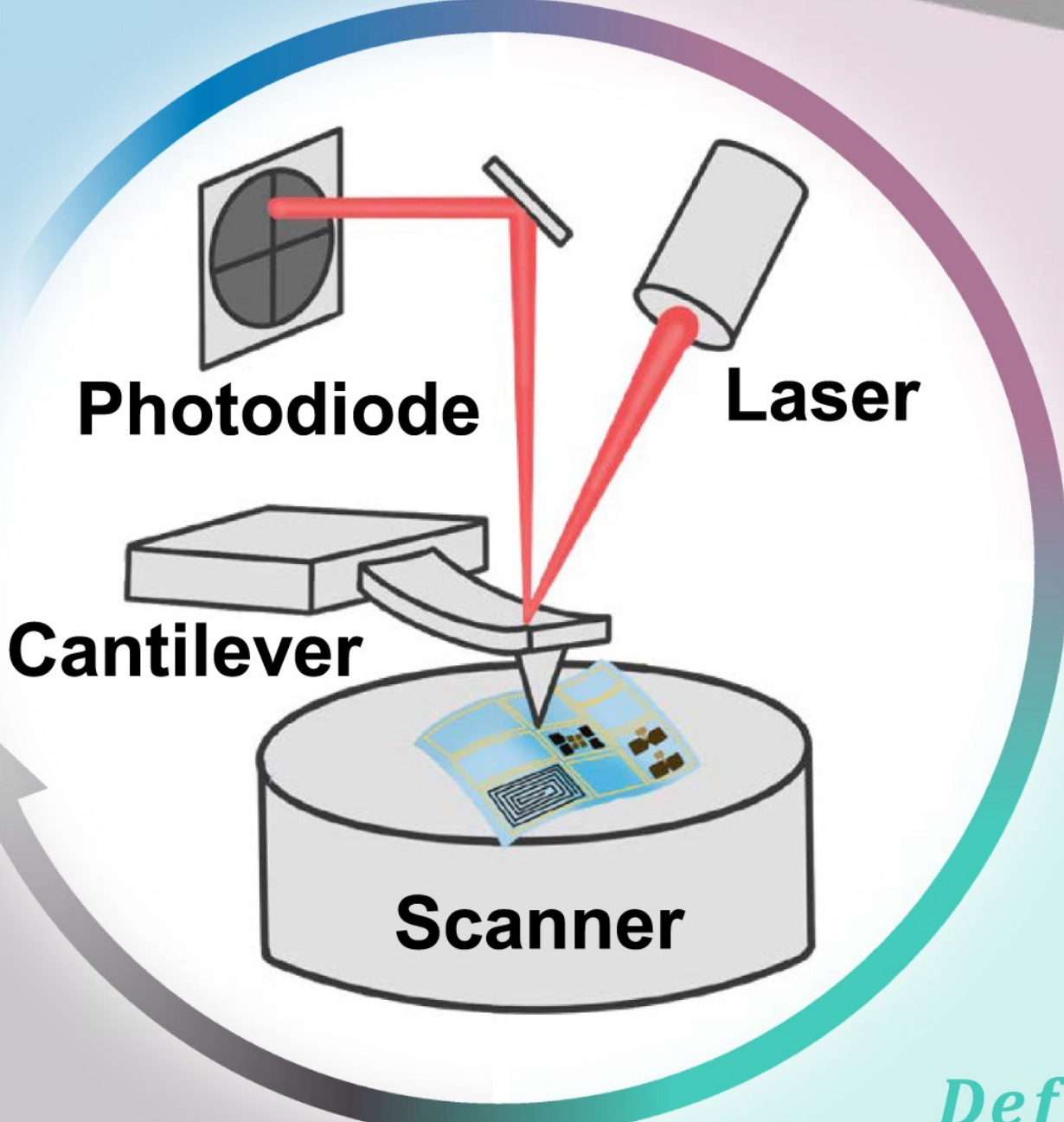
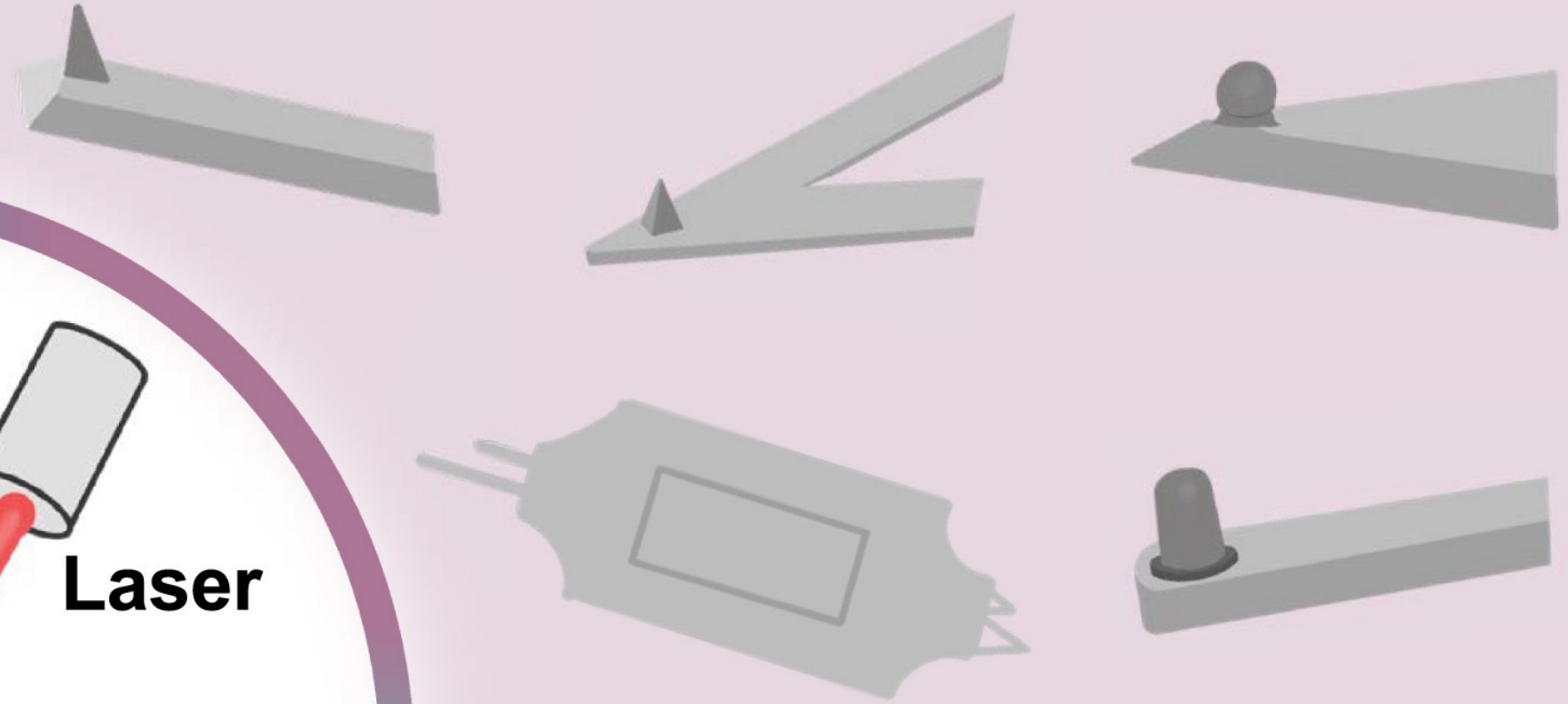


# Nanomechanical Characterization of Surfaces

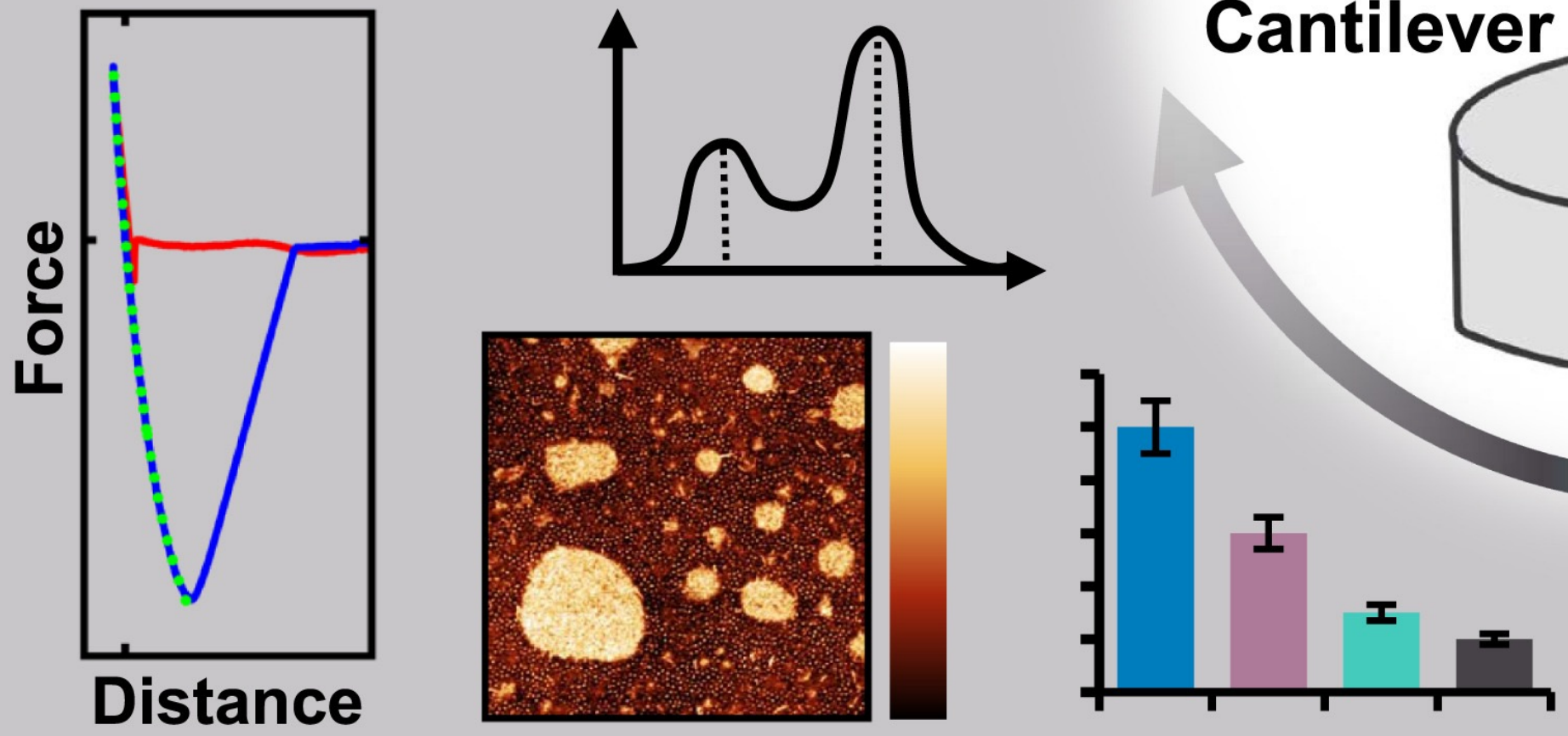
## 1. Mode Selection



## 2. Probe Selection



- Adhesion
- Elasticity
- Stiffness
- Softness

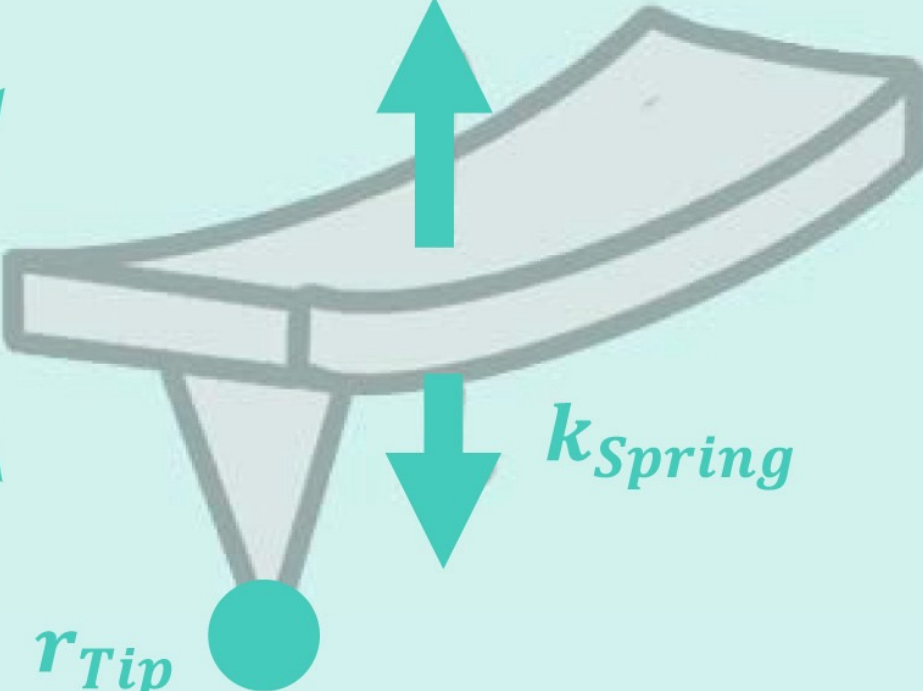


## 4. Data Analysis

$Def_{sens}$

**Deflection sensitivity**

## 3. Calibration

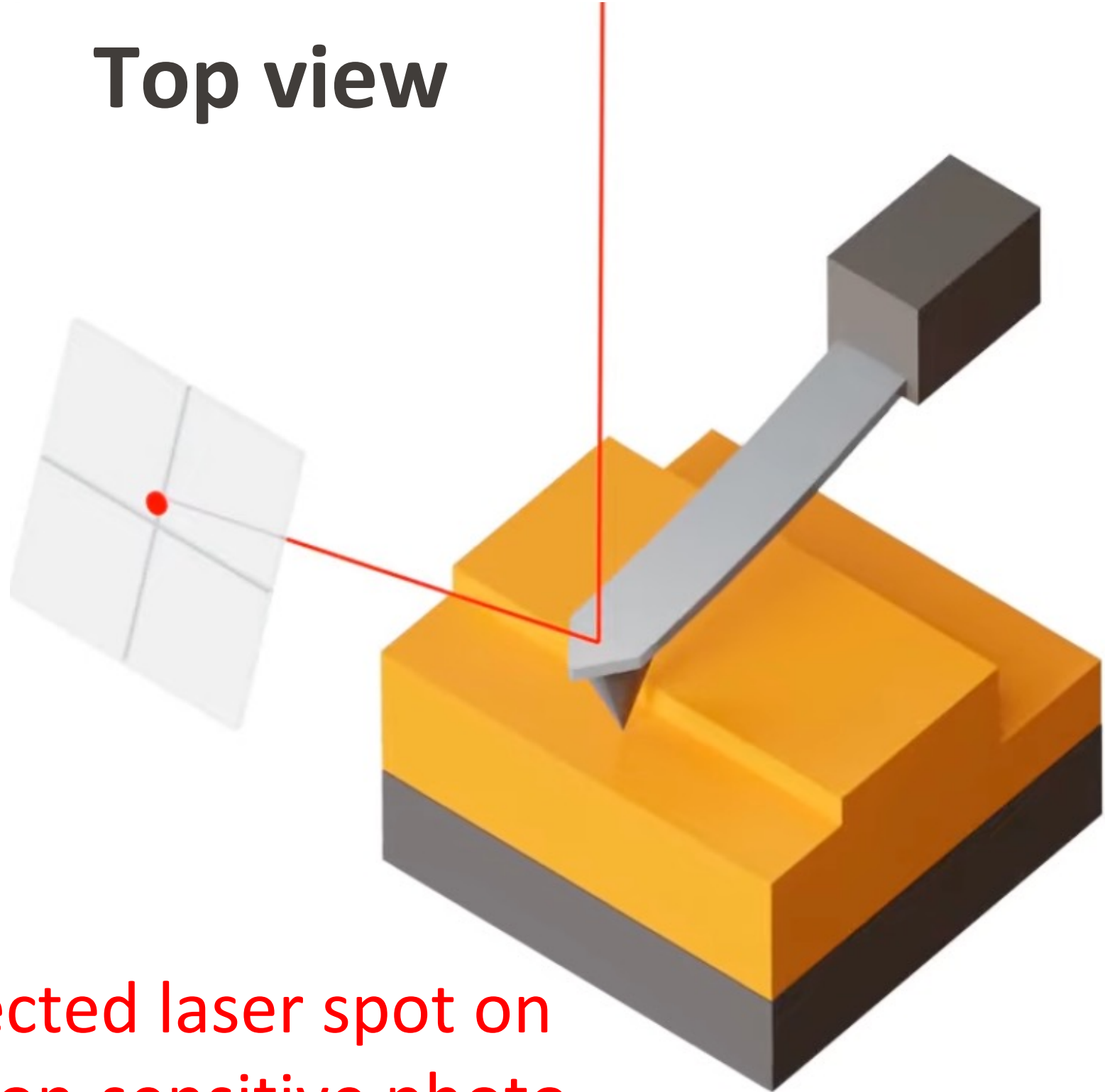


**Tip radius**

**Spring constant of cantilever**

# Contact Mode is the Most Basic Mode of AFM for Topography

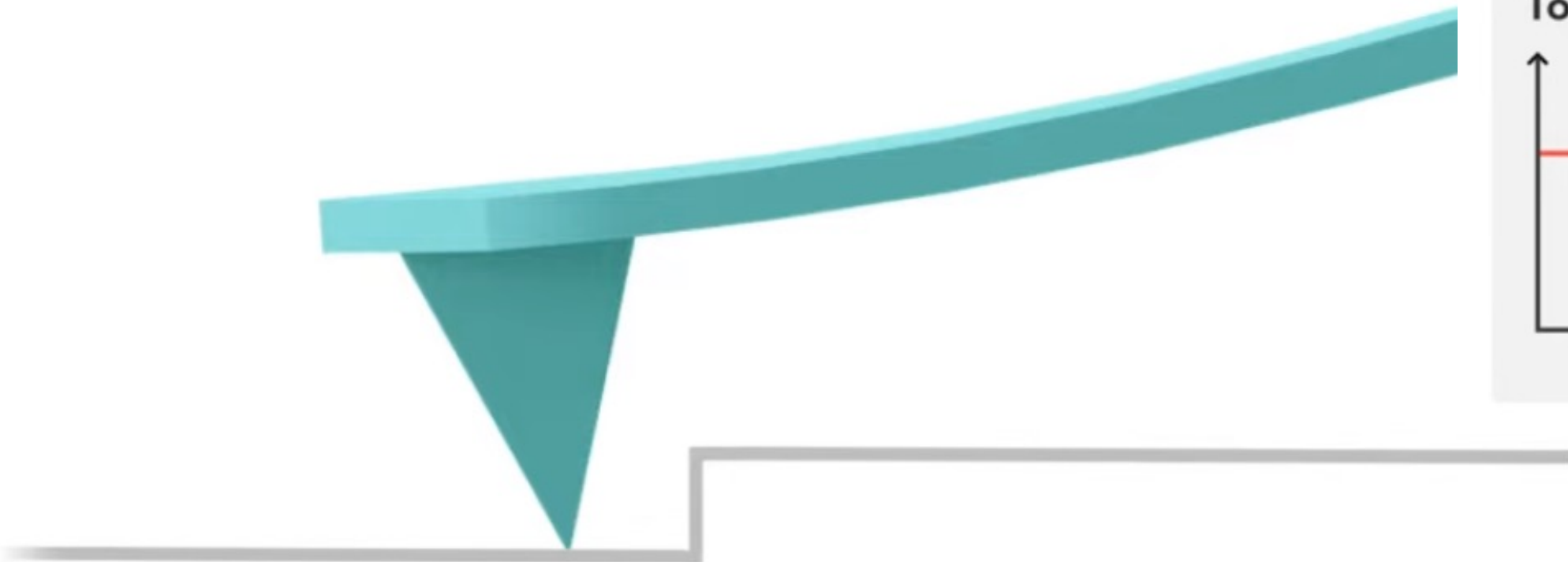
Cantilever scans while applying constant force onto surface of the sample



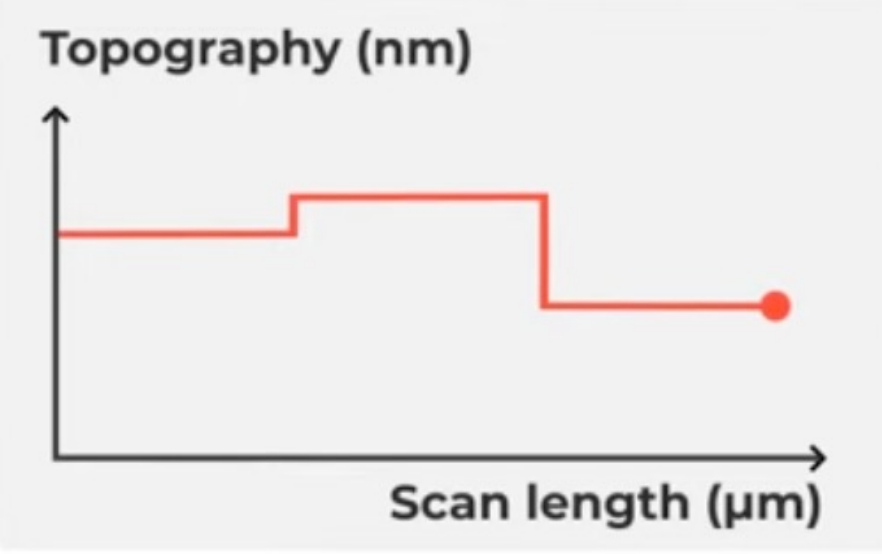
Top view

Deflected laser spot on position-sensitive photo detector moves due to change in contact force

Side view

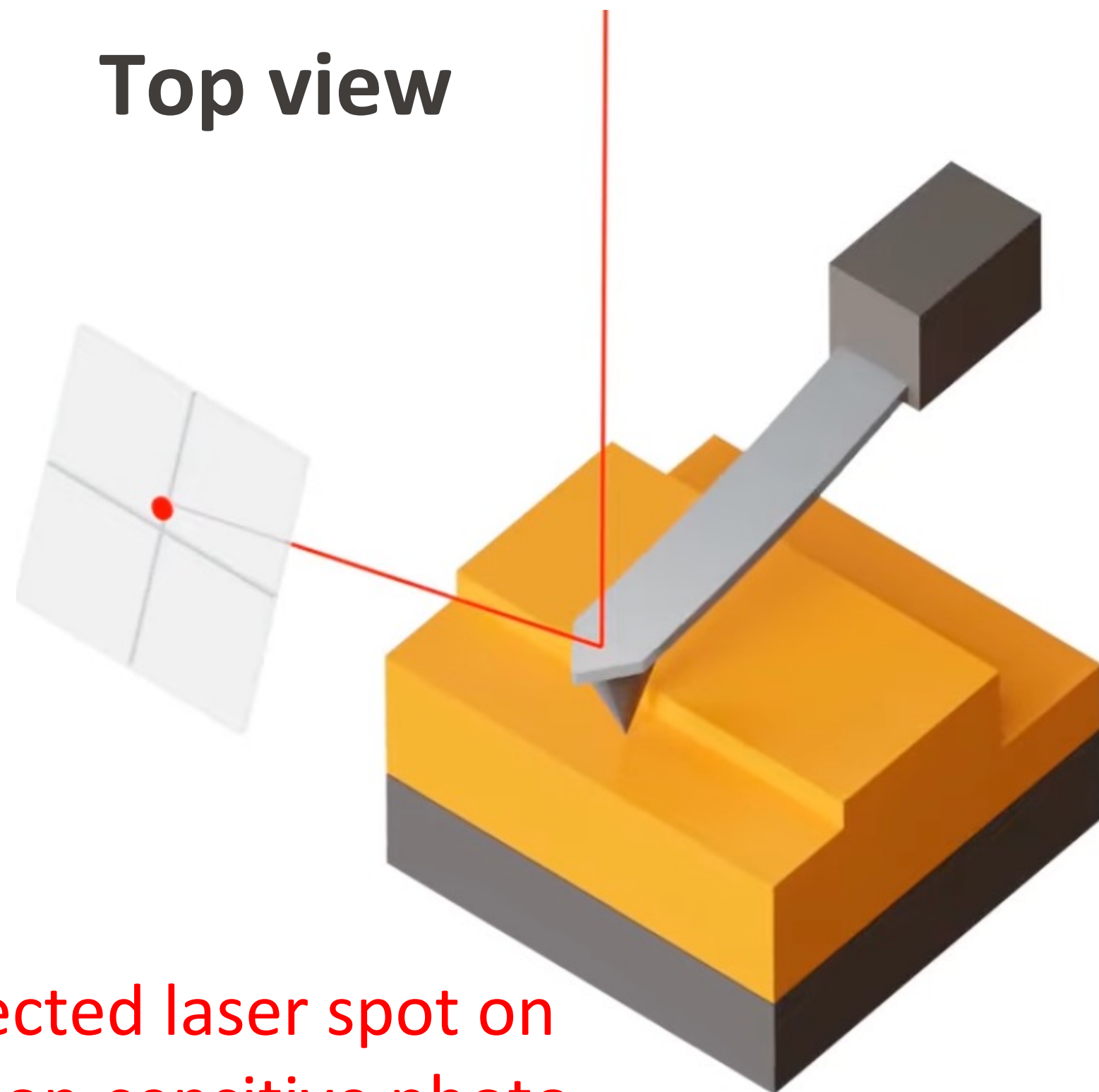


When engaged, cantilever bends upwards proportional to the amount of applied force



# Contact Mode is the Most Basic Mode of AFM for Topography

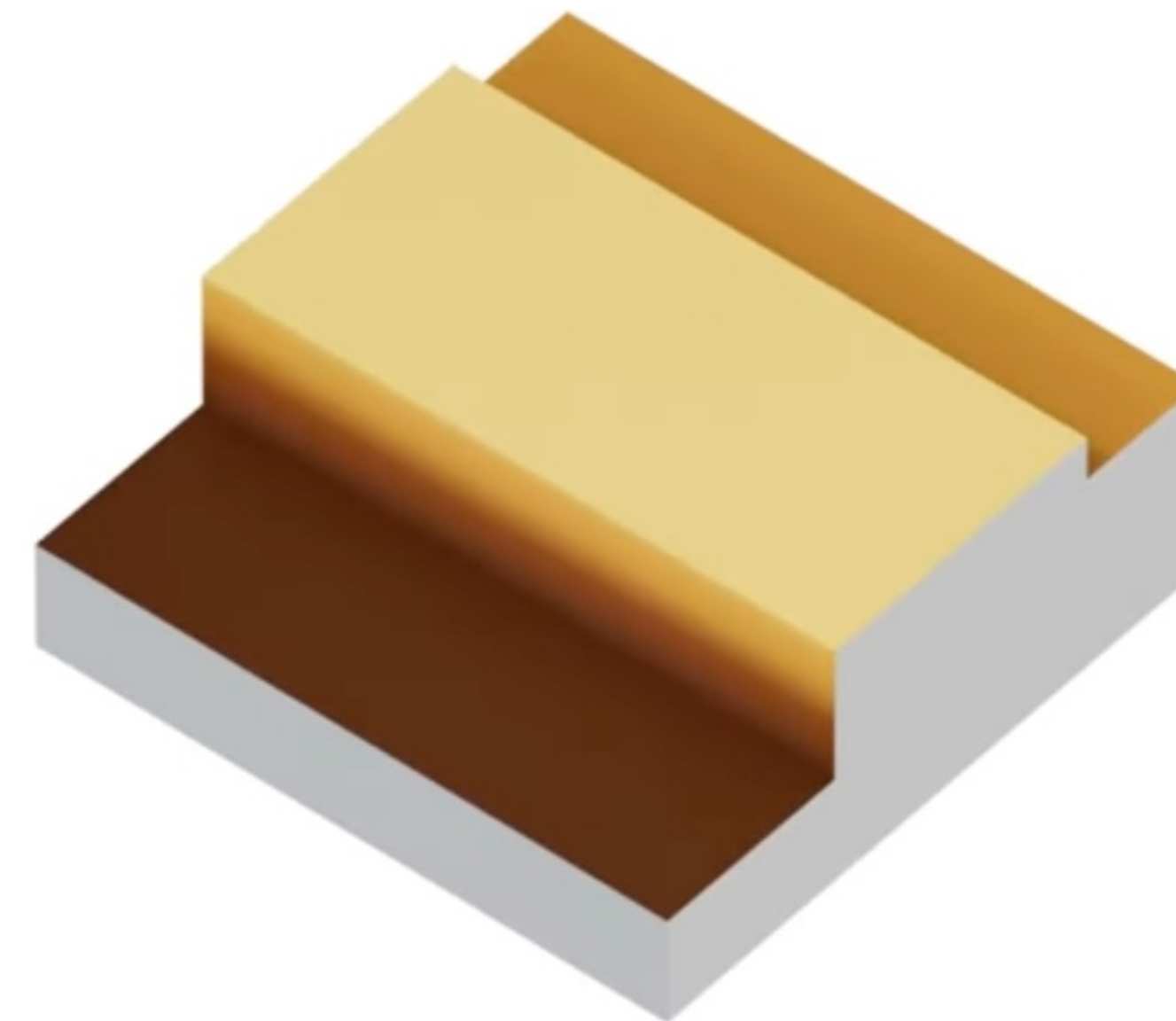
Cantilever scans while applying constant force onto surface of the sample



Deflected laser spot on position-sensitive photo detector moves due to change in contact force

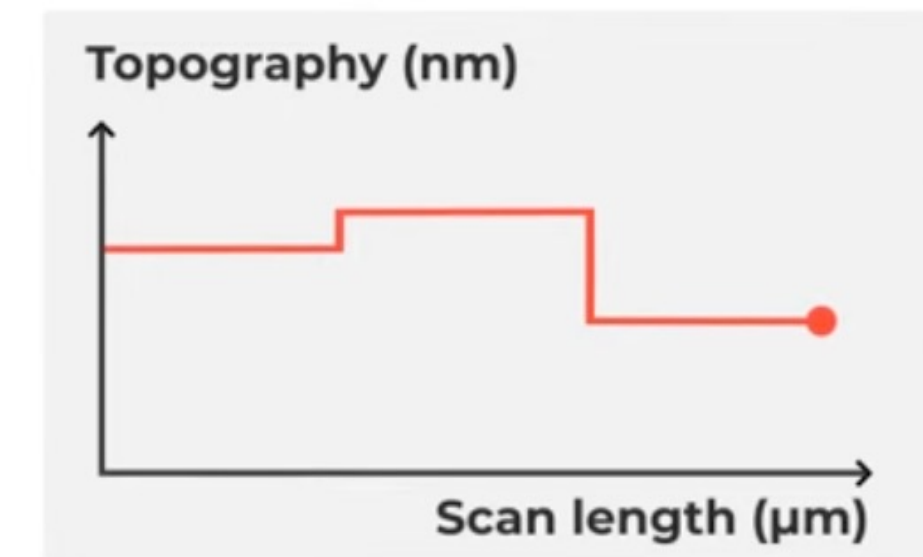


## Topography



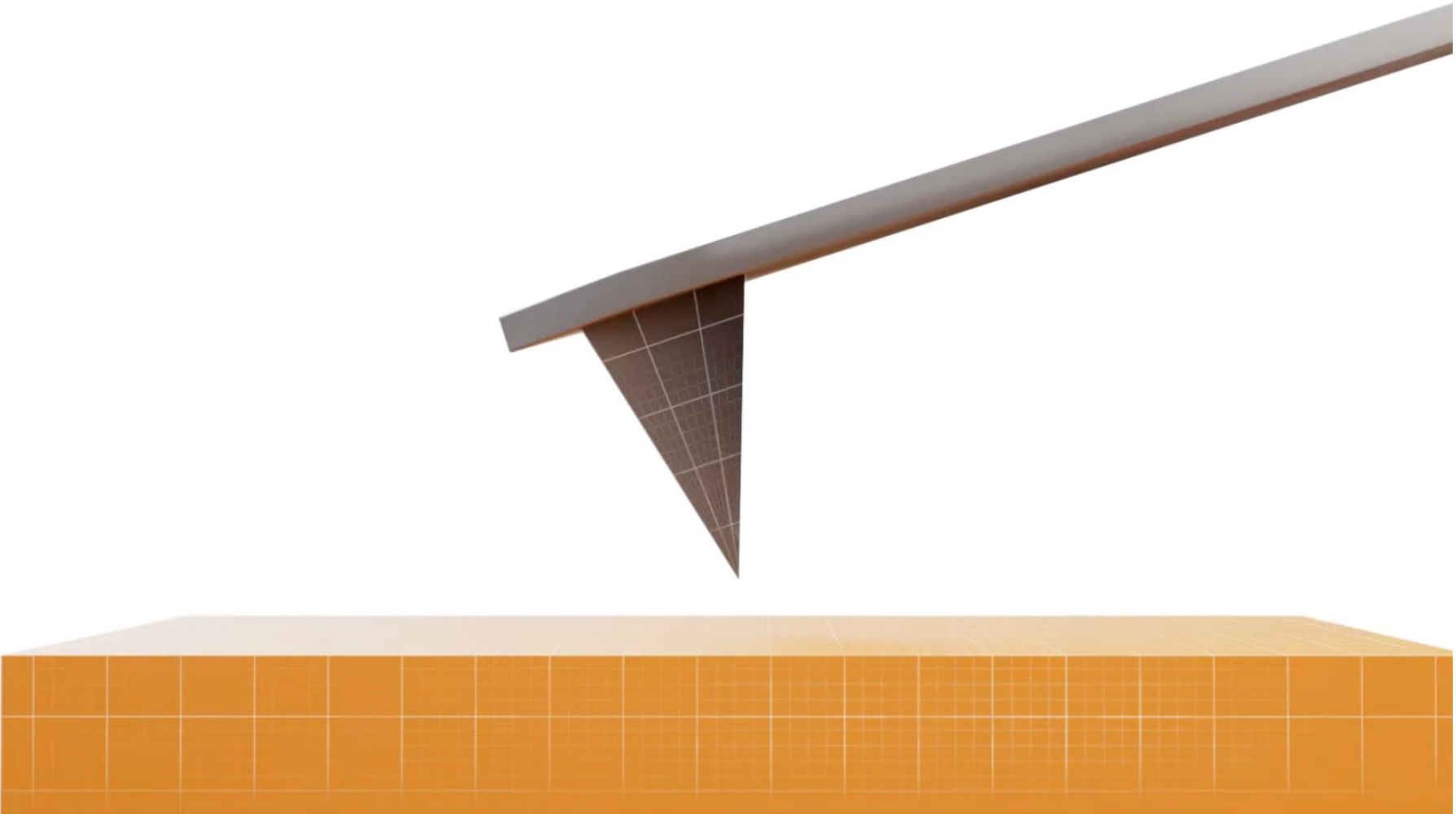
By tracking displacement of the z-scanner obtain the surface topography of the sample

Fast real-time feedback loop continuously adjusts vertical position (z) of scanner

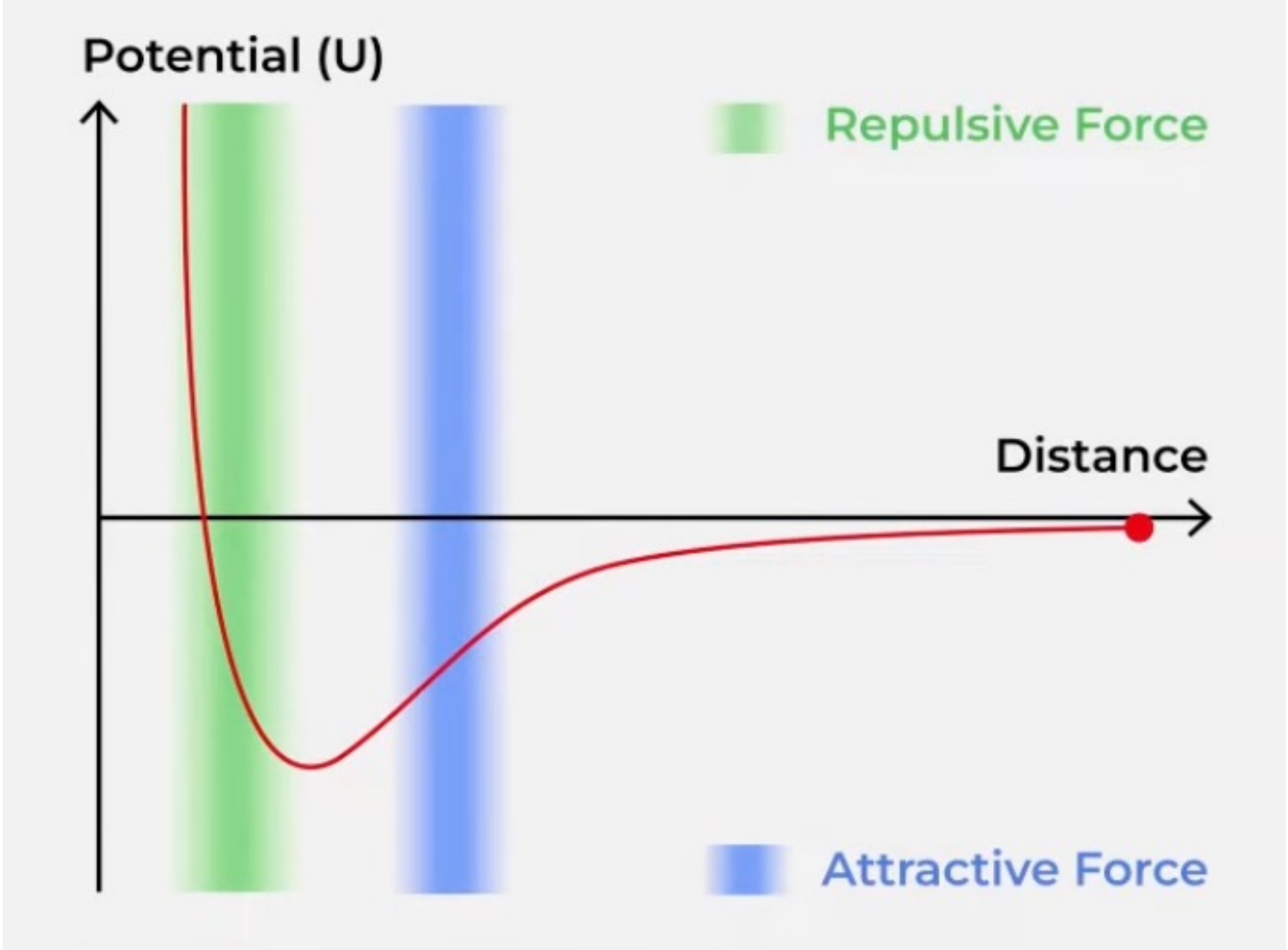
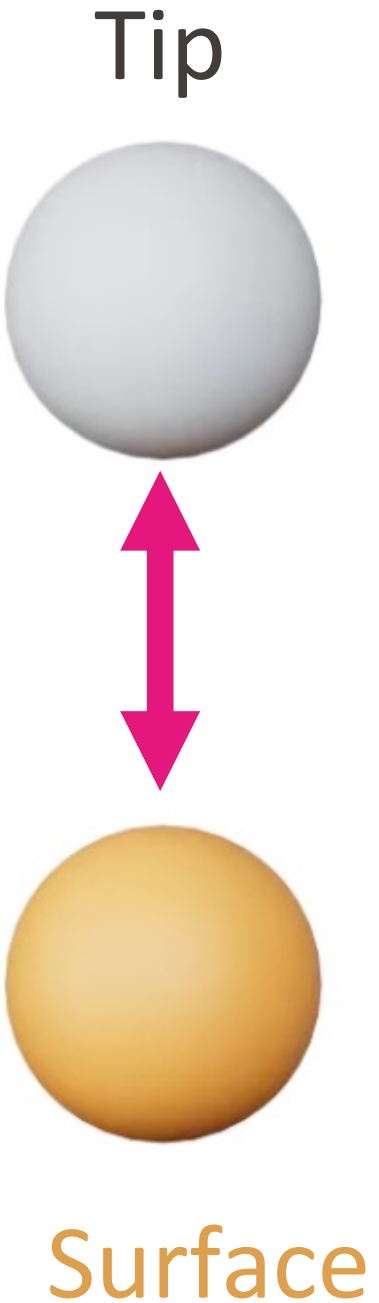
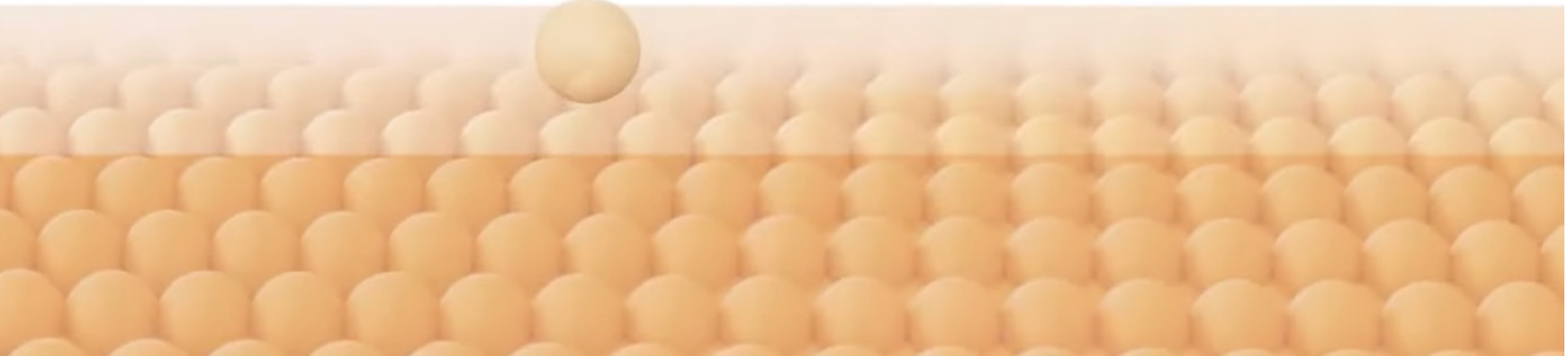


# Non-Contact Mode is the Safer Measurement Method

Cantilever does not touch the surface – avoids damage to both the tip and sample

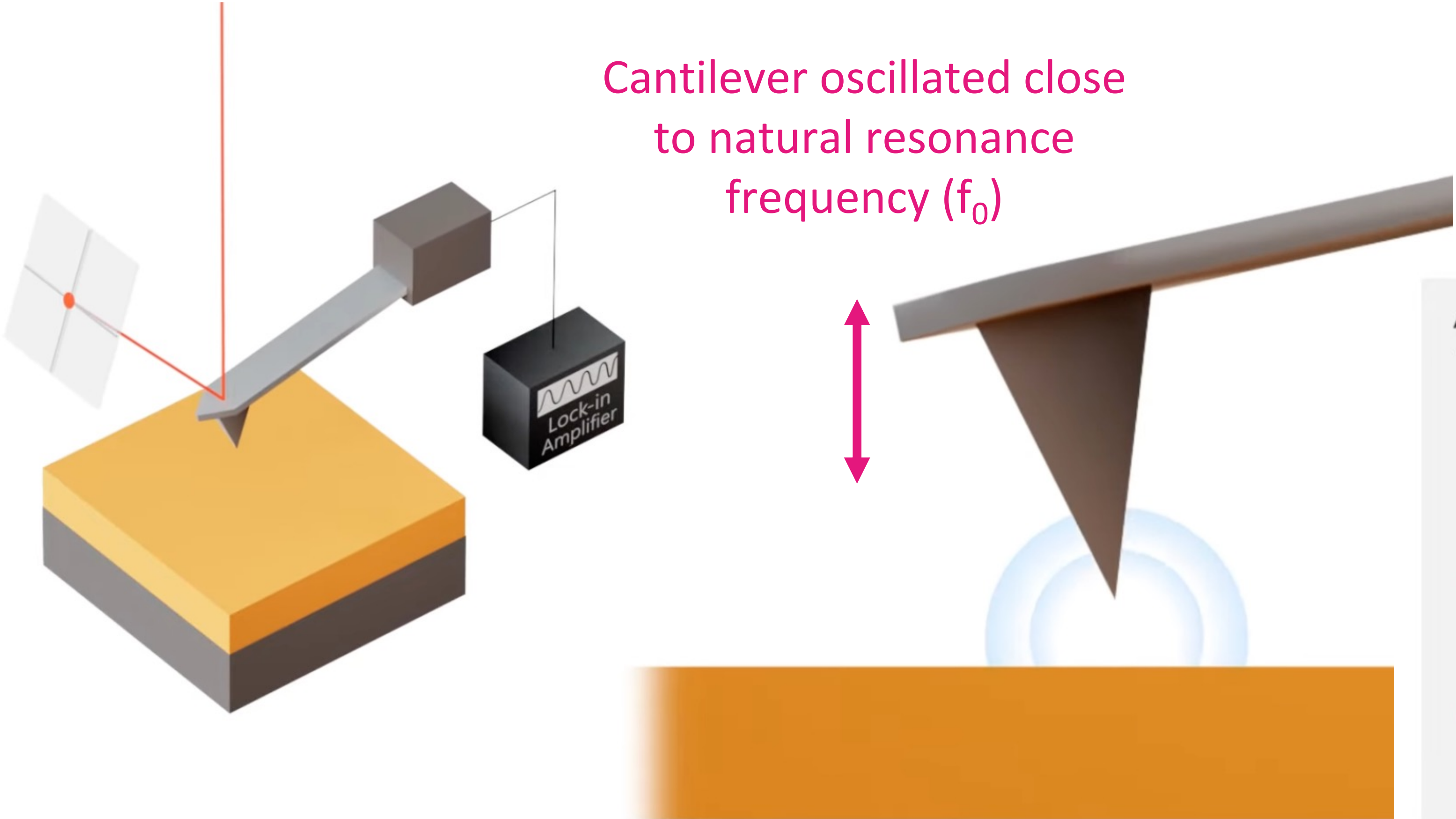


As atoms on tip approach atoms on sample, force arises that pull them closer

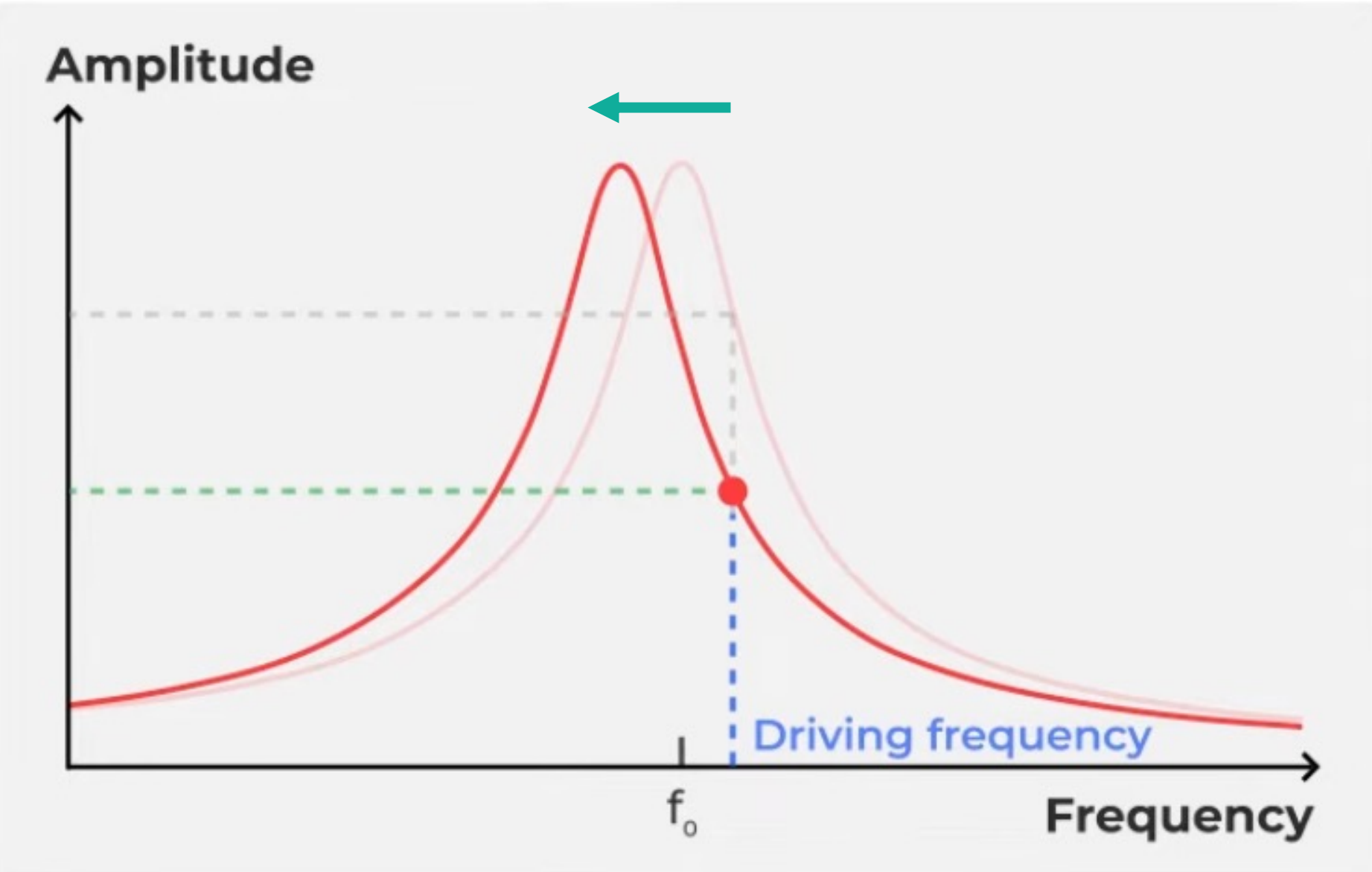


# Non-Contact Mode is the Safer Measurement Method

When tip and sample in close proximity, attractive force may not be sufficient to bend the cantilever  
→ resonance frequency of cantilever used to detect subtle force



When tip gets closer to sample, attractive forces increase → causes shift in  $f_0$  to lower values



# Non-Contact Mode is the Safer Measurement Method

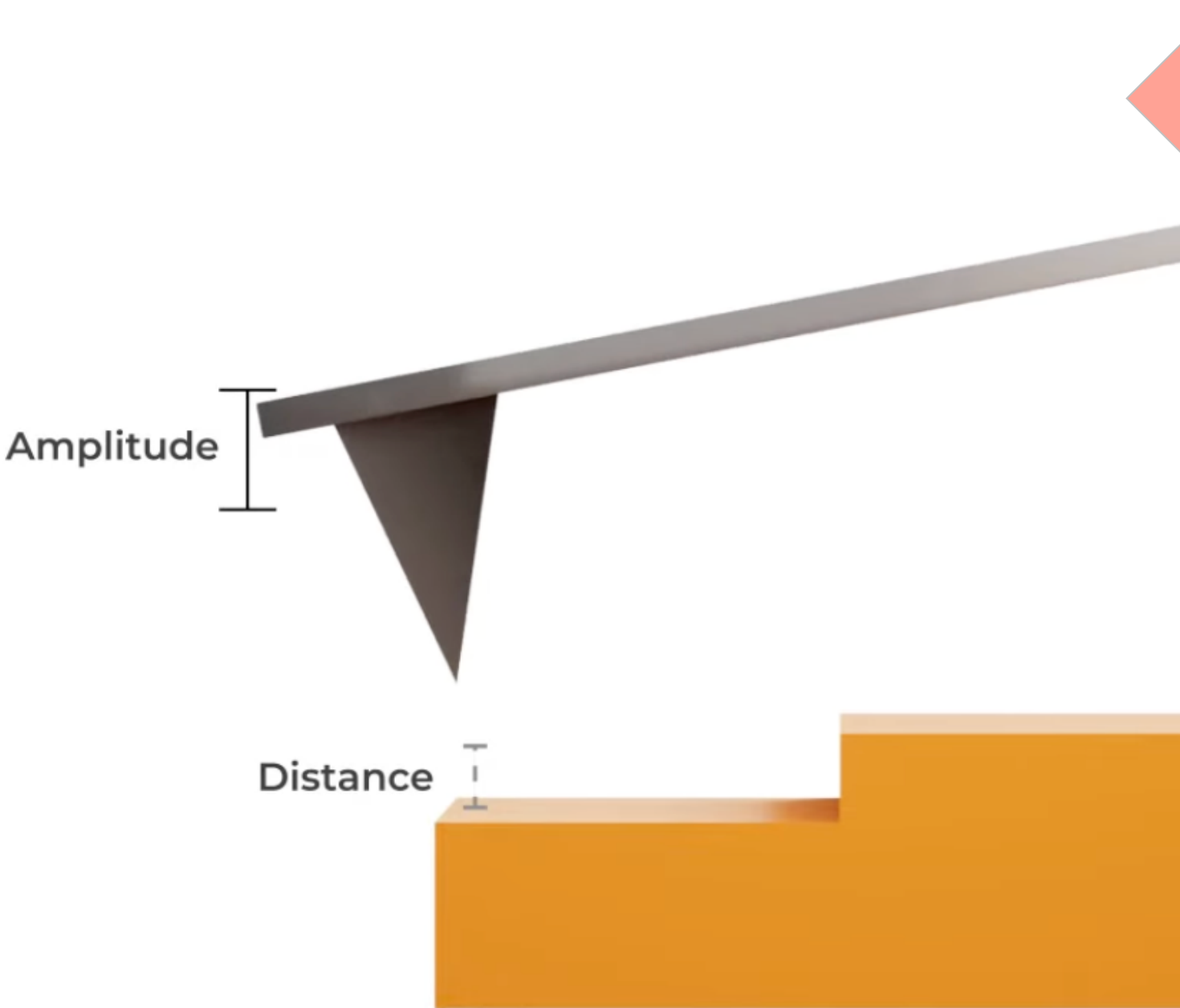
As tip and sample come closer



attractive forces strengthens



decrease in amplitude of cantilever oscillation



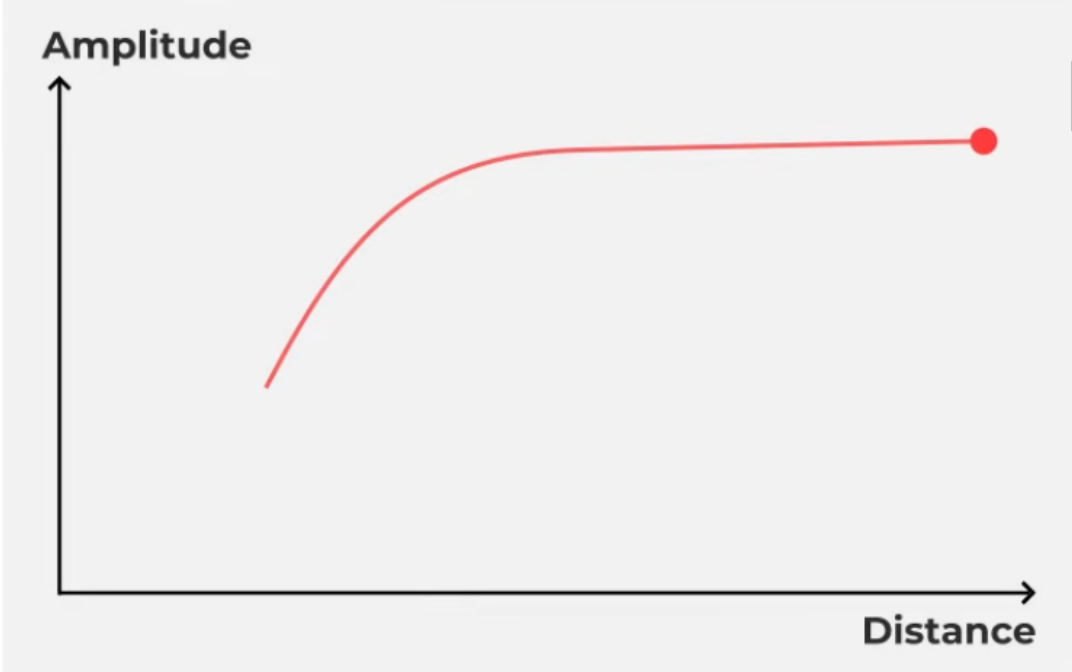
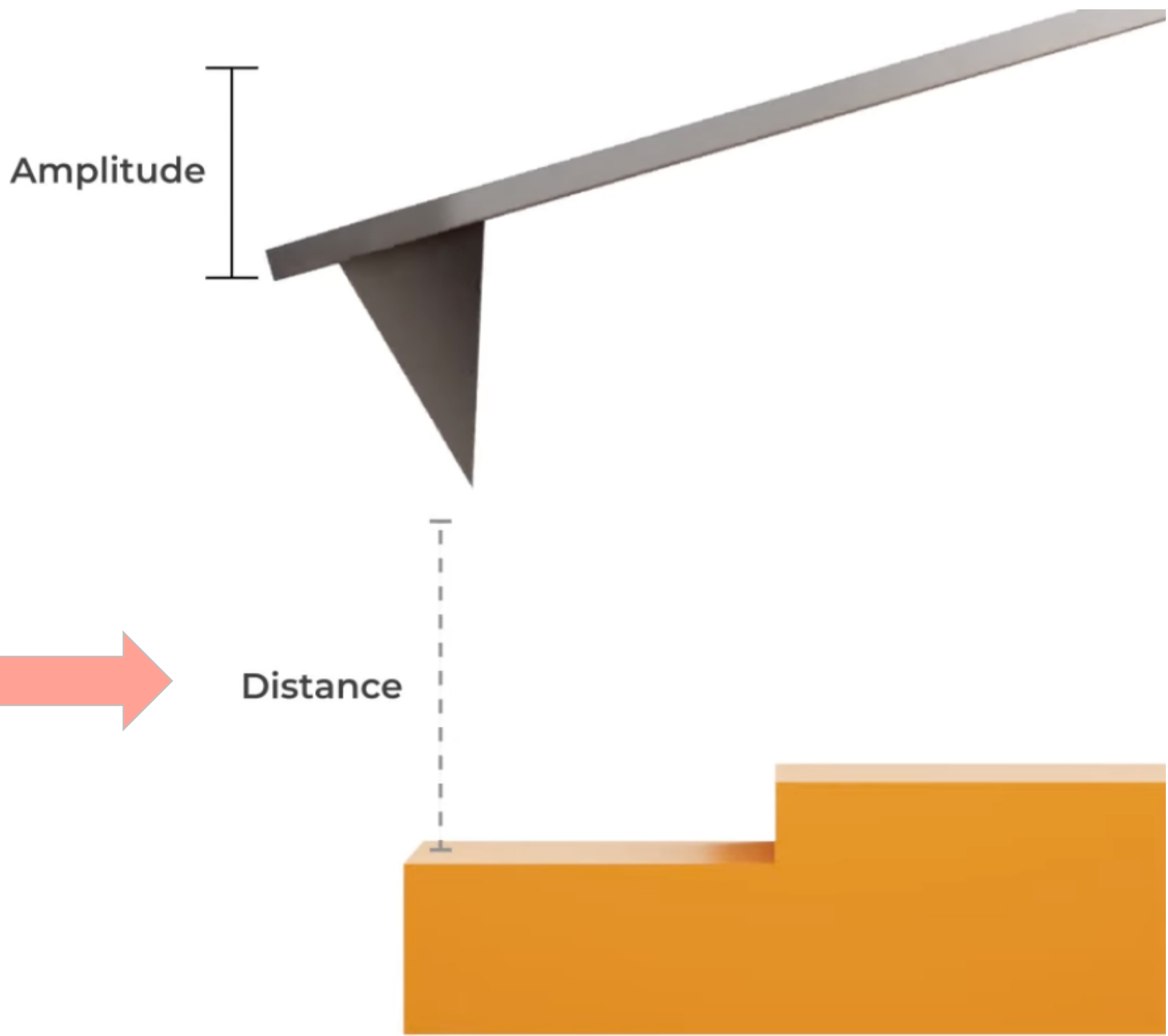
As tip and sample go further apart



attractive forces weaken



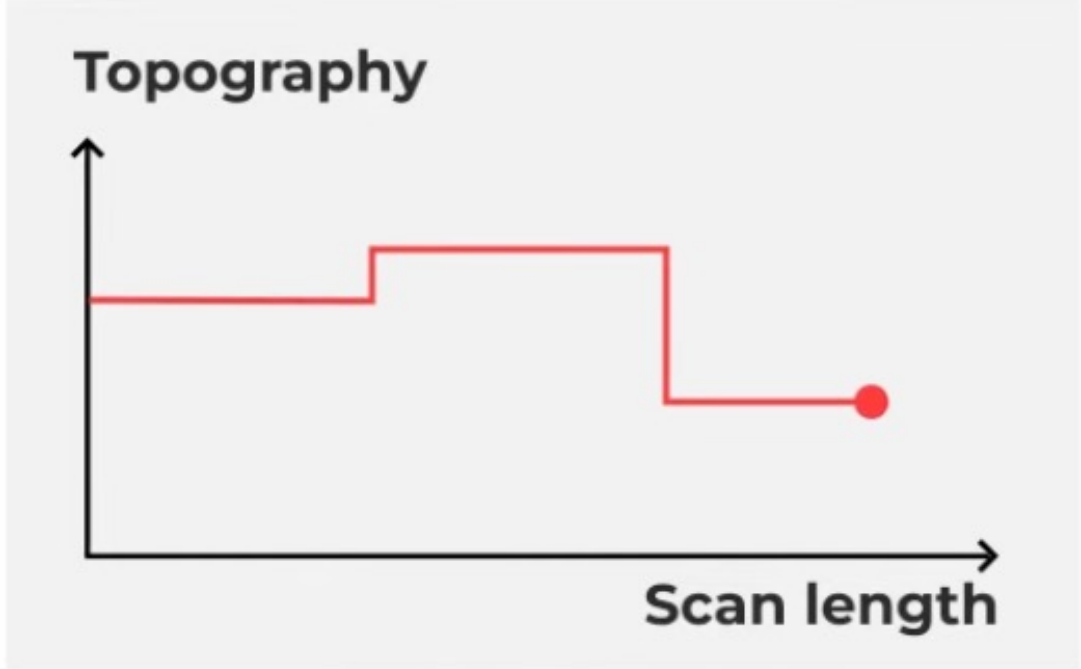
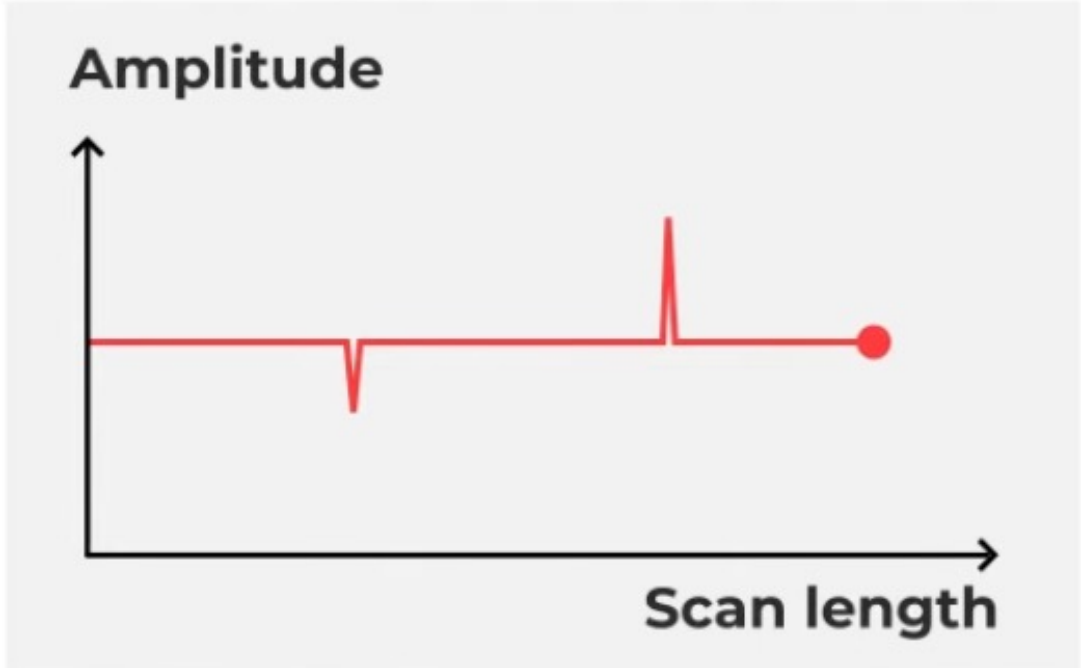
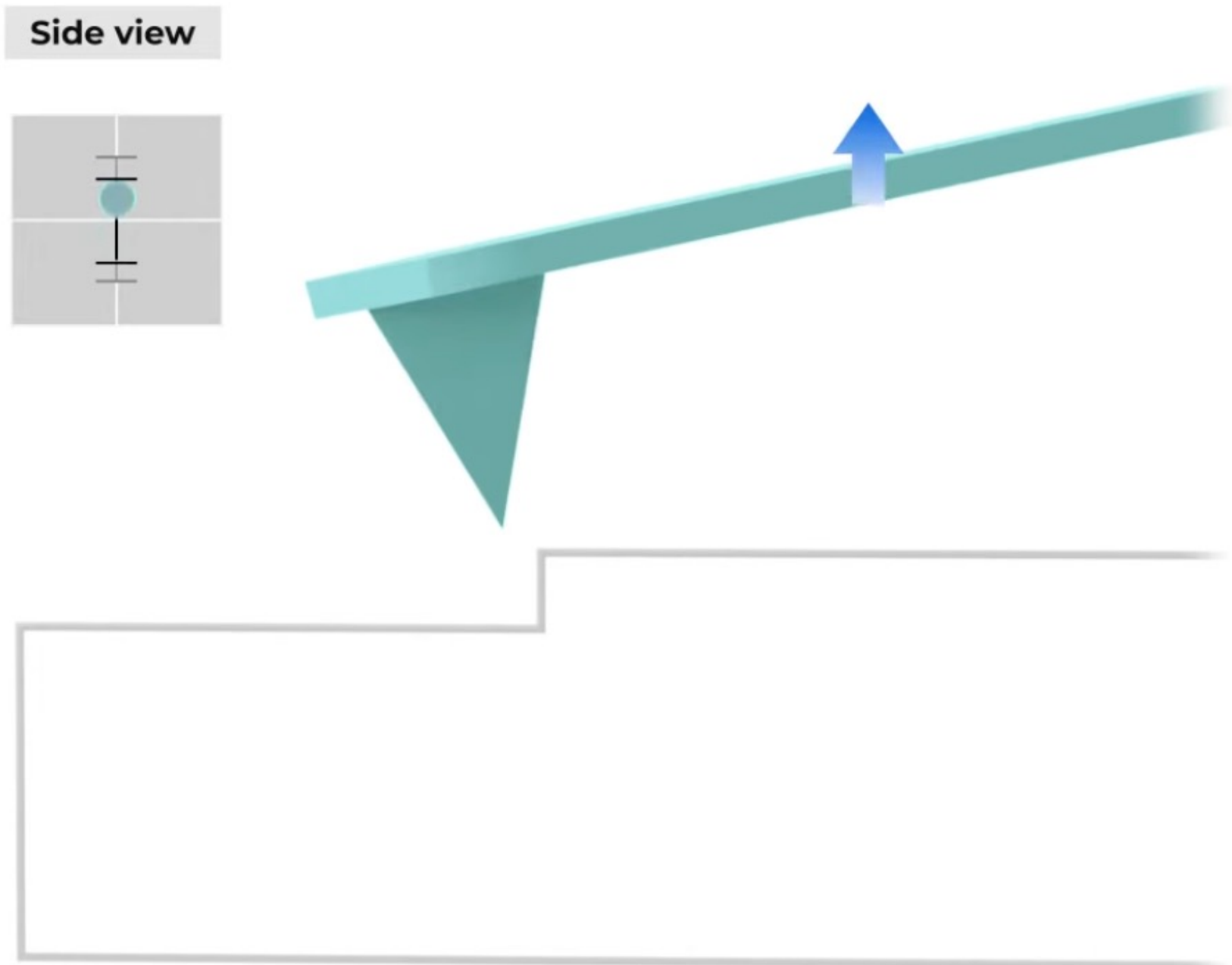
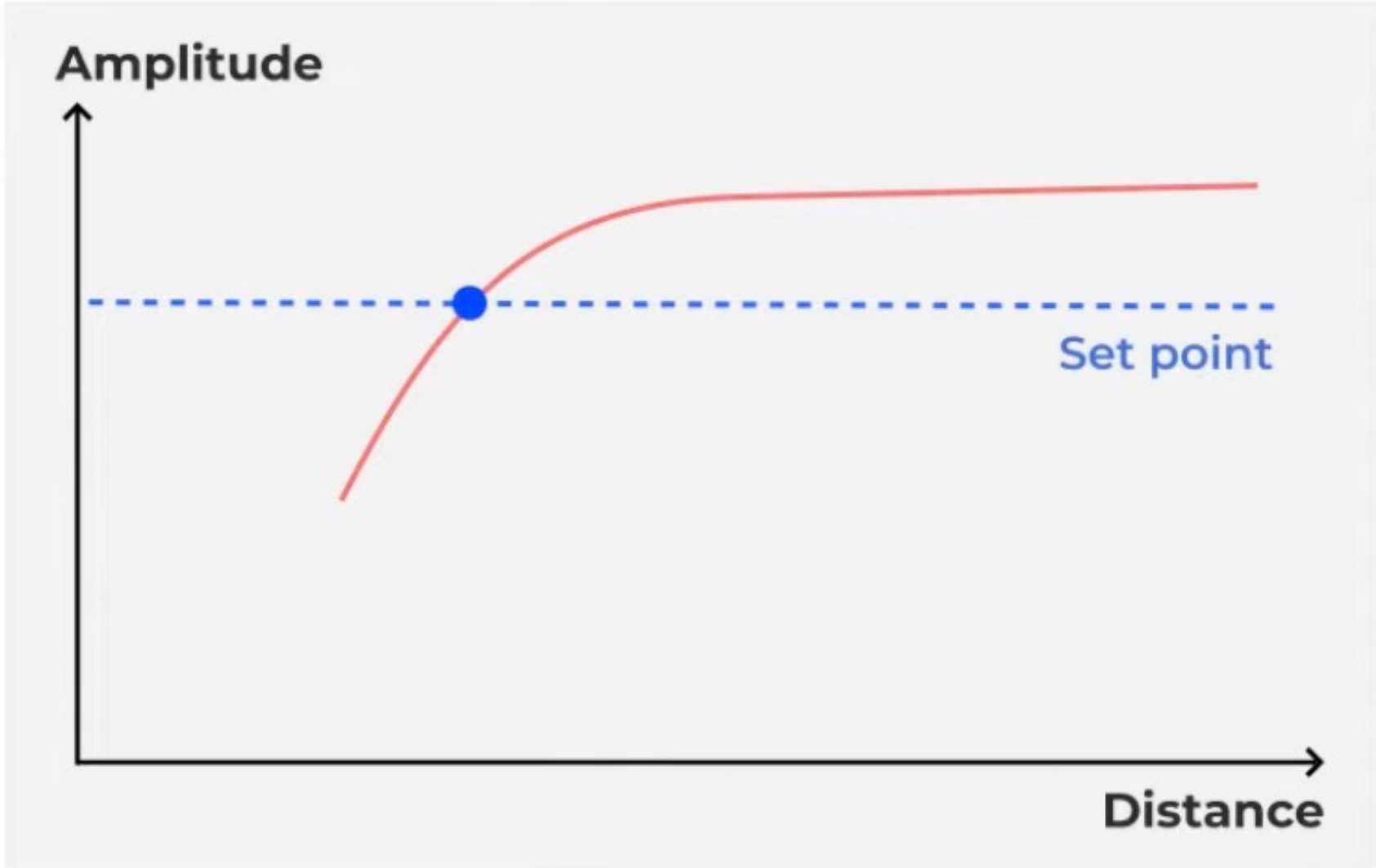
increase in amplitude of cantilever oscillation



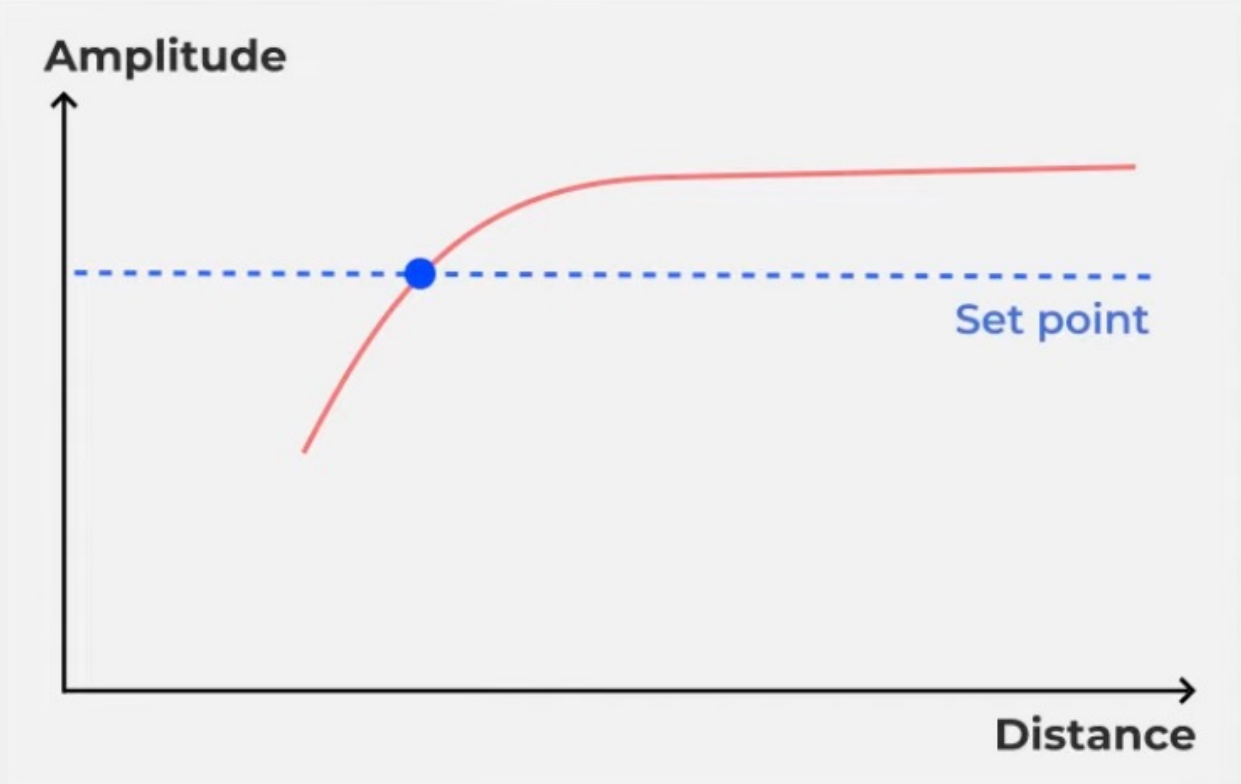
# Non-Contact Mode is the Safer Measurement Method

To scan sample, a set point (reference amplitude) is selected for feedback control

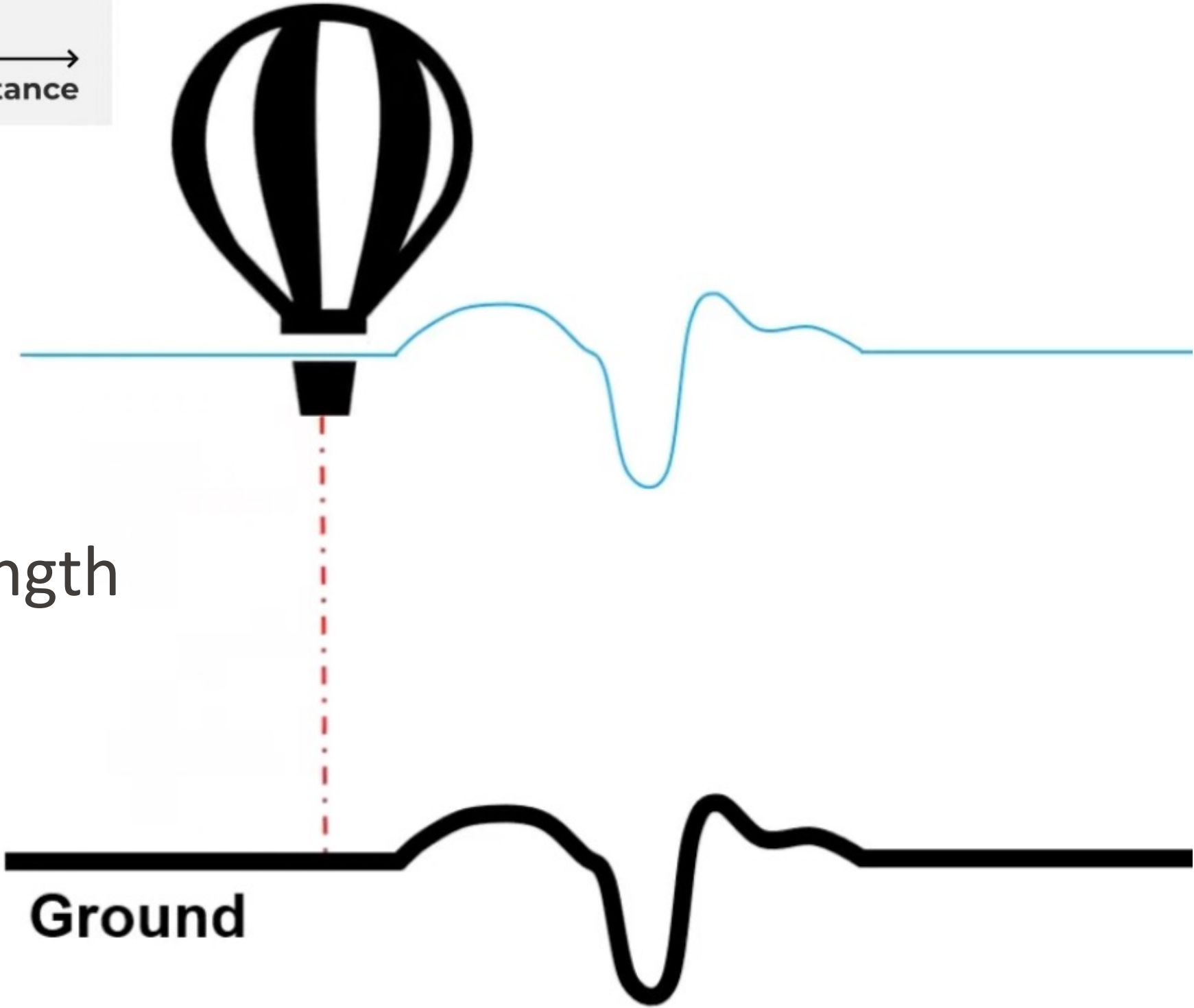
During scanning, feedback loop ensures consistent tip-sample distance by adjusting z-scanner height to maintain constant amplitude



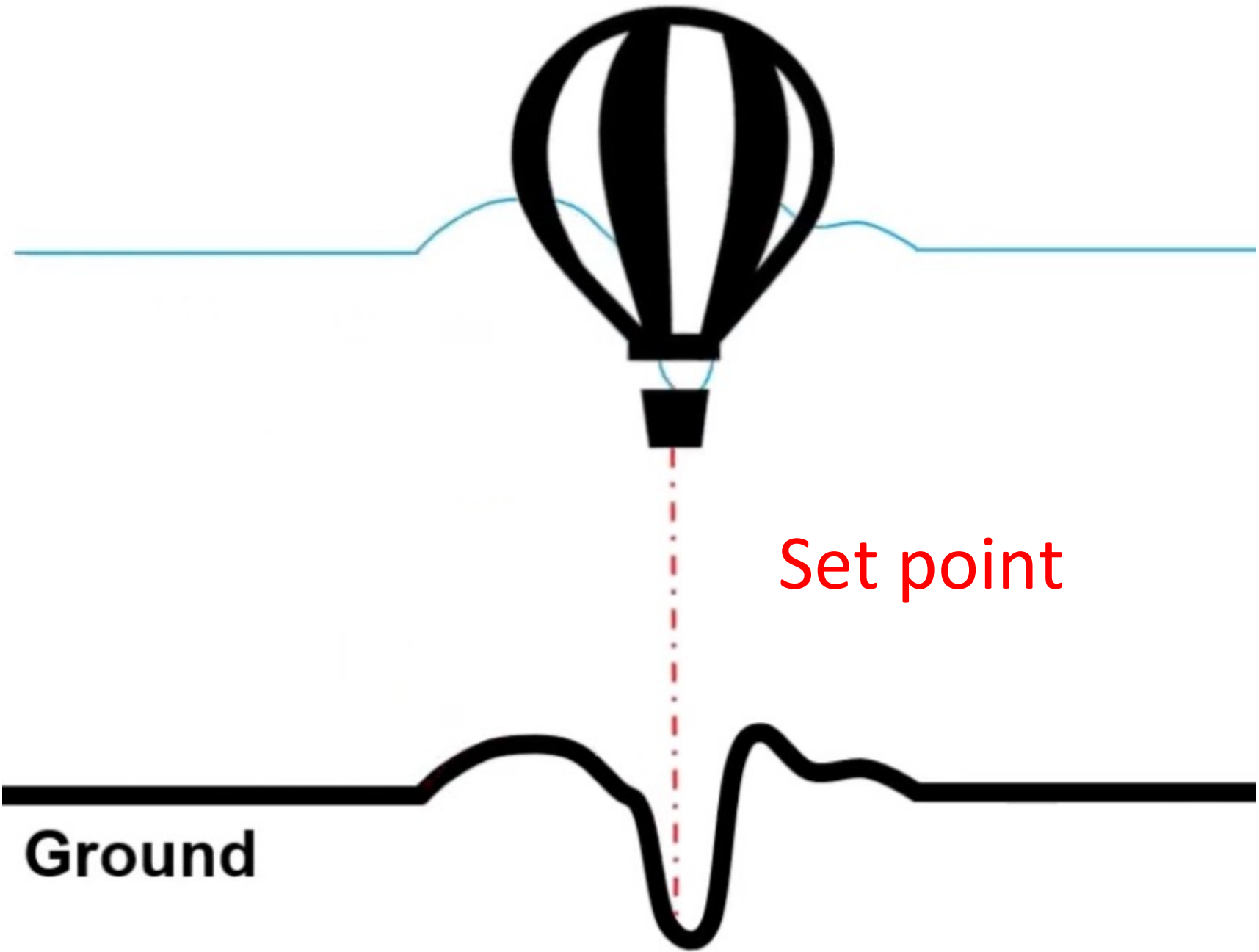
# Explaining Set Point From the Perspective of a Hot Air Balloon



Fixed focal length camera



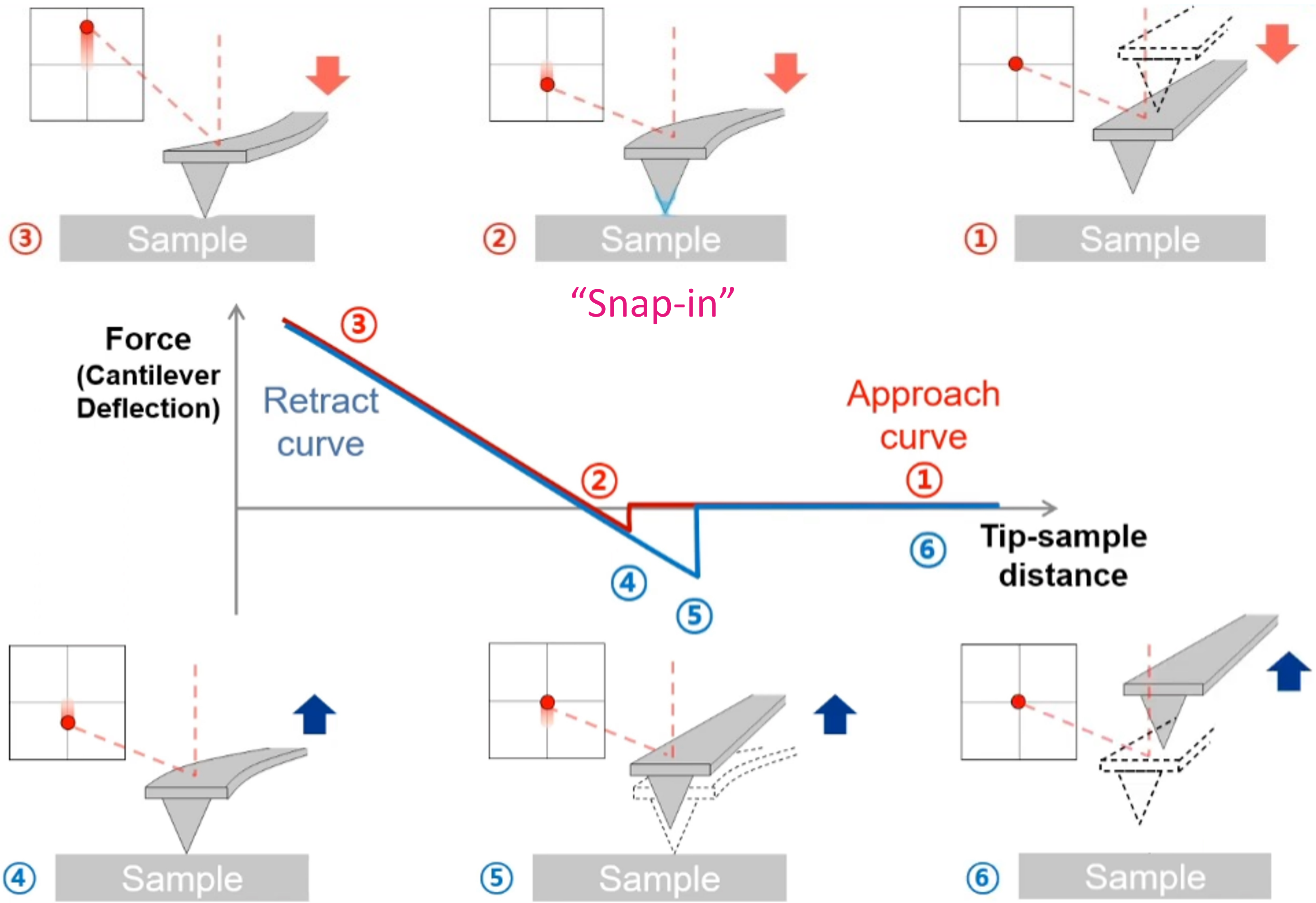
Z-scanner of AFM



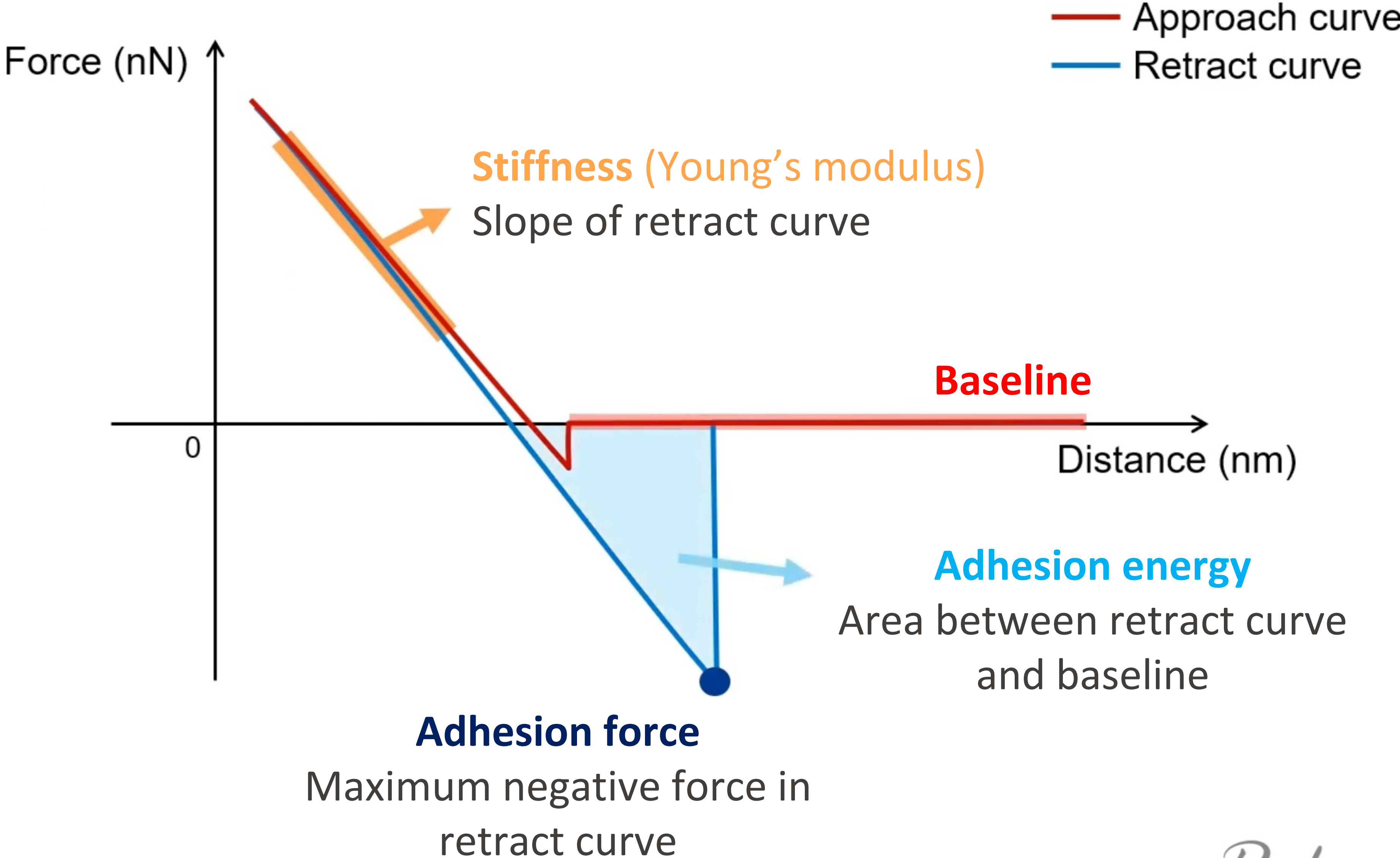
# Contact vs. Non-Contact Mode AFM

Feature / Aspects	Contact Mode AFM	Non-Contact AFM
Tip-sample interaction	Tip remains in continuous physical contact with surface	Tip oscillates near the surface without touching it (only long-range forces)
Potential for sample / tip damage	High — can deform or scratch soft samples	Low — minimal wear and damage
Image resolution (topography)	Excellent on hard, flat surfaces; can be degraded by tip wear on soft materials	High, but sensitive to contamination and environmental noise
Suitability for soft/biological samples	Poor to fair (risk of damage)	Good if stable in air/vacuum Difficult in liquid
Operation in liquid	Stable	Difficult — oscillation damped by liquid
Quantitative force measurement	Yes — directly from deflection (ideal for force-distance curves, adhesion, stiffness)	Limited — indirect via force gradients
Speed / scan rate	Fast, robust feedback loop	Slow, due to weak signals and delicate tuning
Complexity of setup	Simple — easy to align and tune	Complex — requires stable environment
Typical applications	Hard materials, tribology, friction mapping, force spectroscopy	Delicate surfaces, molecular-scale imaging, surface potential studies

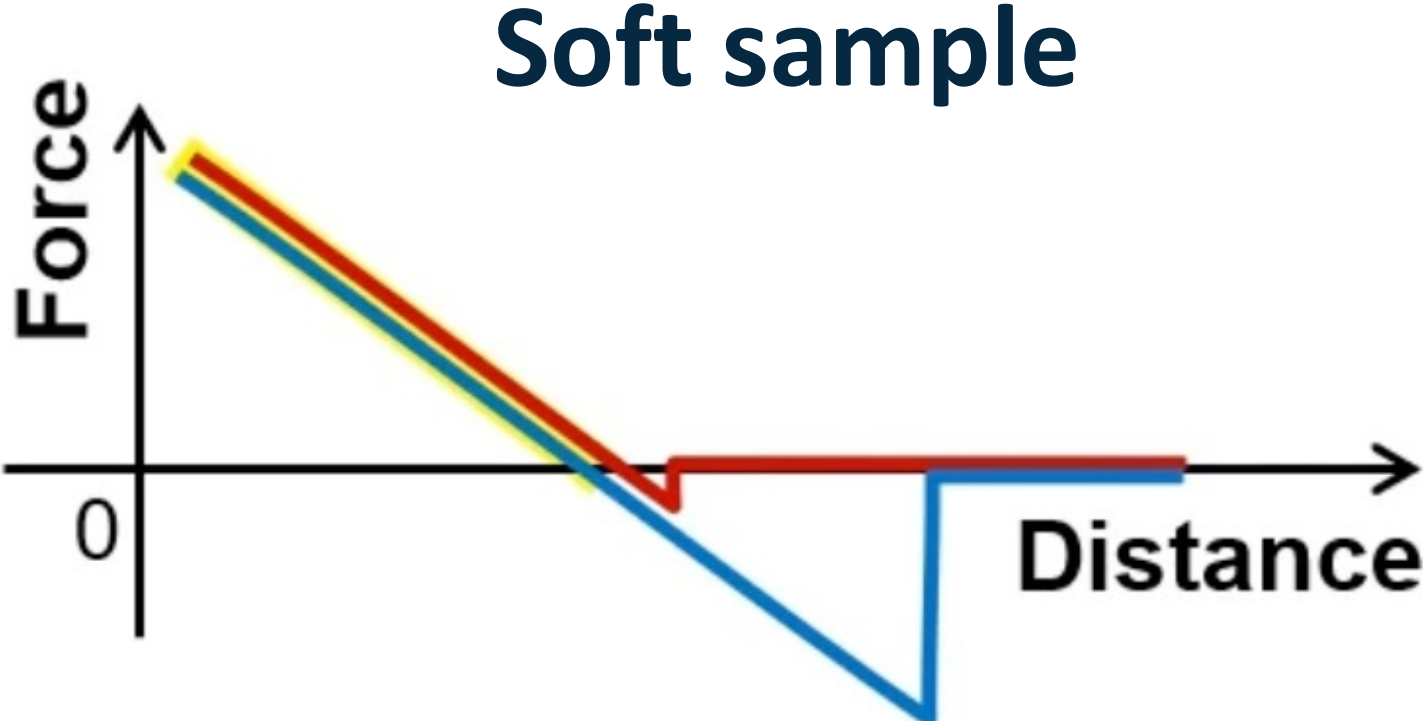
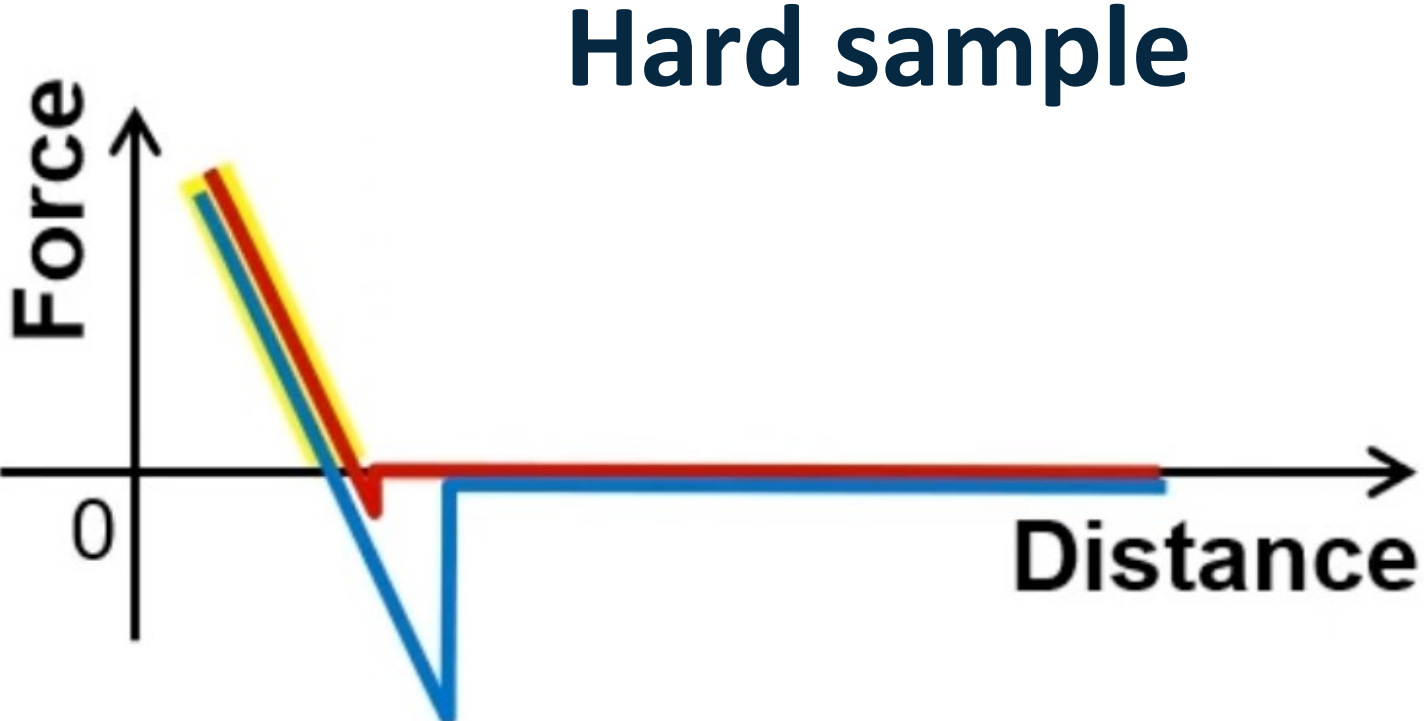
# Force-Distance Curve for Mechanical Measurements



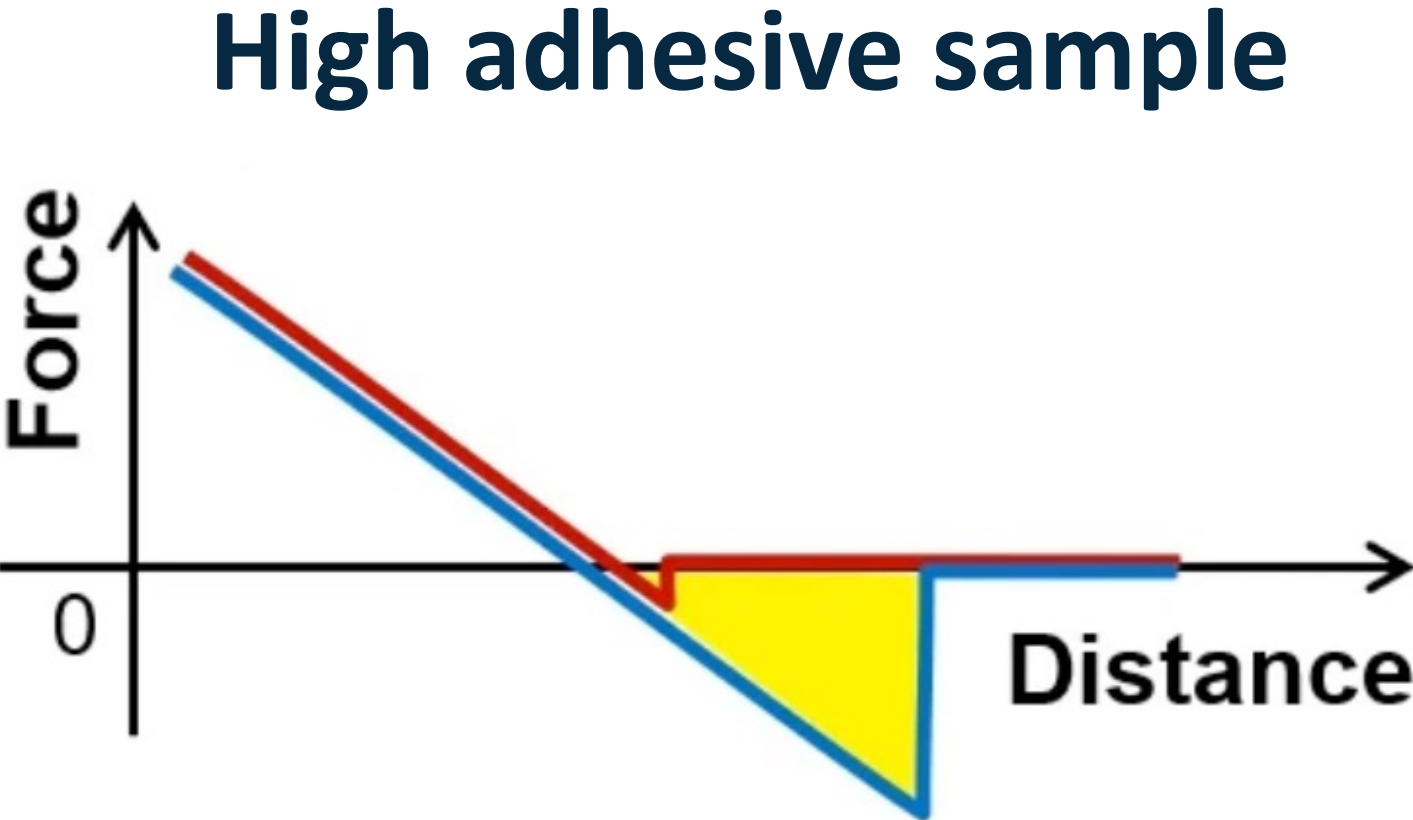
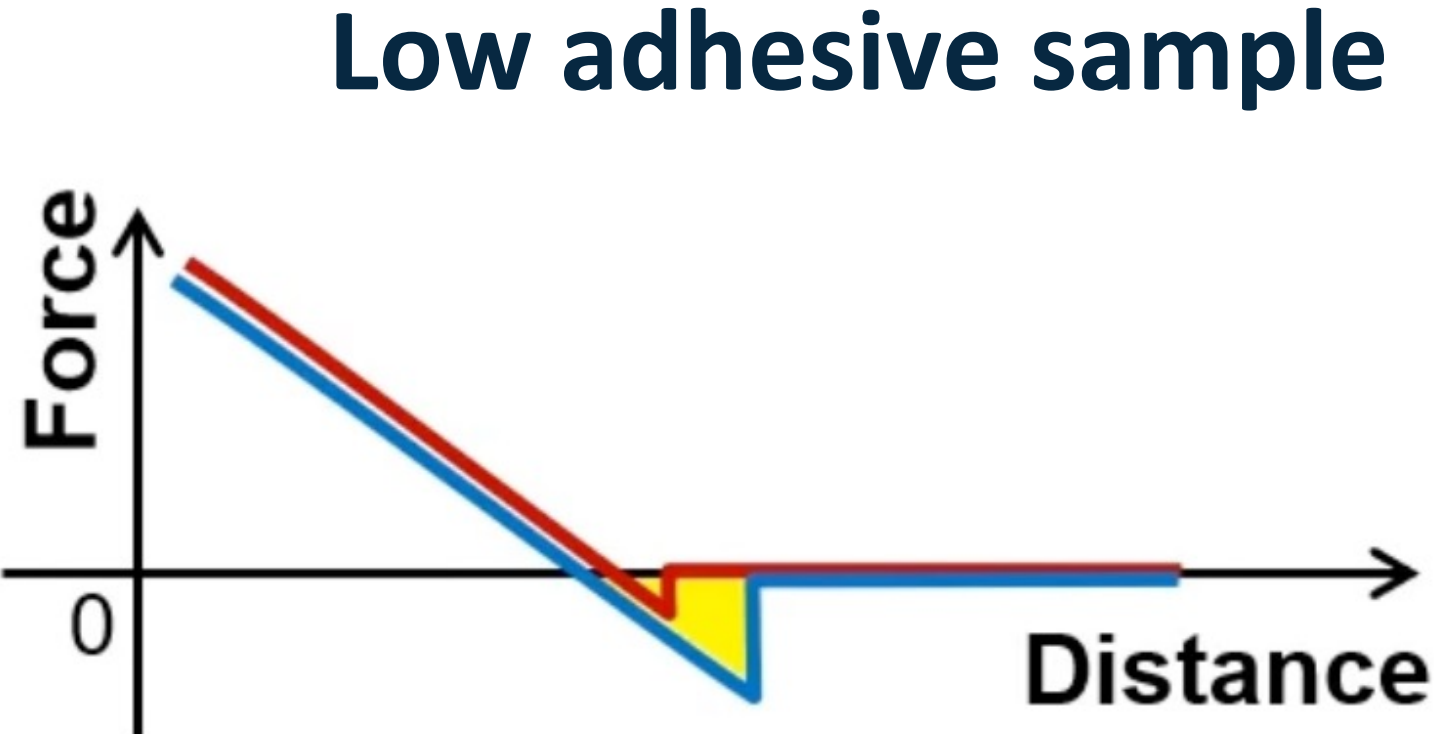
# Force-Distance Curve for Mechanical Measurements



# Force-Distance Curve Vary For Different Samples

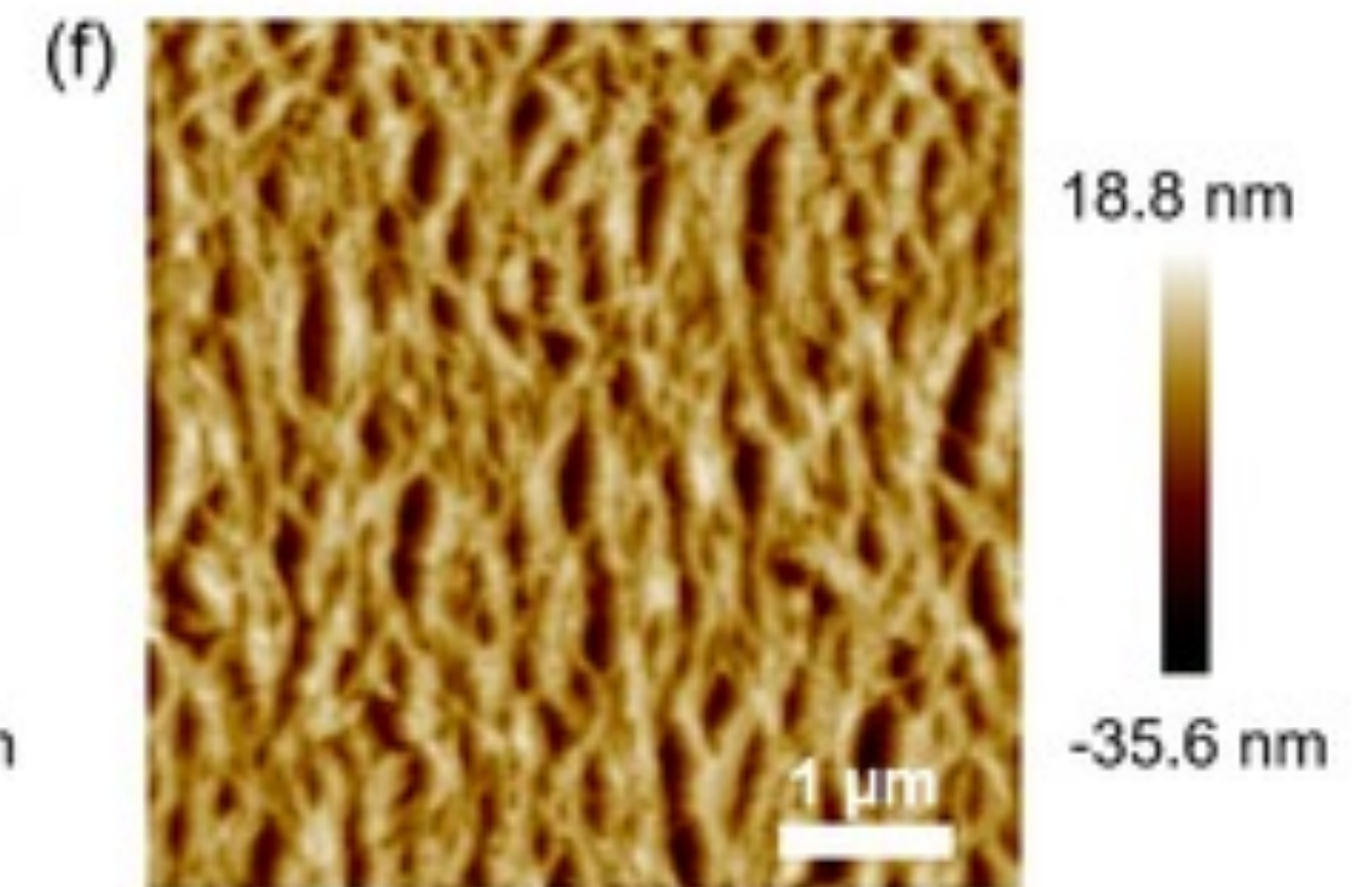
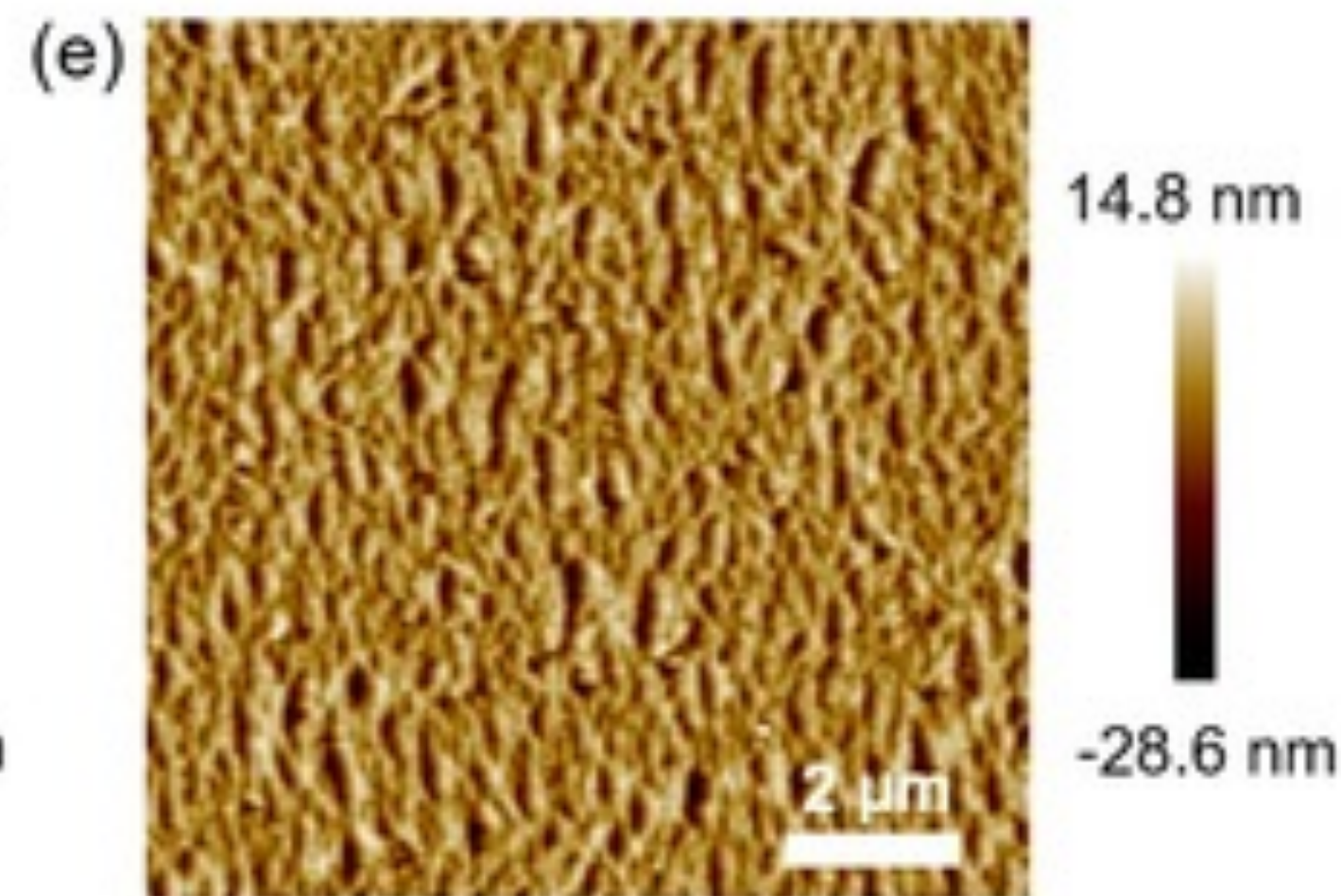
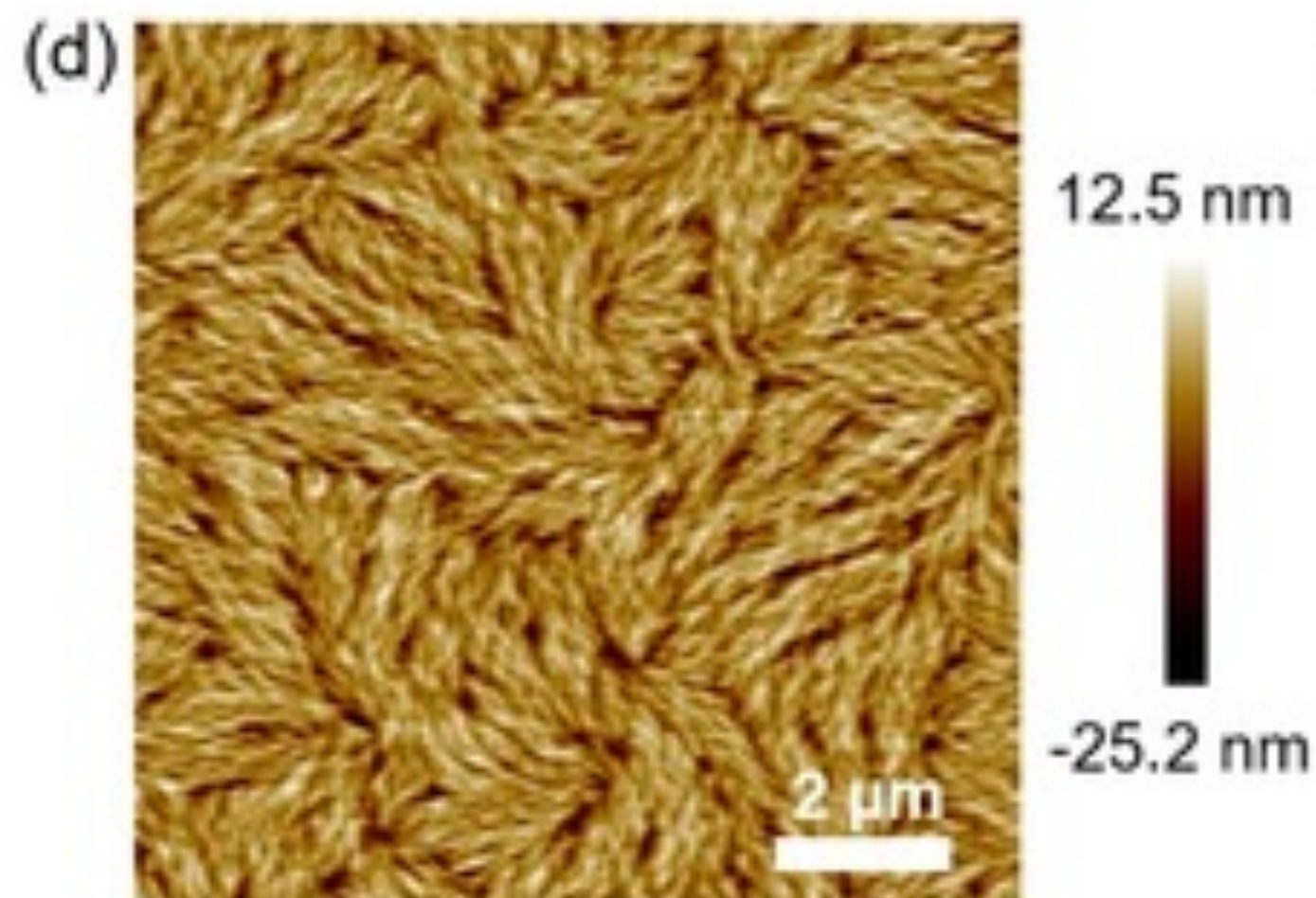
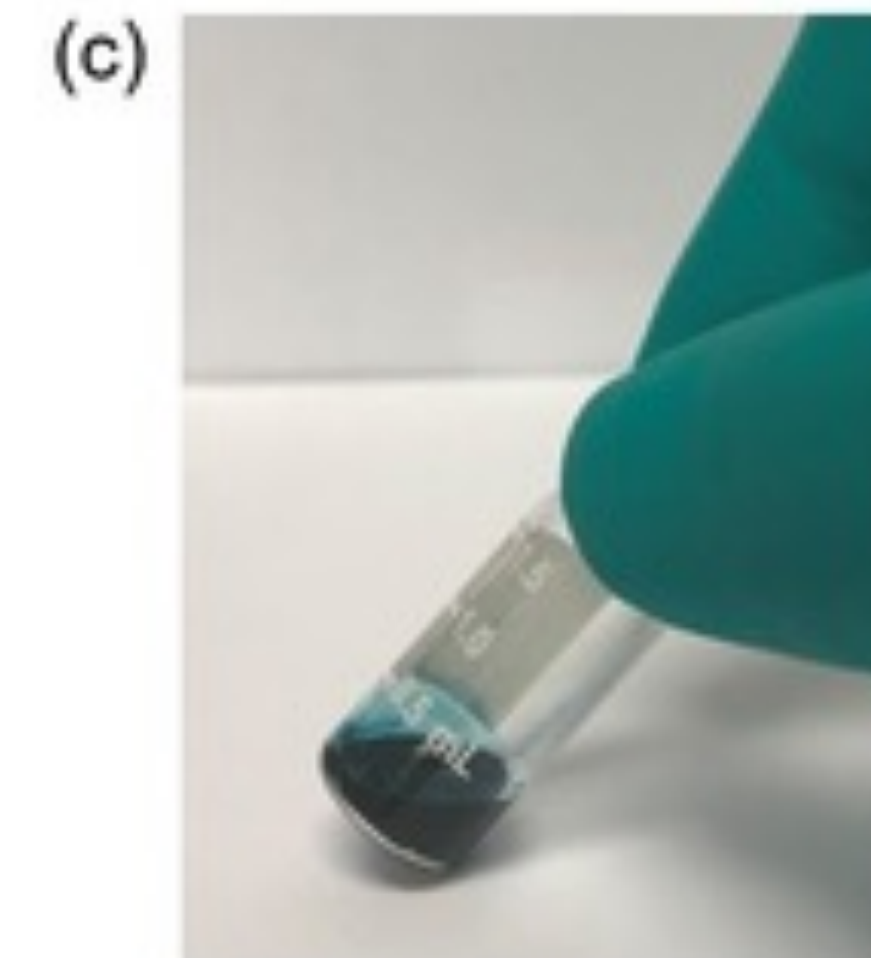
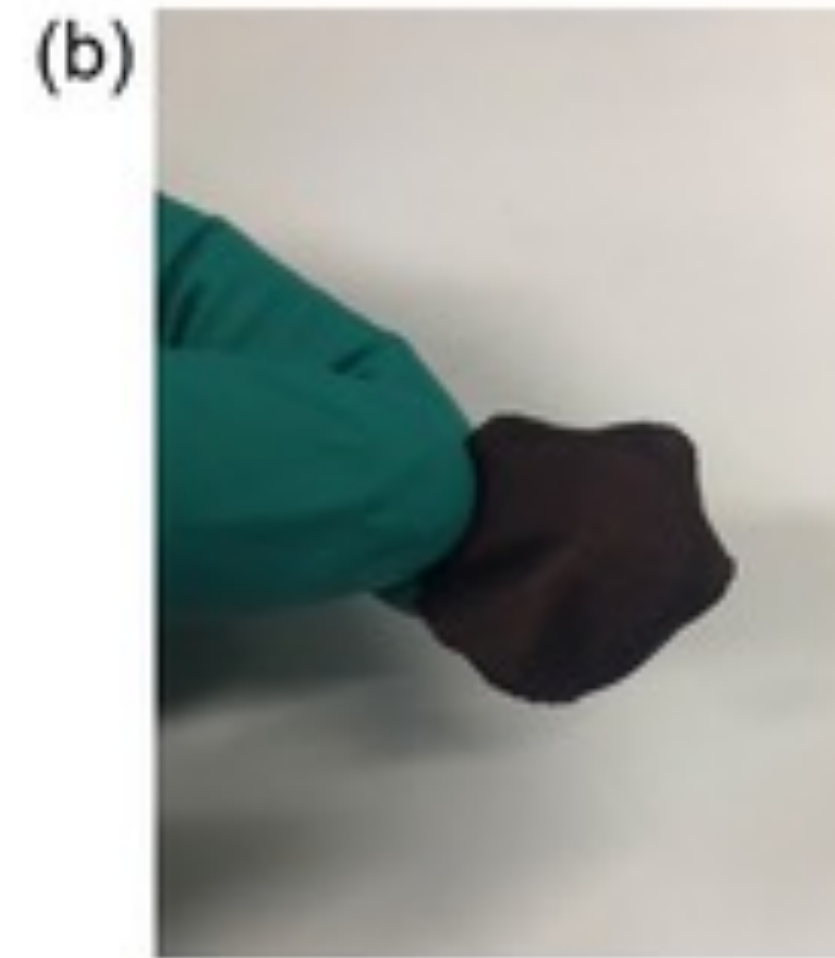
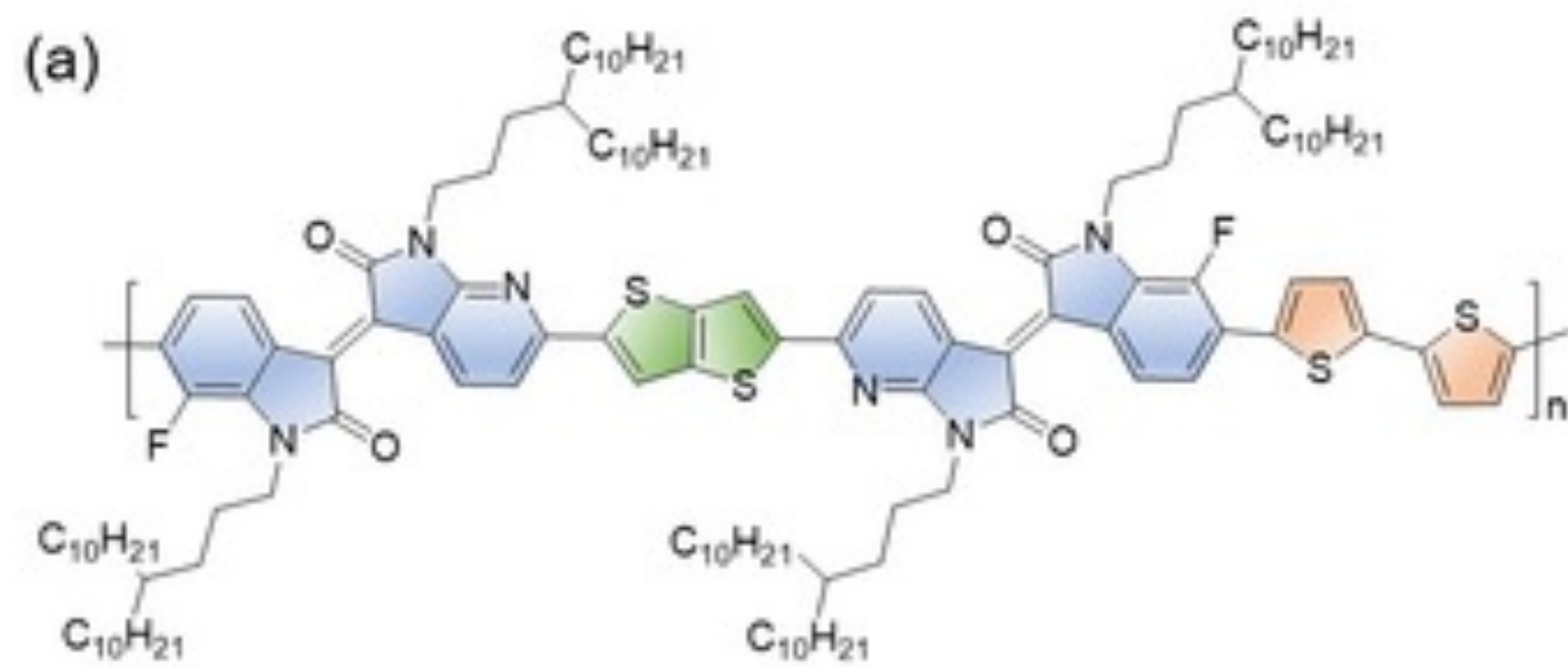


Harder samples have steeper slopes on the force-distance curve

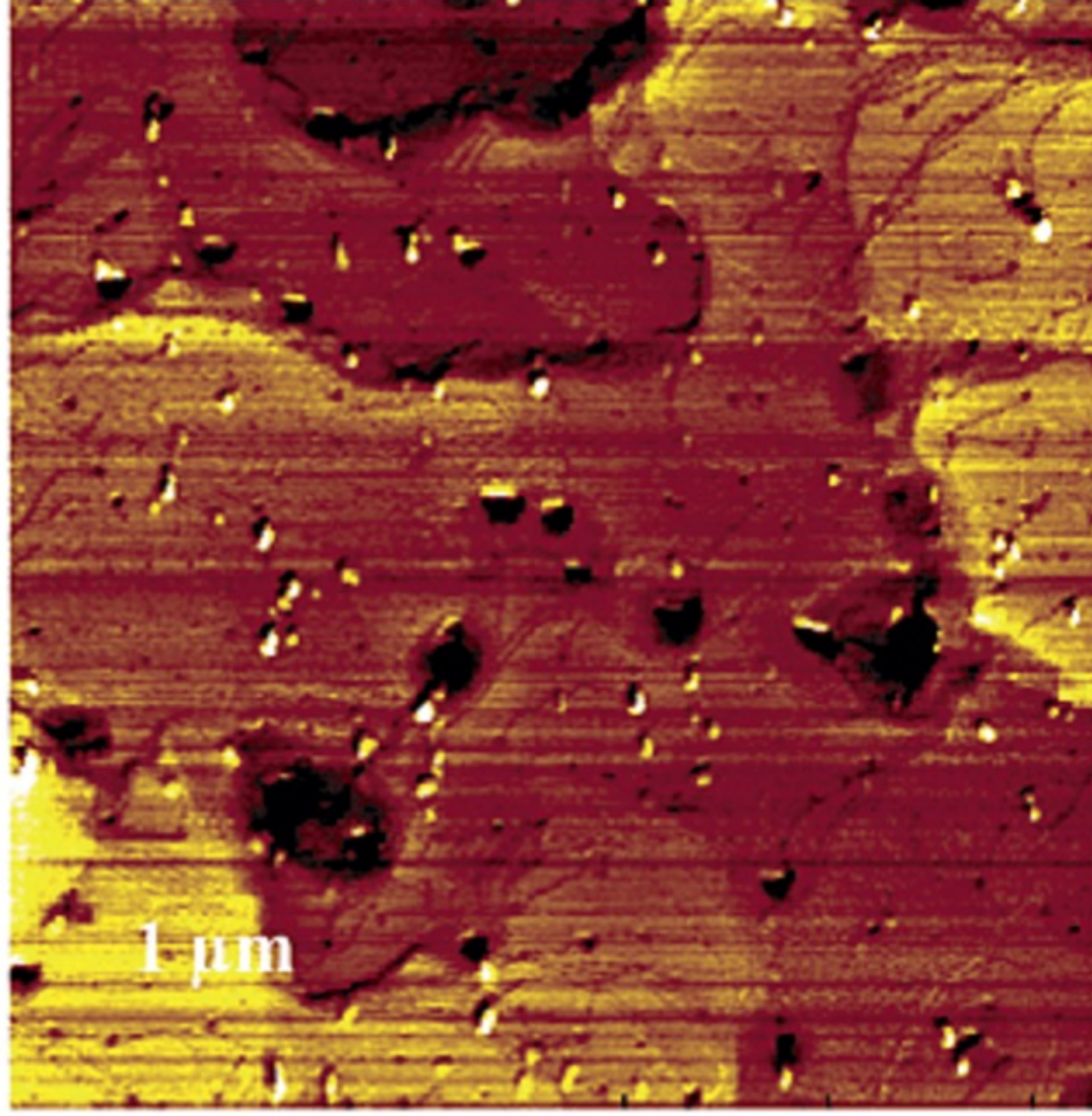
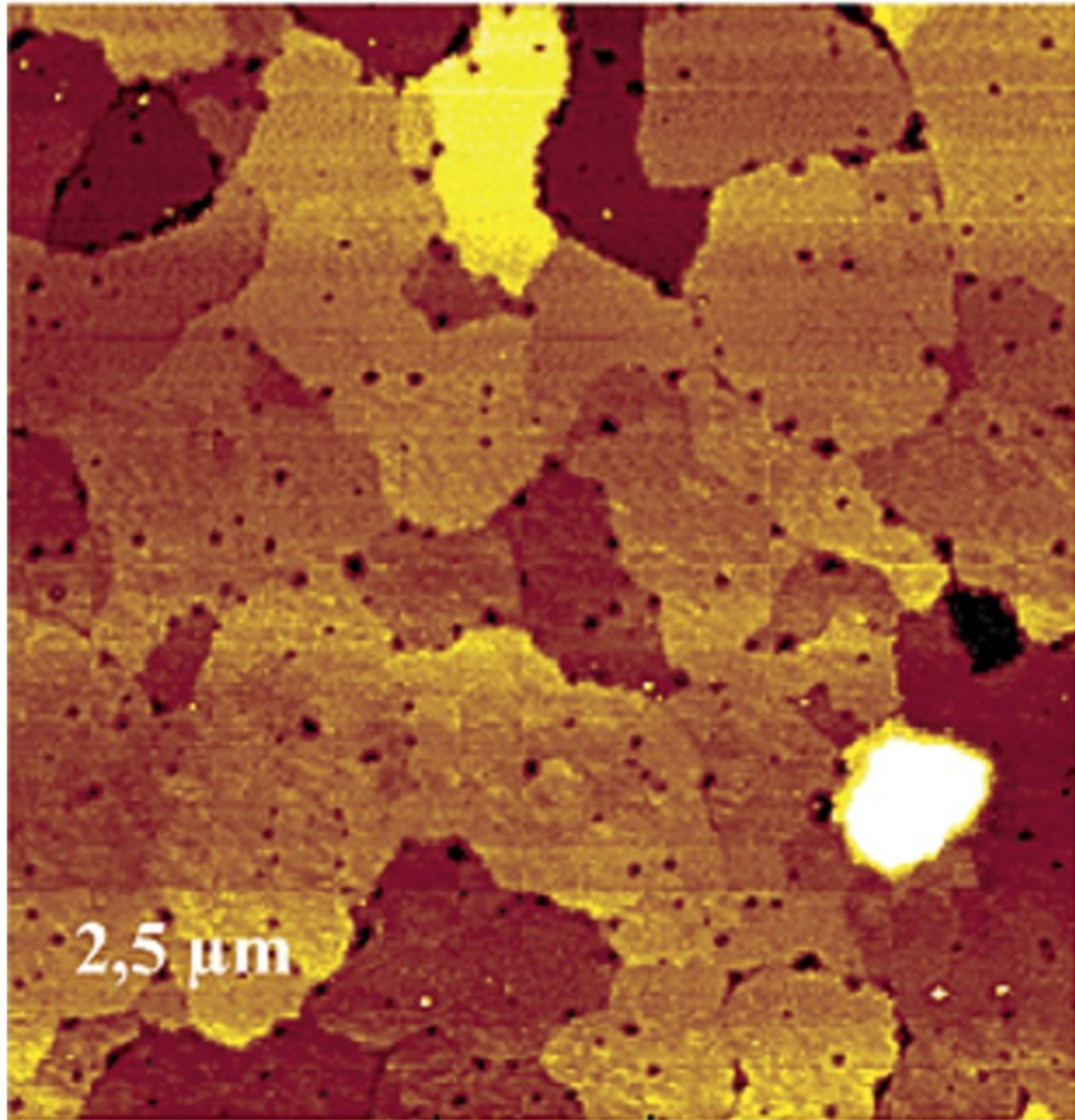


Sticky adhesive samples have larger area between retract curve and baseline

# AFM Images of Non-Conductive Polymer Films

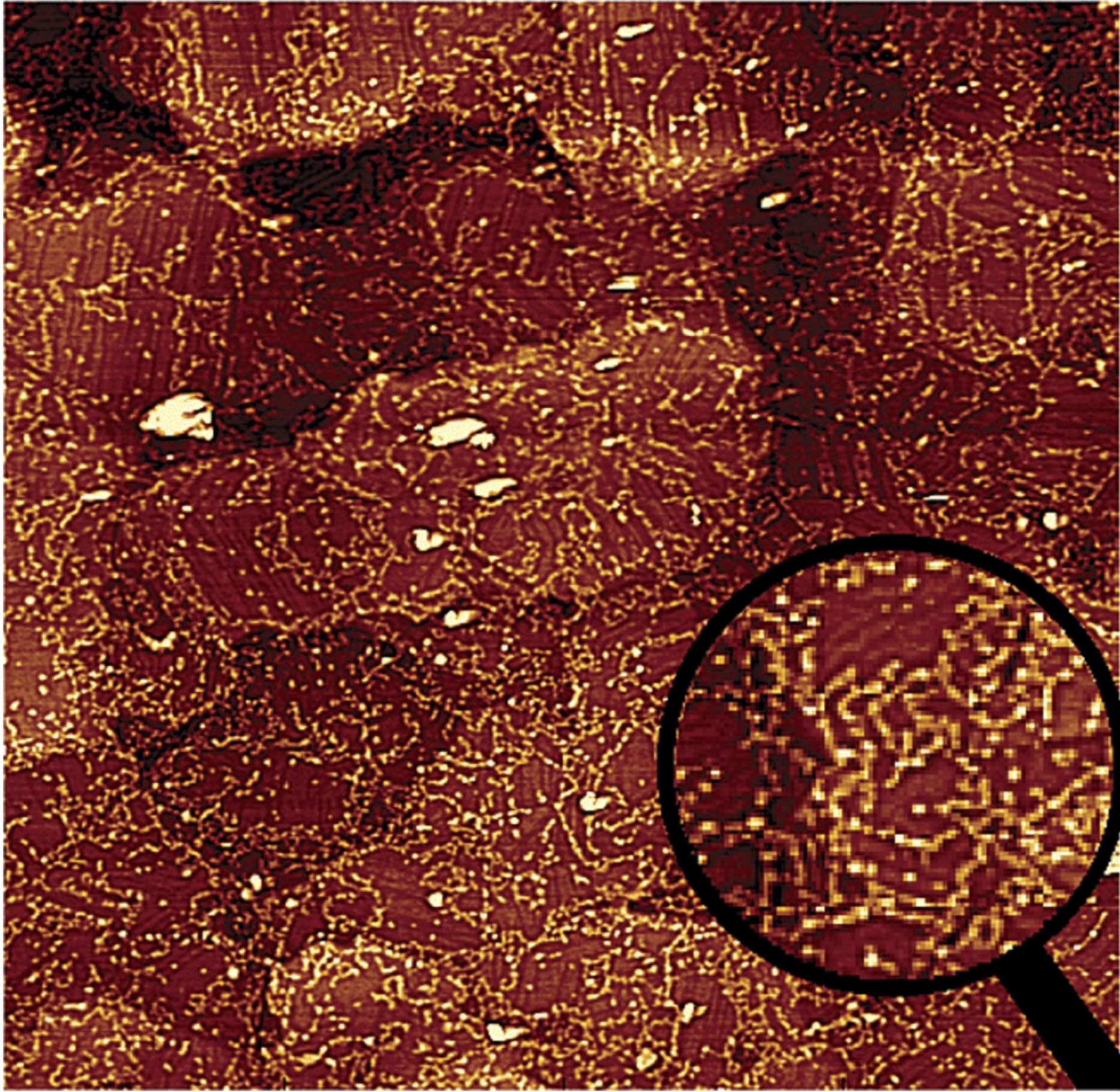


# AFM to Visualize Molecular Assembly on Surfaces (Thiolated DNA)

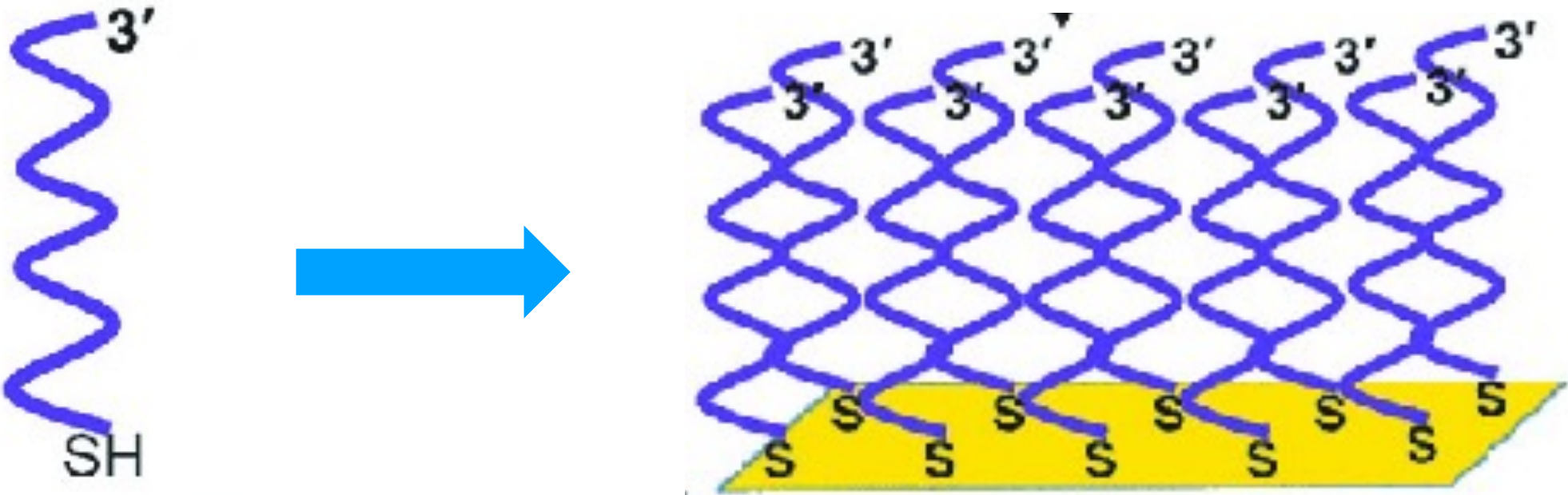


AFM image of Au (111) surface (terraces observed)

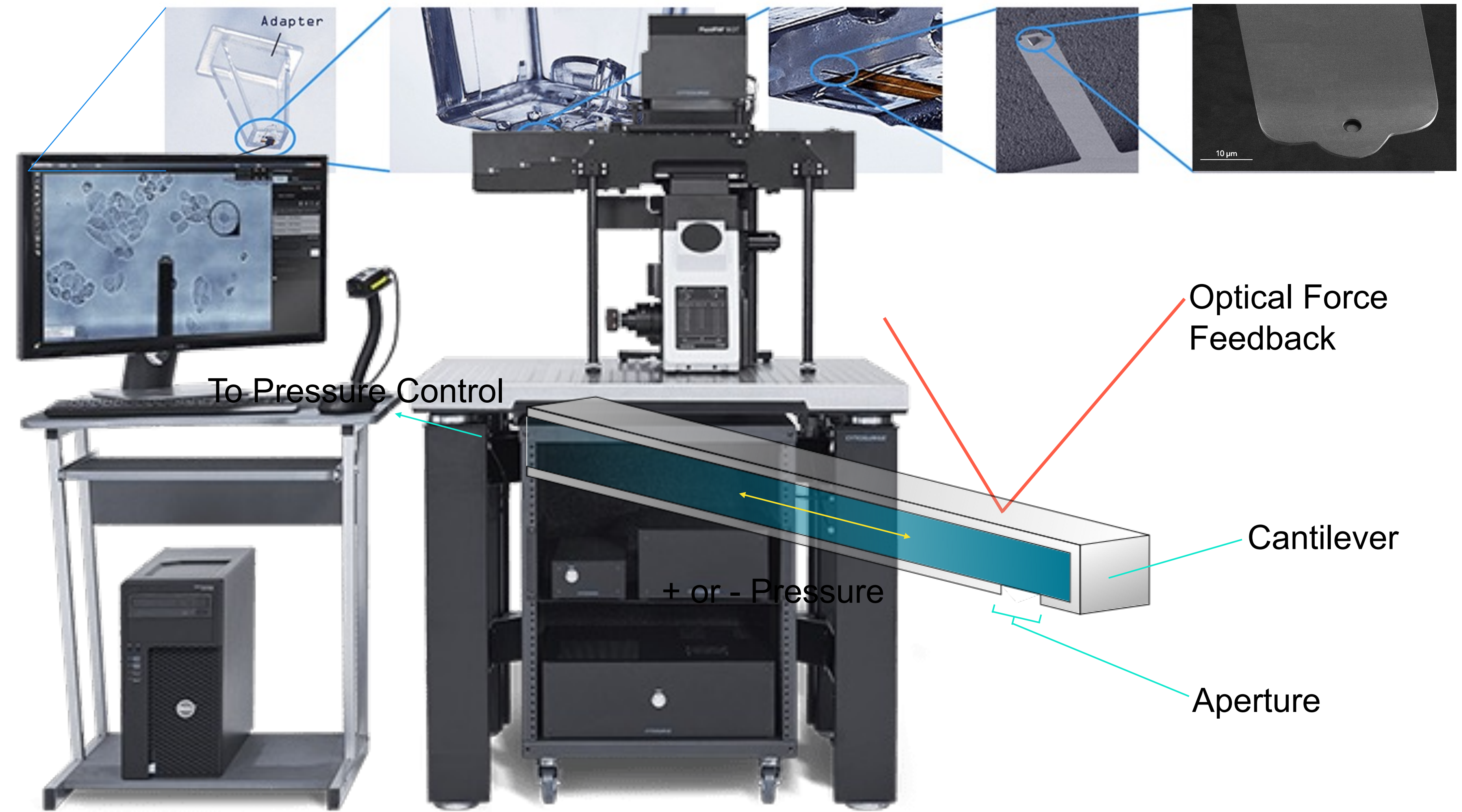
Surface exposed to a solution of oligonucleotides (25-base thiolated DNA)



2 μm



# Advances in AFM – the Fluid Force Microscope (FluidFM)

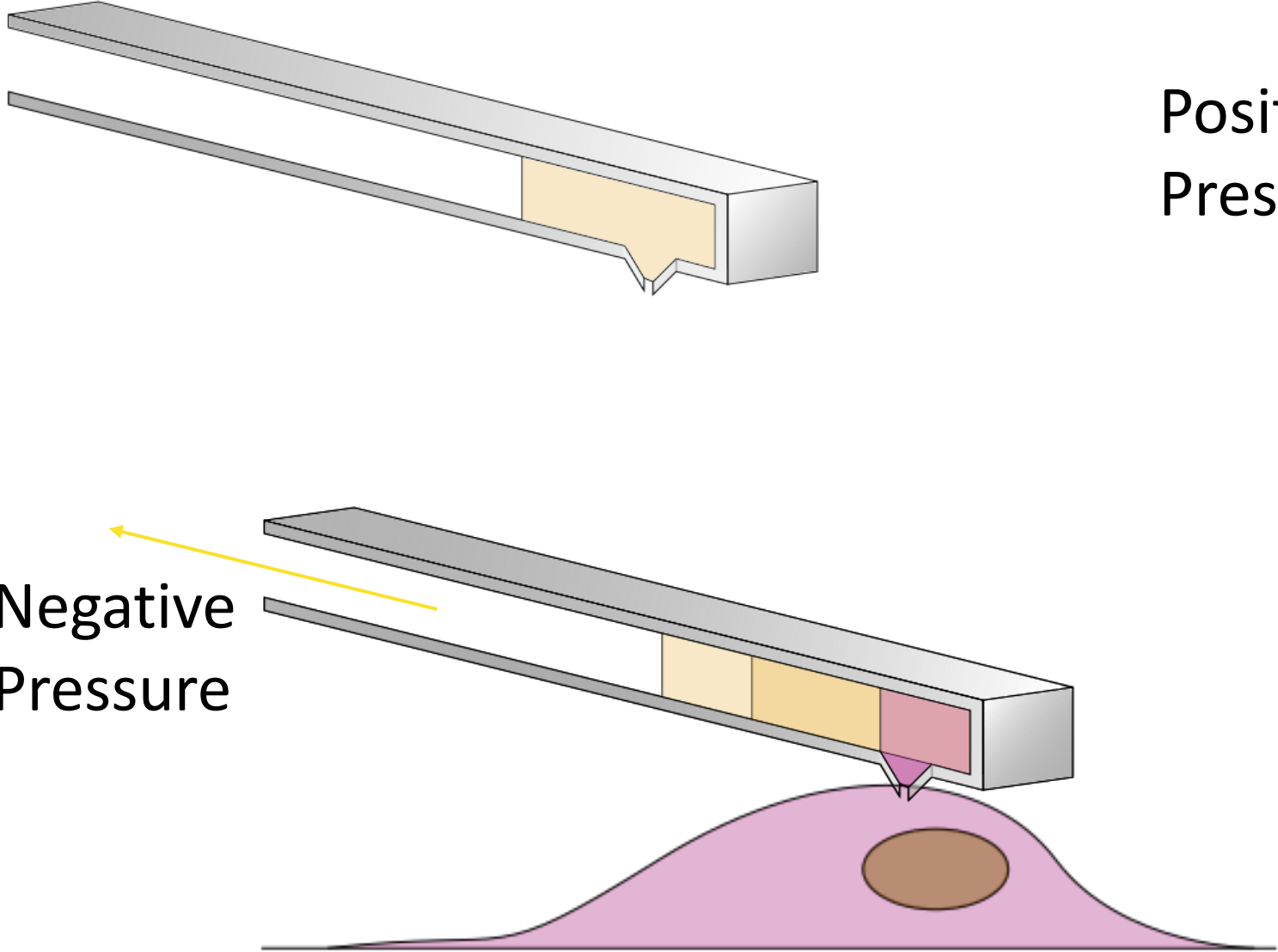


CYTOSURGE®

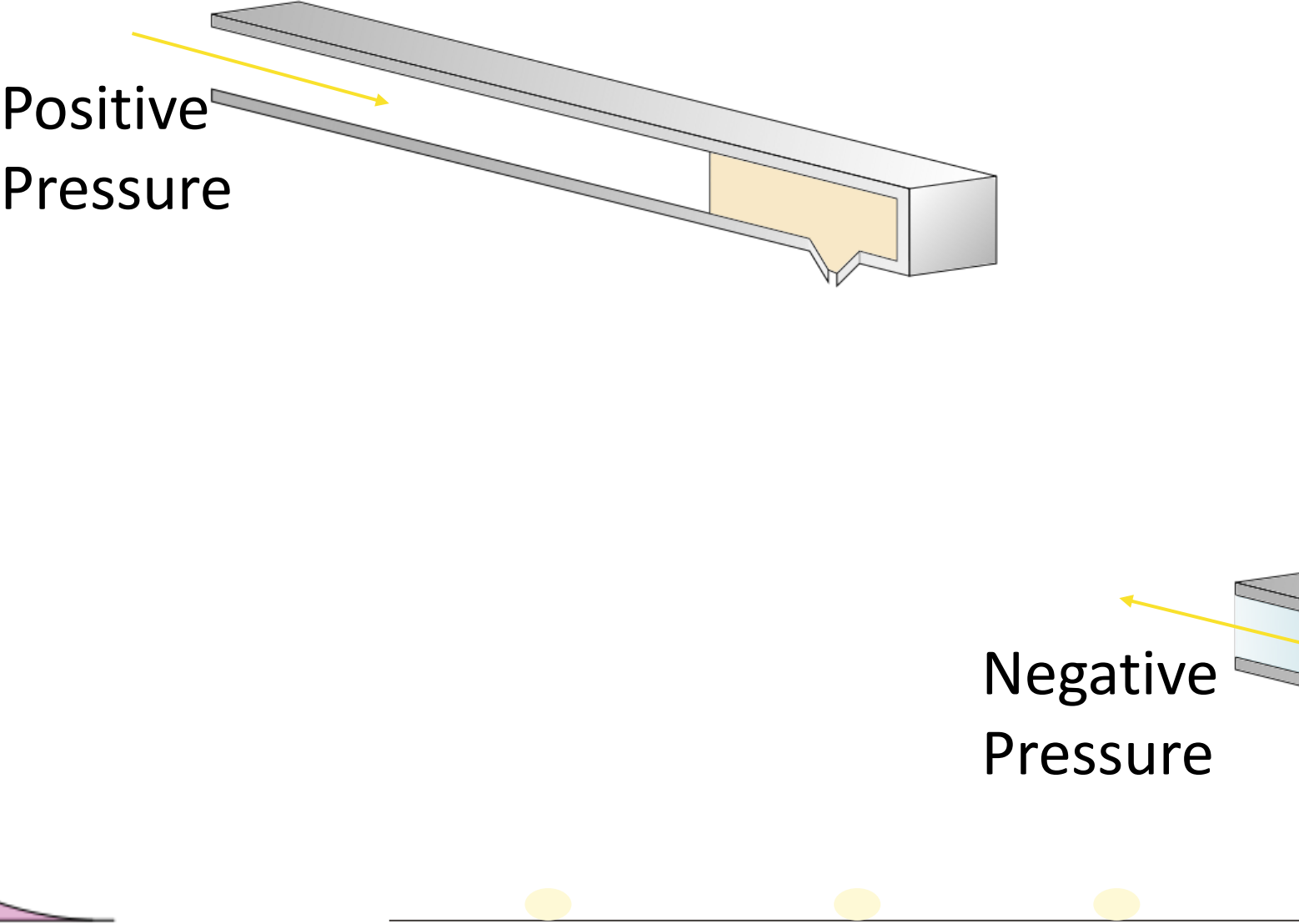
CHEMNA

# Advances in AFM – the Fluid Force Microscope (FluidFM)

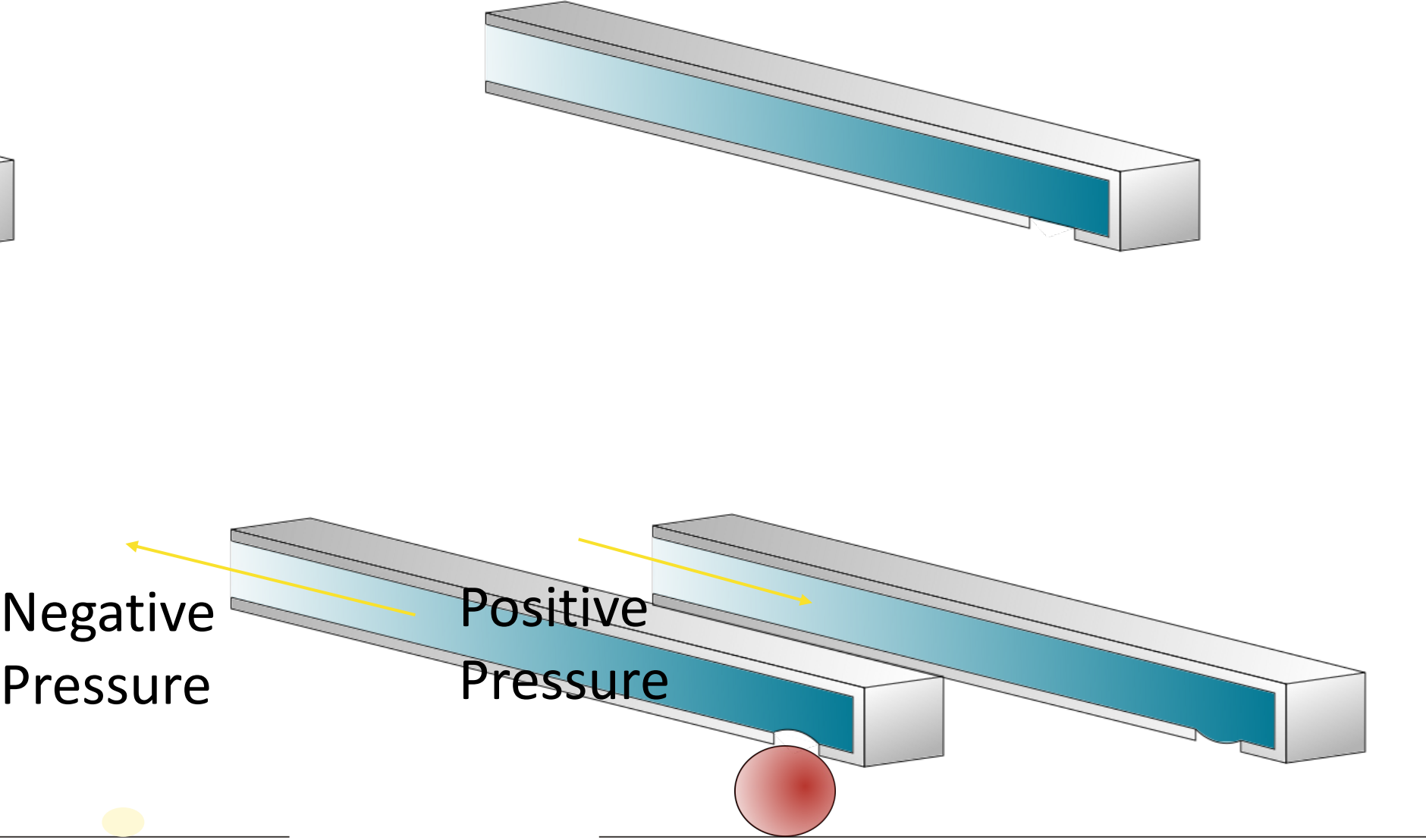
### Injection and Sampling



### Dispensing and Nanoprinting

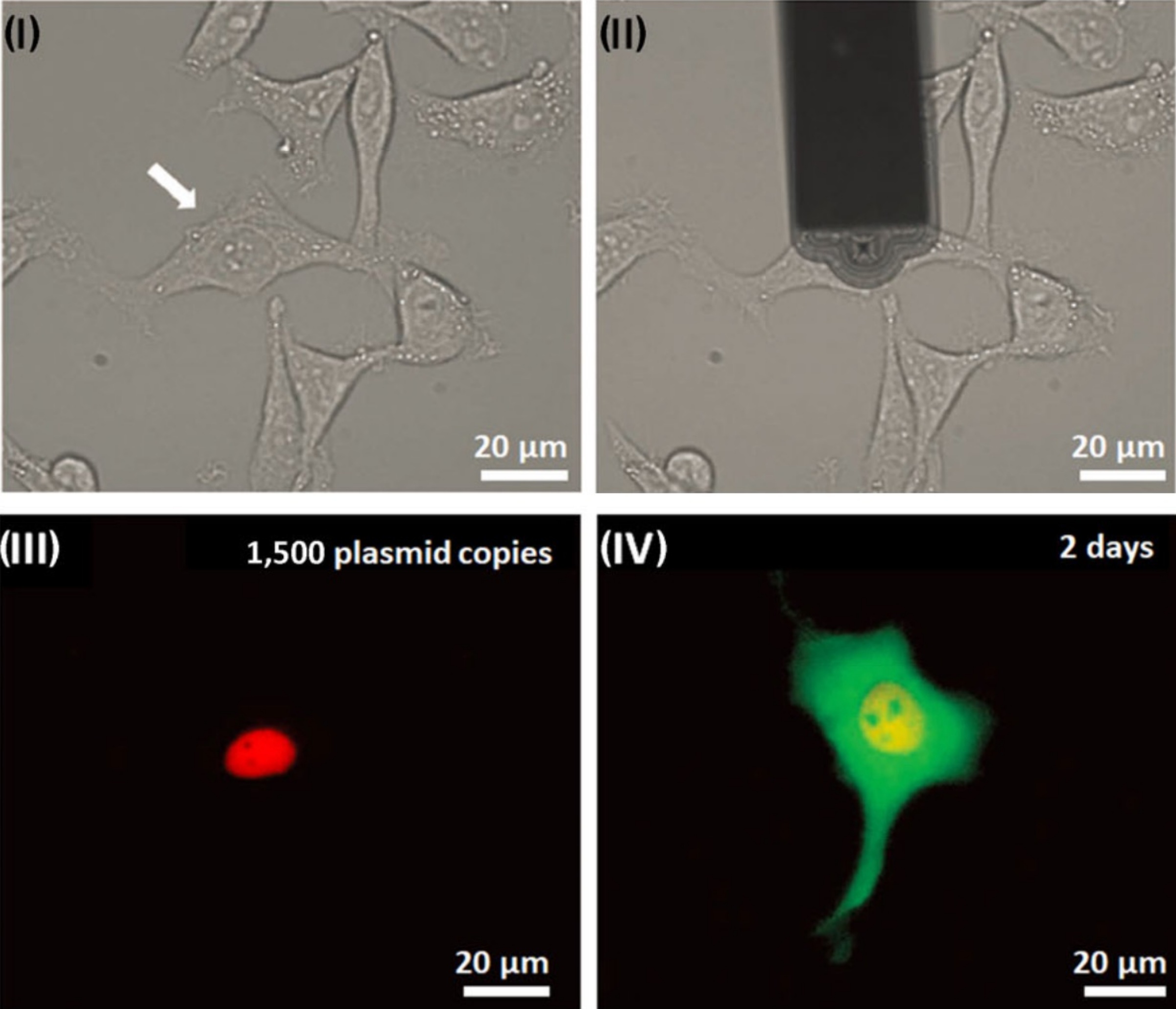


### Pick and Place

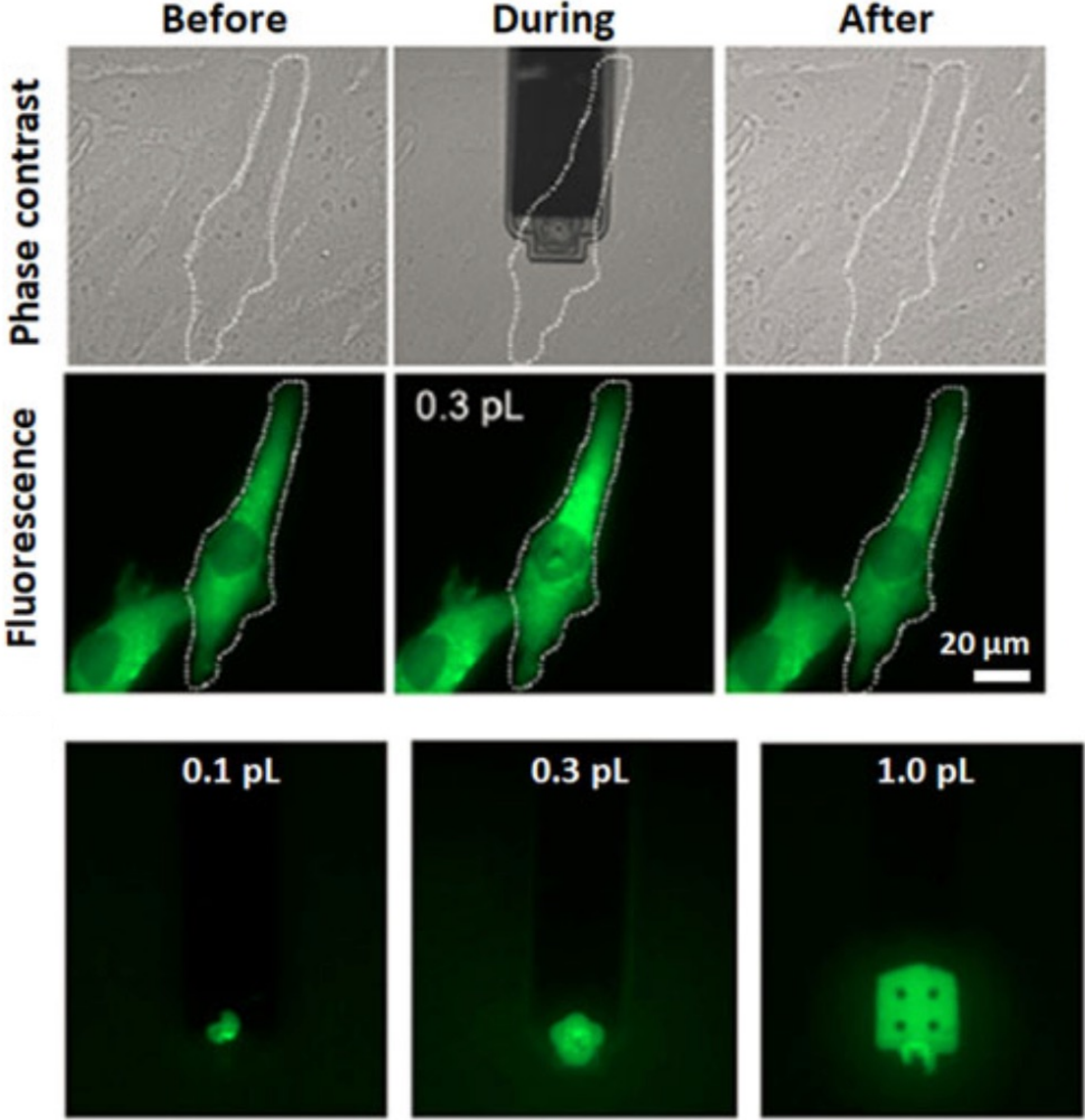


# Applications of Using FluidFM and Interfacing with Cells

Delivering plasmid DNA to cell nucleus



Extract from nucleus (82% viability for 4.0 pL)



# Key Takeaways

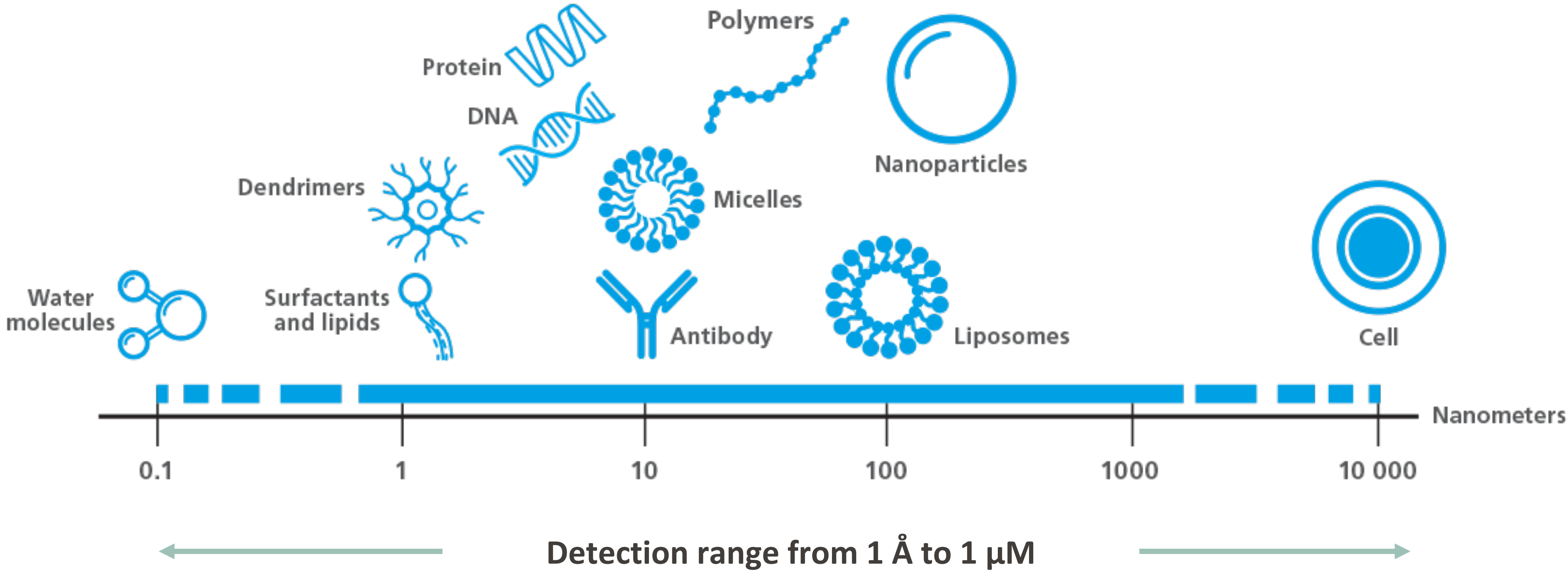
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- Comparisons between AFM and STM – pros and cons
- How AFM can go from surface imaging to mechanical properties
  - Contact vs. non-contact mode AFM
  - How to measure forces at surfaces using AFM
- Fluid-force microscopy (FluidFM) to interact with biology

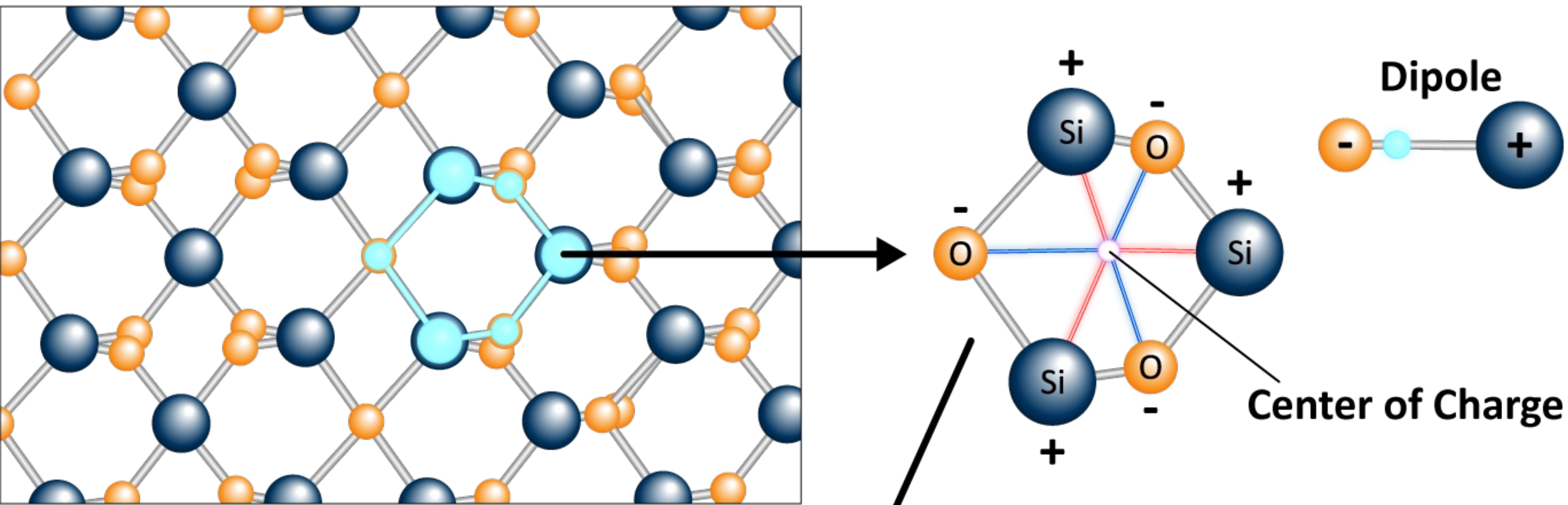
# Quartz-Crystal Microbalance (QCM) – Monitoring Surface Dynamics



# Quartz-Crystal Microbalance (QCM) – Monitoring Surface Dynamics

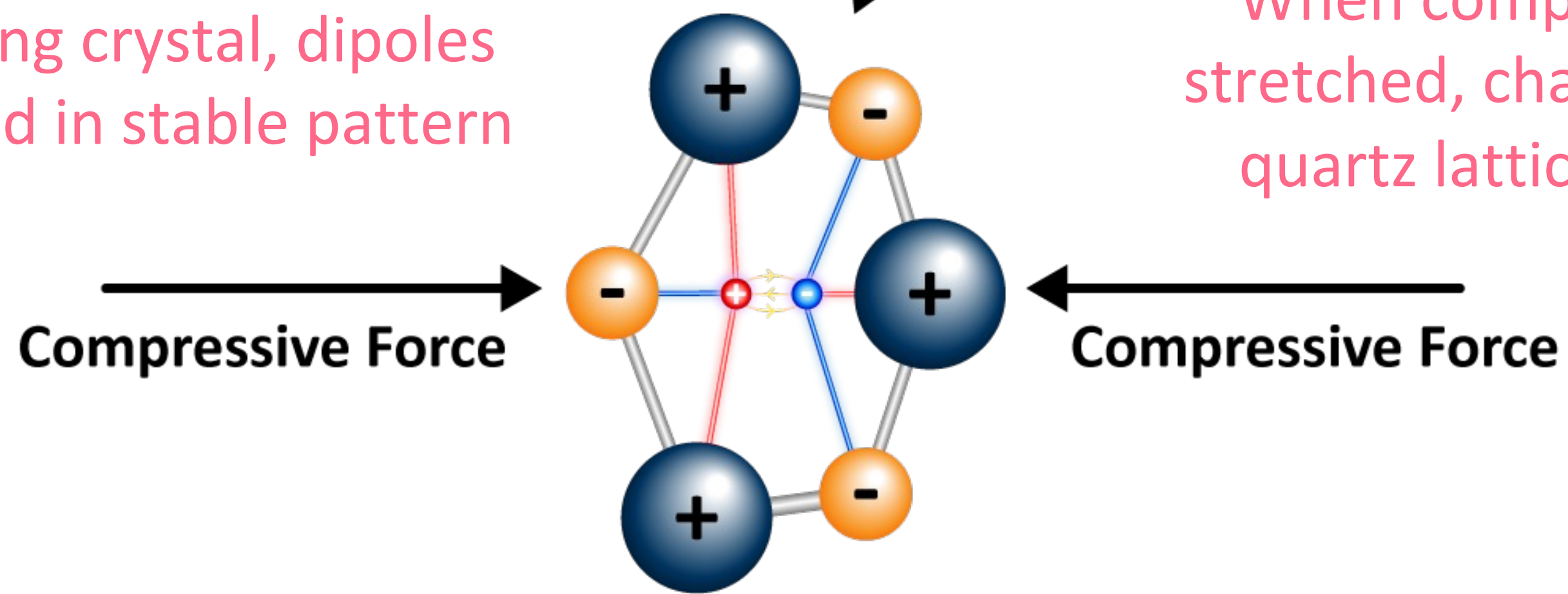


# Quartz as a Piezoelectric Material



In resting crystal, dipoles arranged in stable pattern

When compressed or stretched, charges within quartz lattice shift →



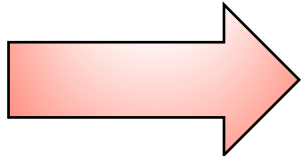
- Abundant in nature
- Easy to grow and process
- Thermodynamically stable

# Resonant Frequency of Quartz and Oscillation Amplitude

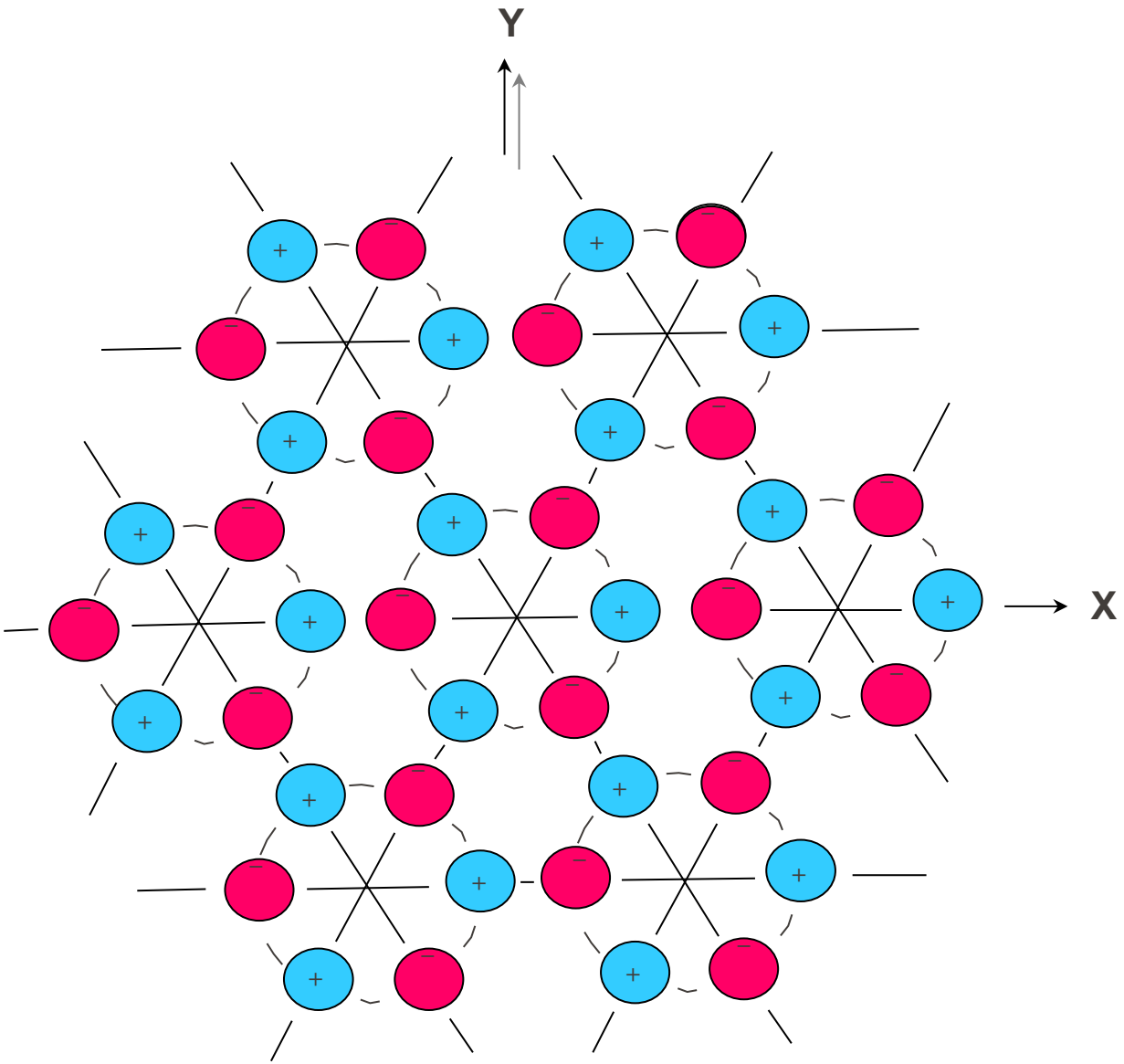
**Resonant frequency:** frequency at which quartz crystal vibrates most efficiently when energy is applied.

At this frequency, layers of atoms within the crystal lattice slide smoothly and consistently in shear motion.

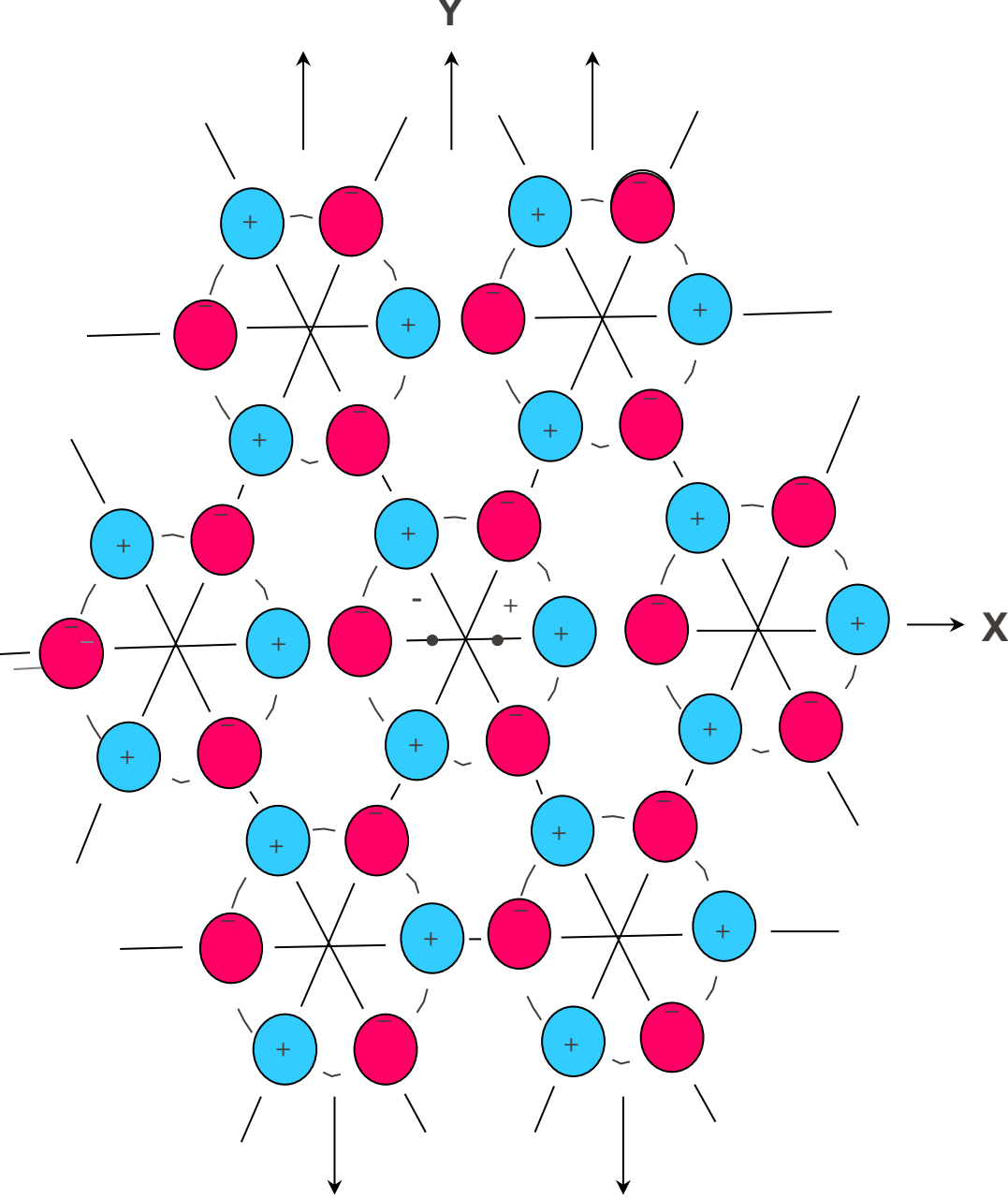
Quartz oscillates with maximum efficiency



Achieve greatest amplitude while minimizing energy loss

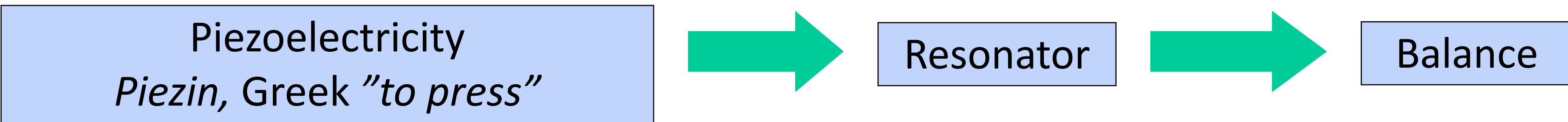


Undeformed lattice



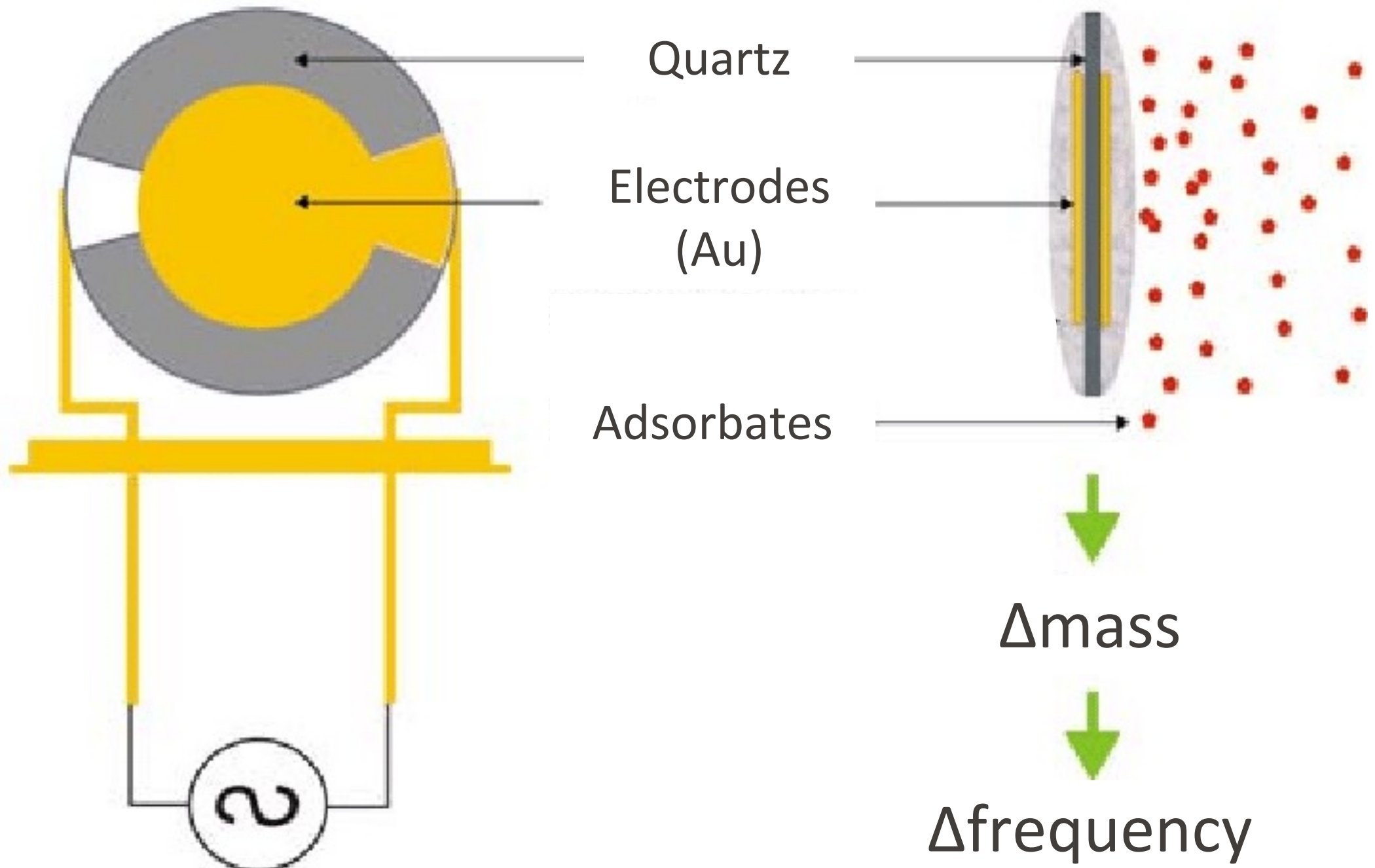
Strained lattice

# From Quartz to QCM-D

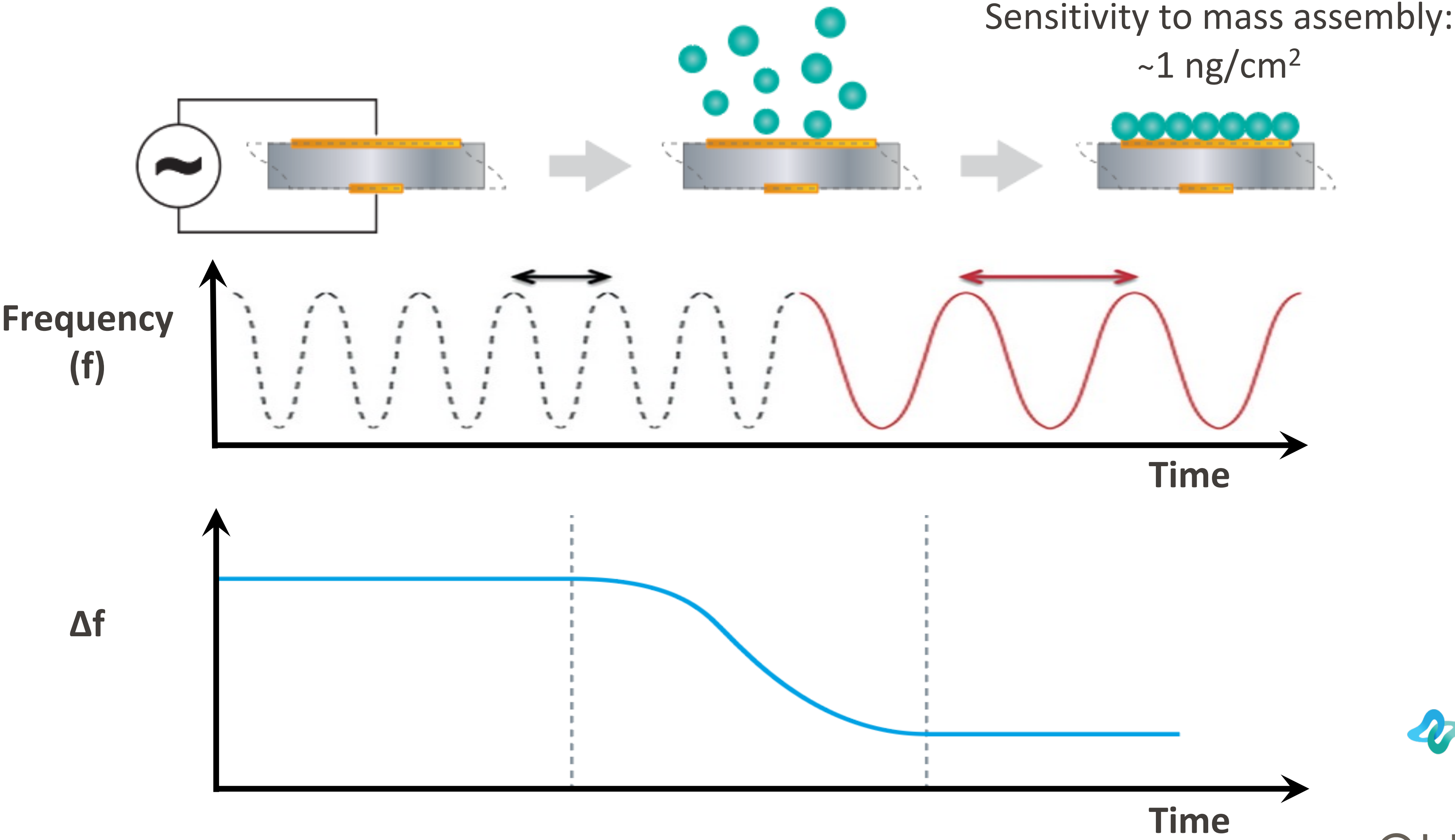


Quartz crystal disk sandwiched between two electrodes

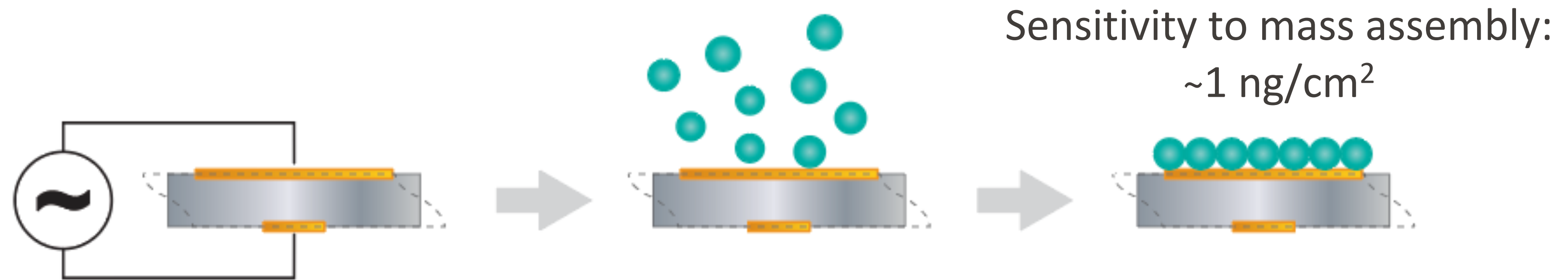
Quartz piezoelectric – applied electric field (voltage) leads to mechanical deformation



# Mass Assembly Monitored Through Change in Frequency



# Sauerbrey Equation



Ability of the QCM to measure mass changes based on discovery of the relation between the resonance frequency and mass by Günter Sauerbrey (1959)

$$\Delta m = -C \cdot \frac{\Delta f}{n}$$

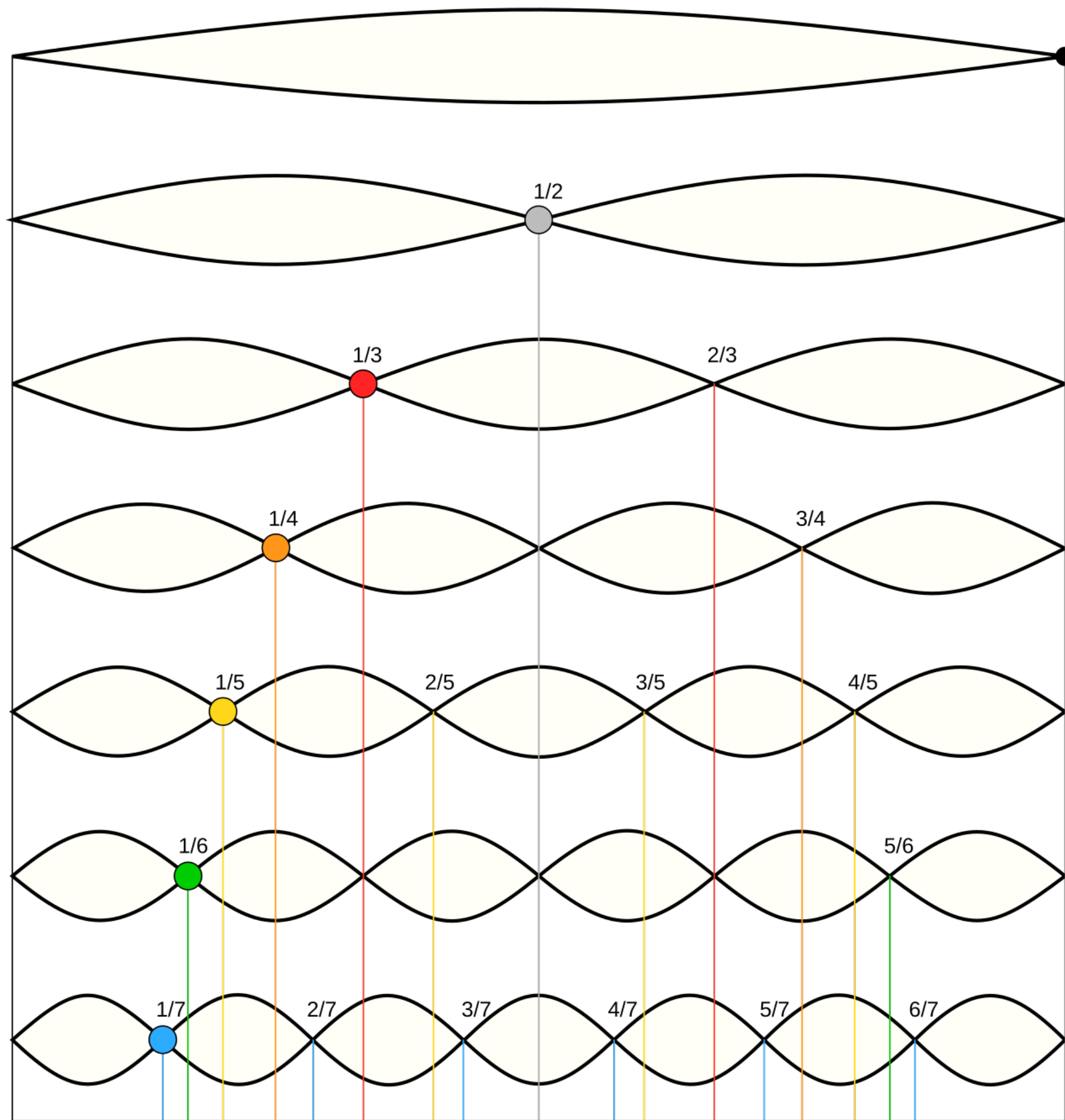
$\Delta m$ : mass change

$\Delta f$ : change in resonance frequency

C is the mass sensitivity constant = 17.7 ng/(cm<sup>2</sup> · Hz) for 5 MHz quartz crystal

n: harmonic number (1, 3, 5, ...)

# Harmonics in QCM-D



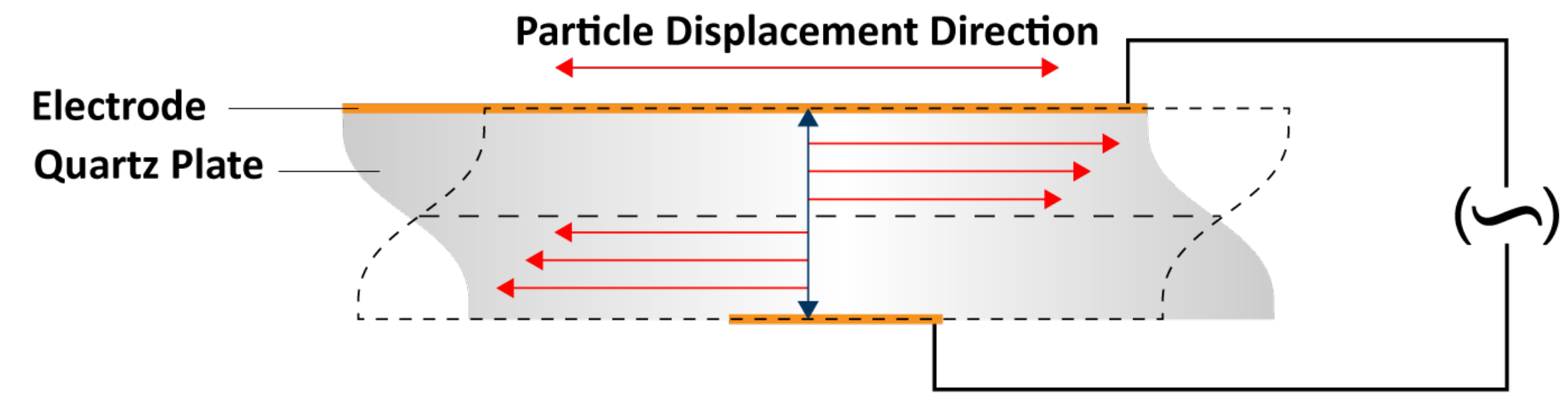
Source: Wikipedia

In physics, harmonics are the different standing-wave patterns a system can vibrate in, each with its own frequency

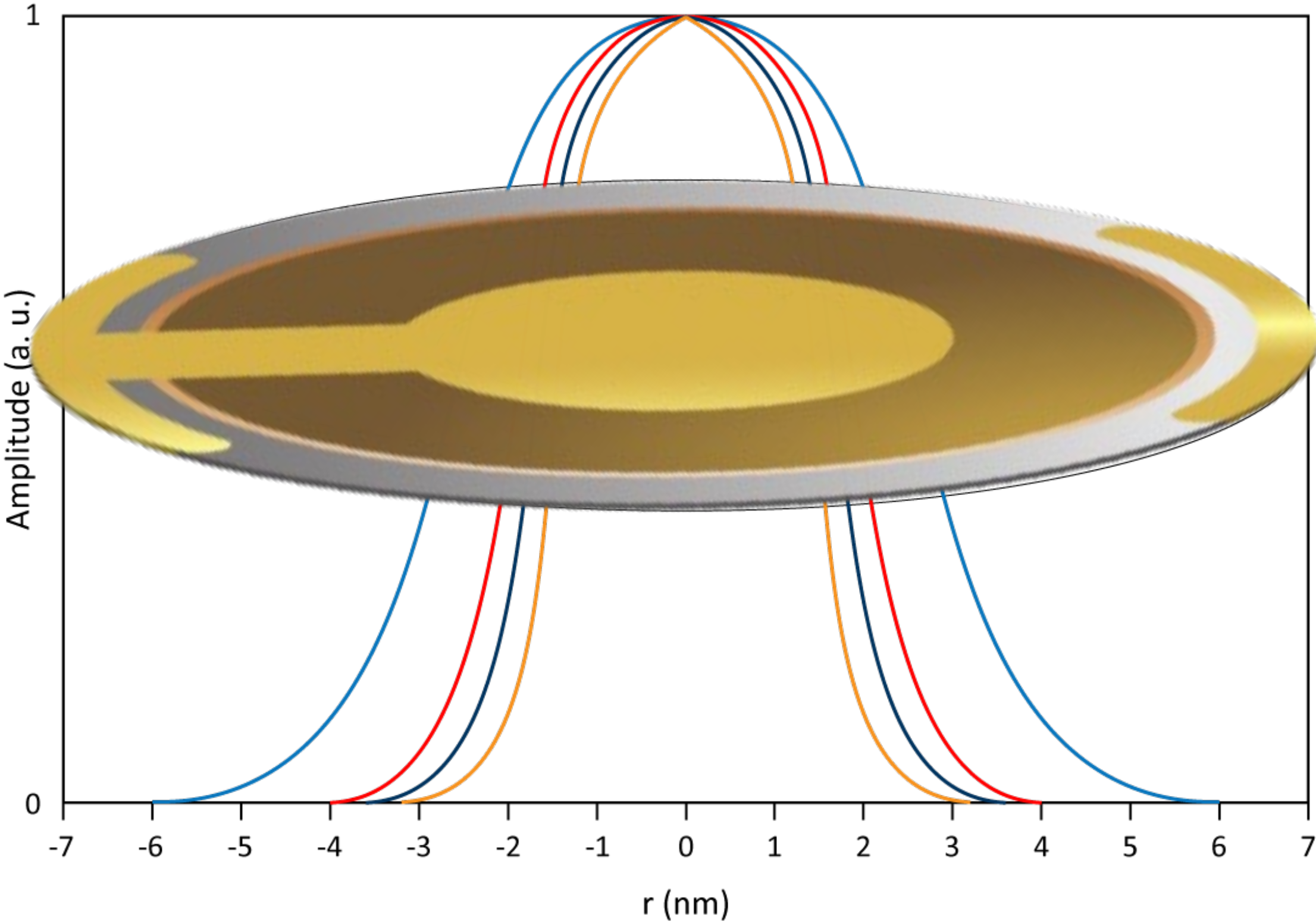
Fundamental mode – slowest vibration

Higher harmonics – faster vibrations

In QCM-D, we only use odd harmonics (1, 3, 5, 7...) because only those patterns make the top and bottom surfaces move in the same phase

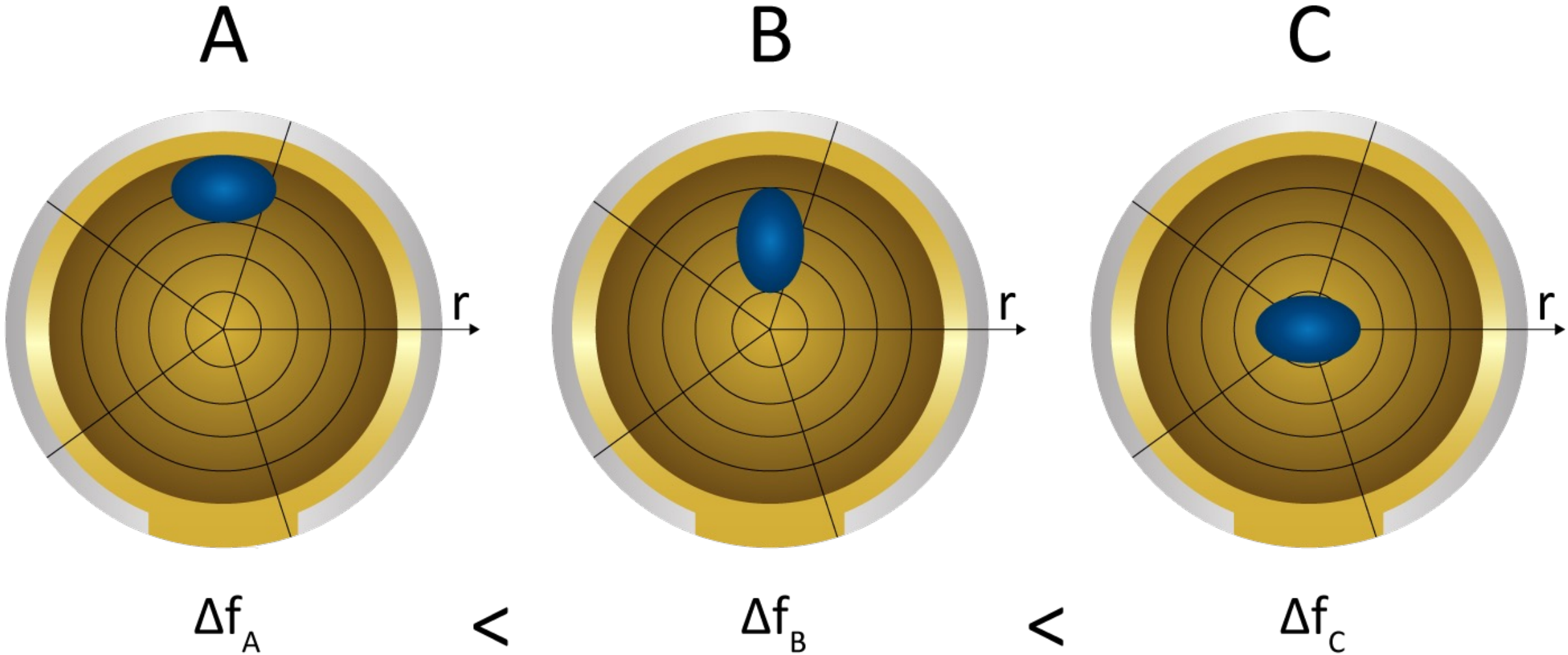


# Sensitivity Near the Center of the Sensor

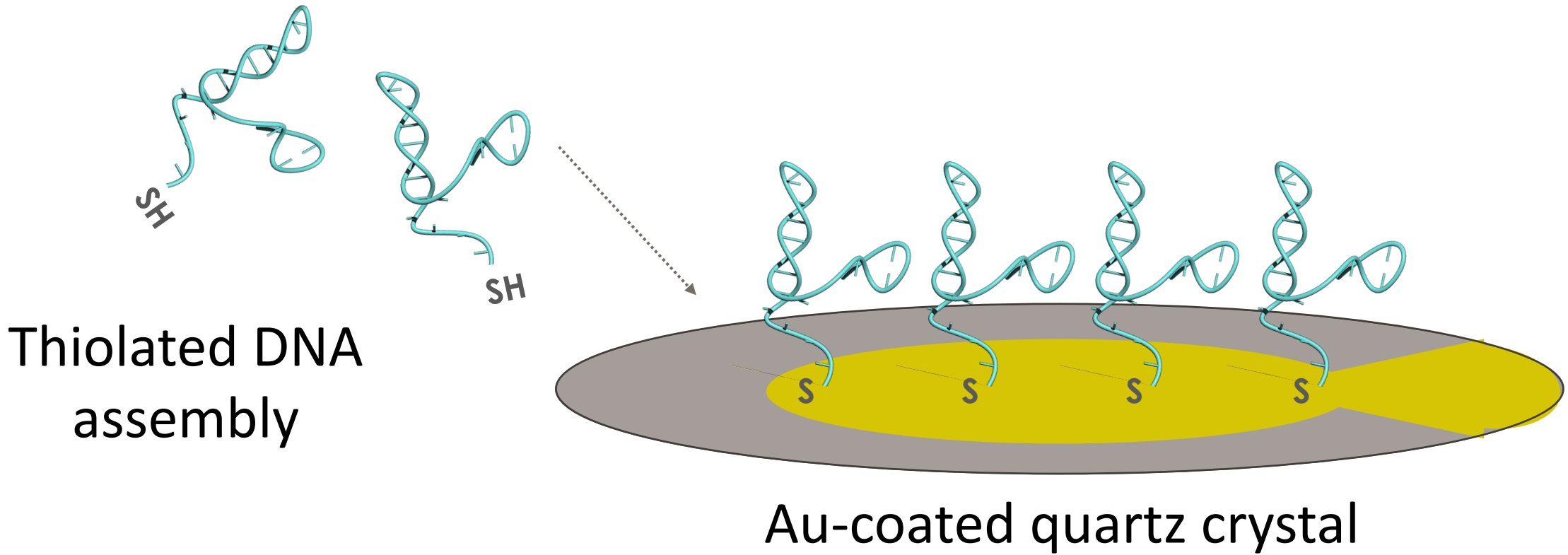


- n=1
- n=3
- n=5
- n=7

Frequency shift based on sample location



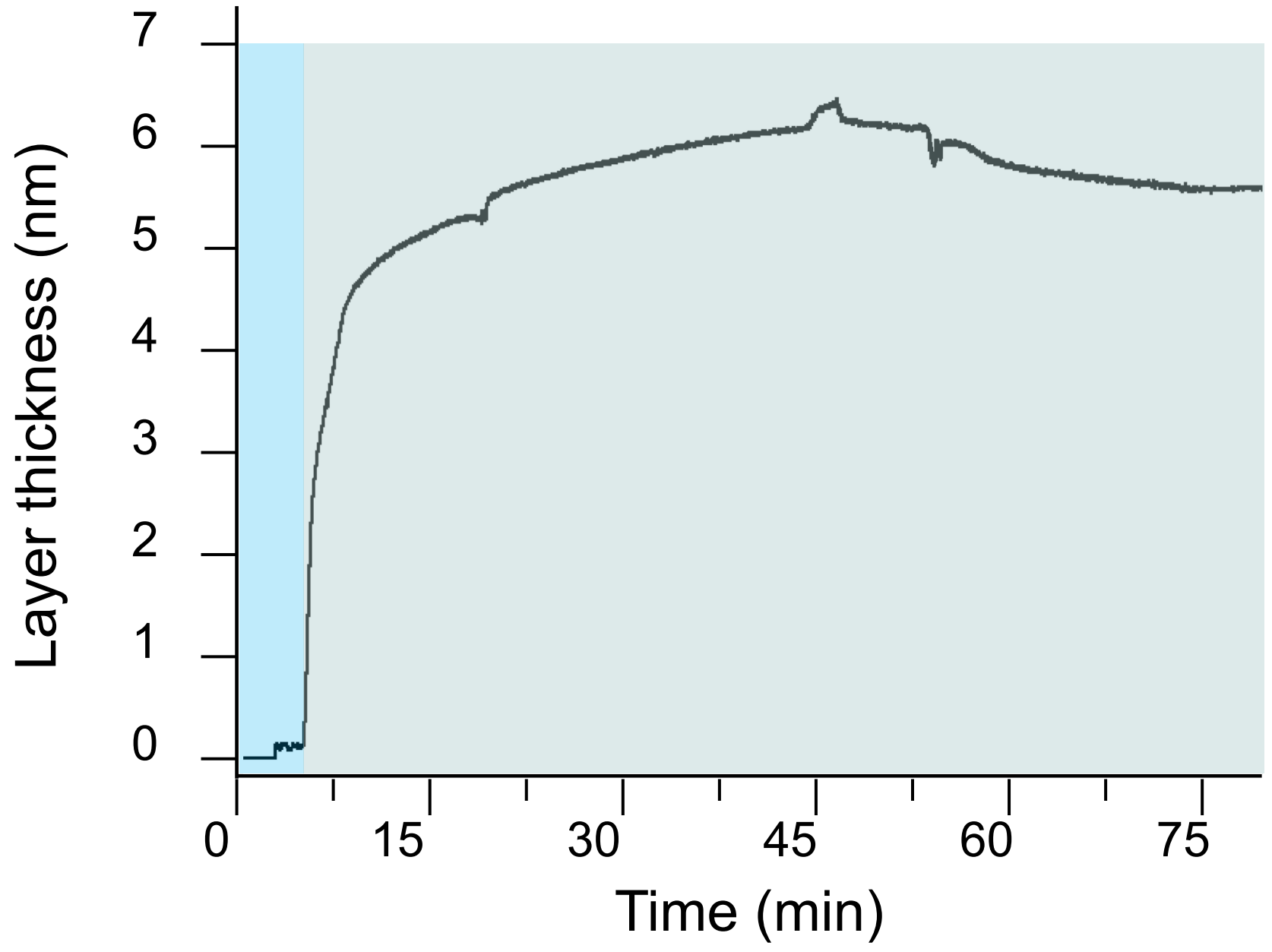
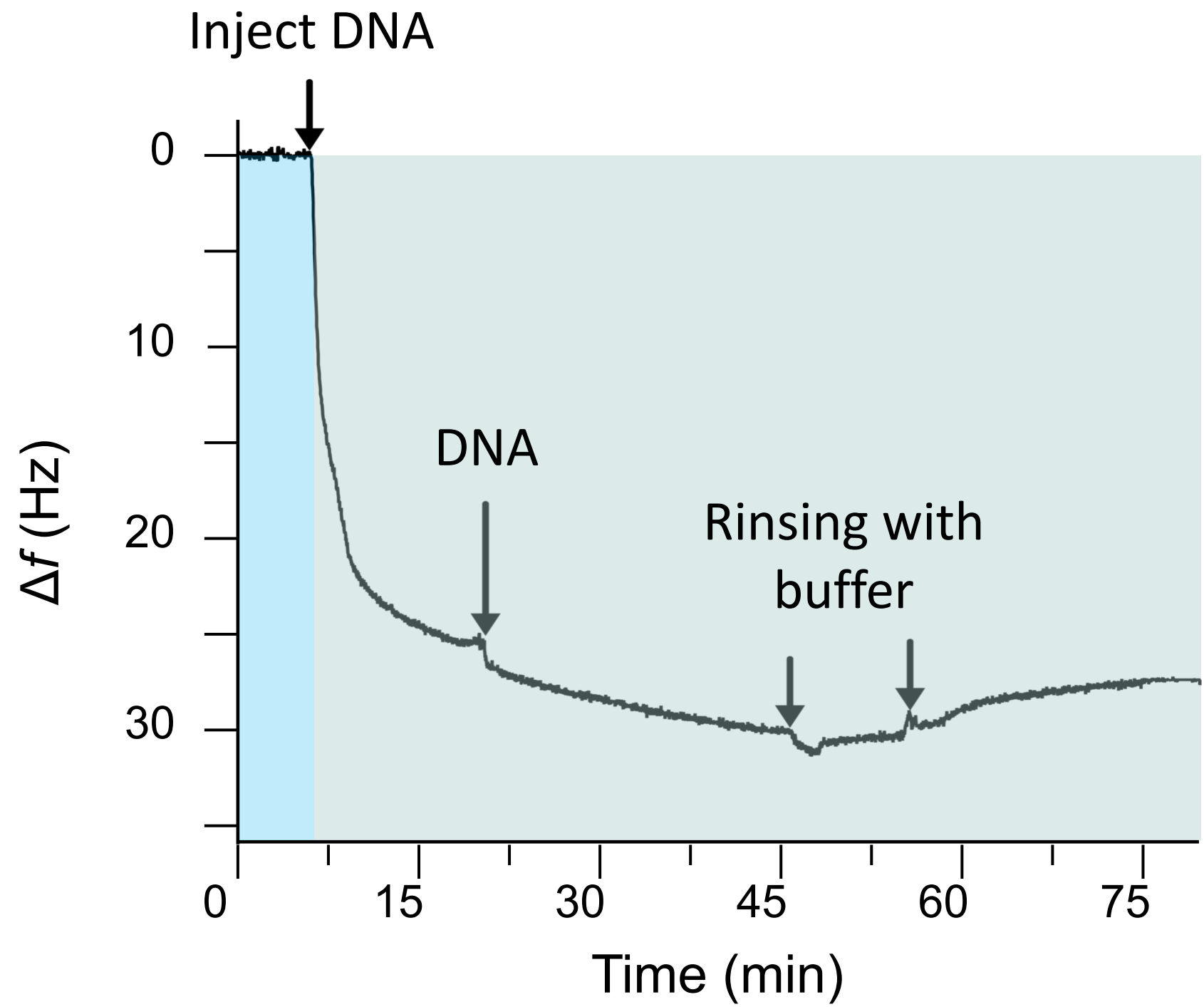
# Quartz-Crystal Microbalance to Monitor DNA Assembly on Surface



Sauerbrey equation

$$\Delta m = -\frac{\Delta f}{C}$$

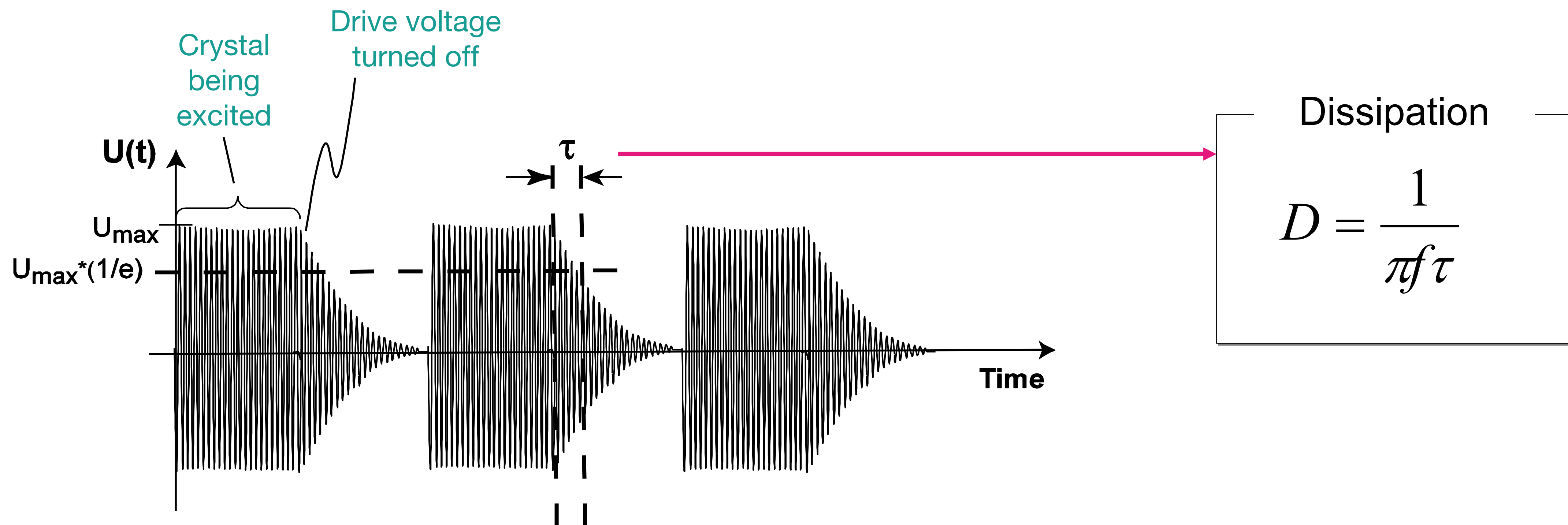
$$d = \frac{\Delta m}{\rho}$$



# Quartz-Crystal Microbalance With Dissipation Monitoring

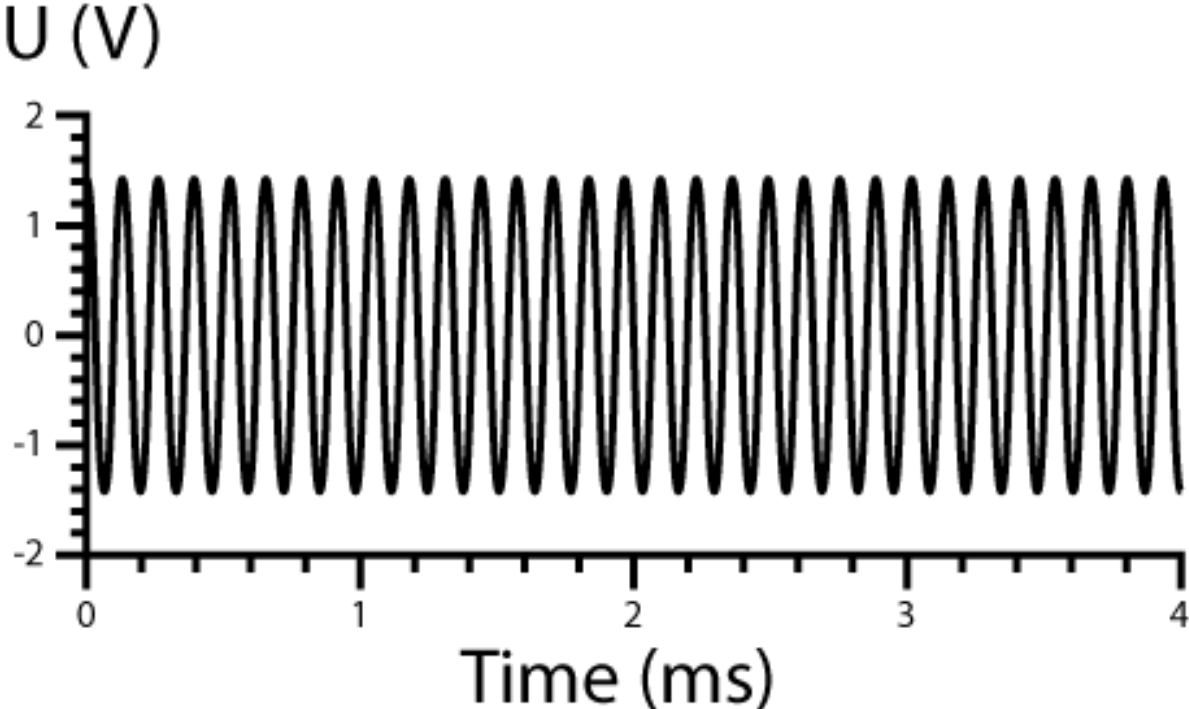
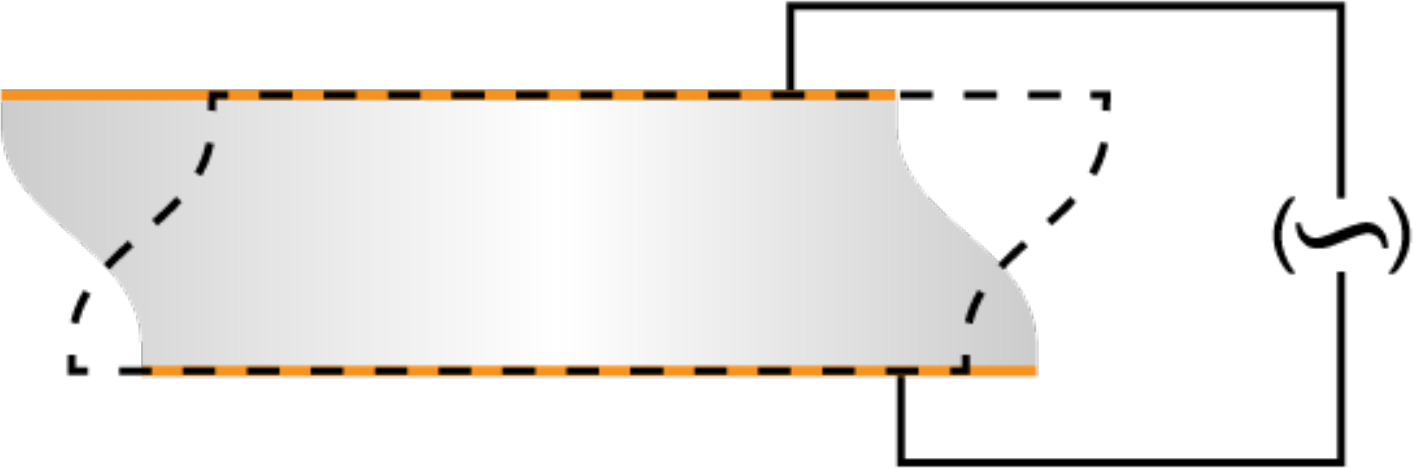
We can also extract information on the viscoelastic properties of soft, viscous layers

Dissipation data reveals characteristics of non-rigid layers that undergo internal rearrangements and energy loss

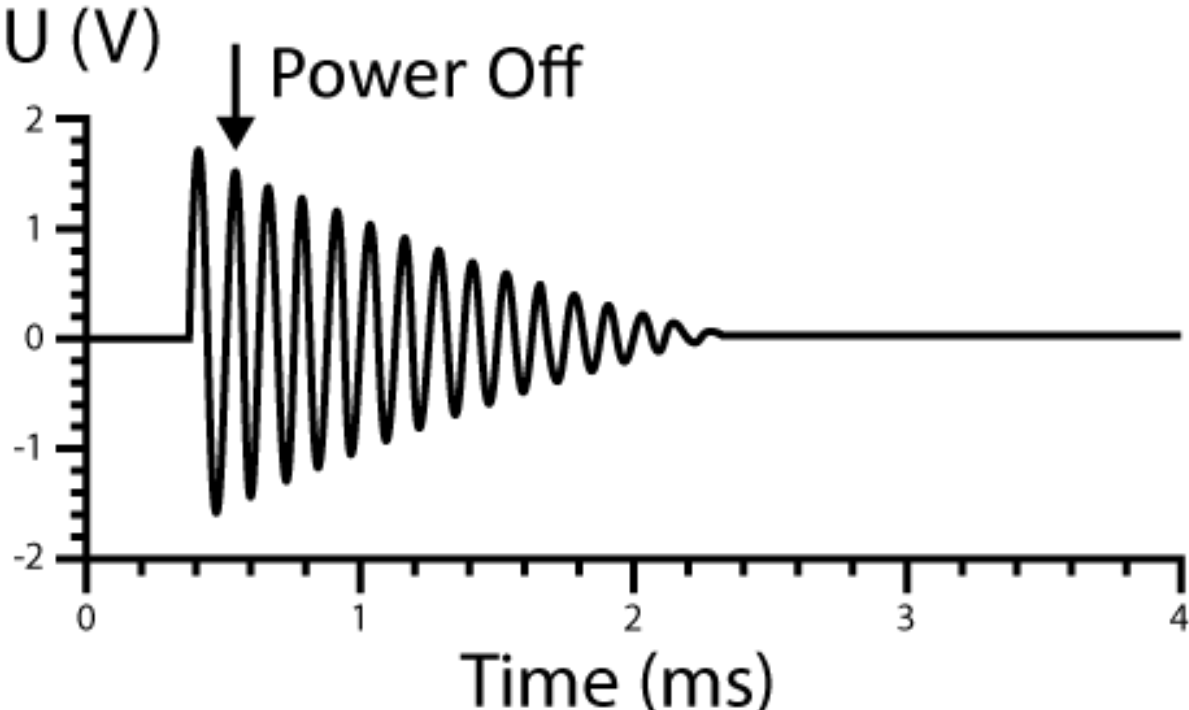
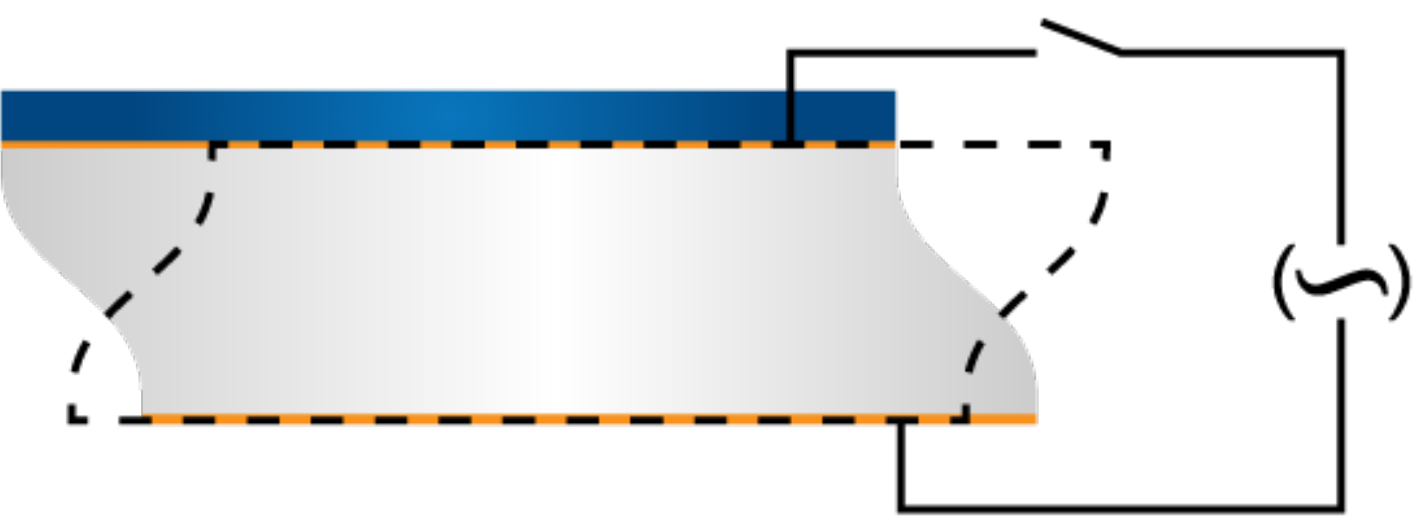


# Quartz-Crystal Microbalance With Dissipation Monitoring

**Bare Sensor**

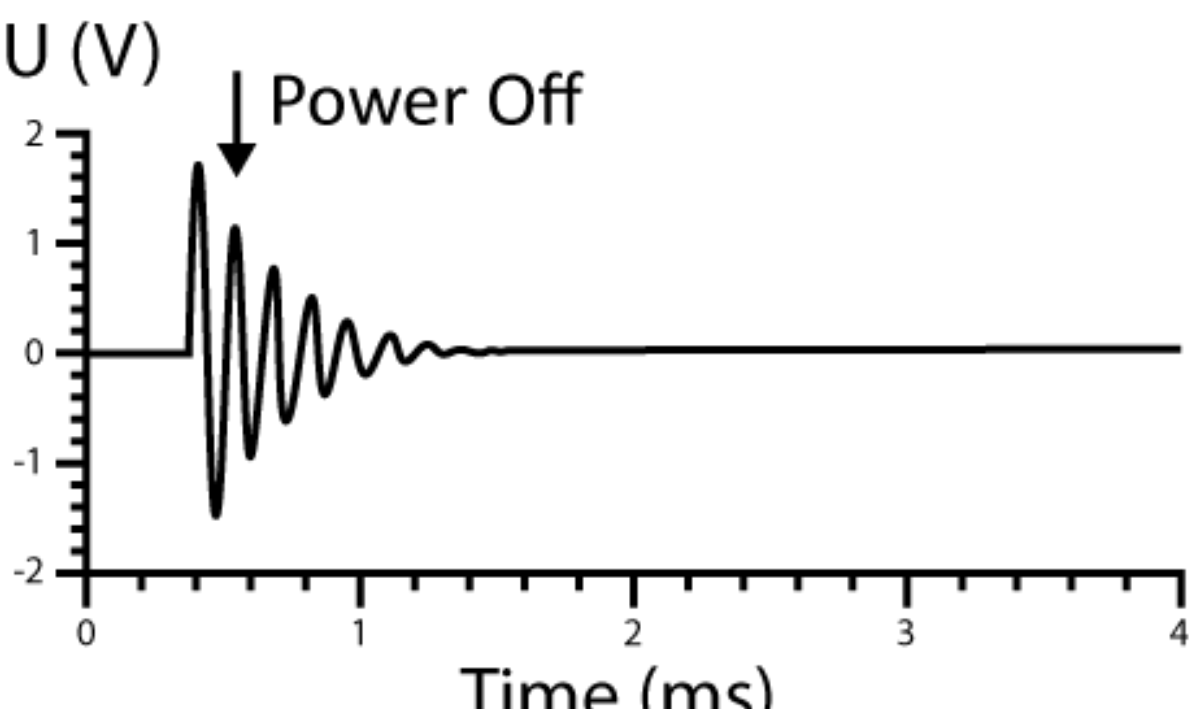
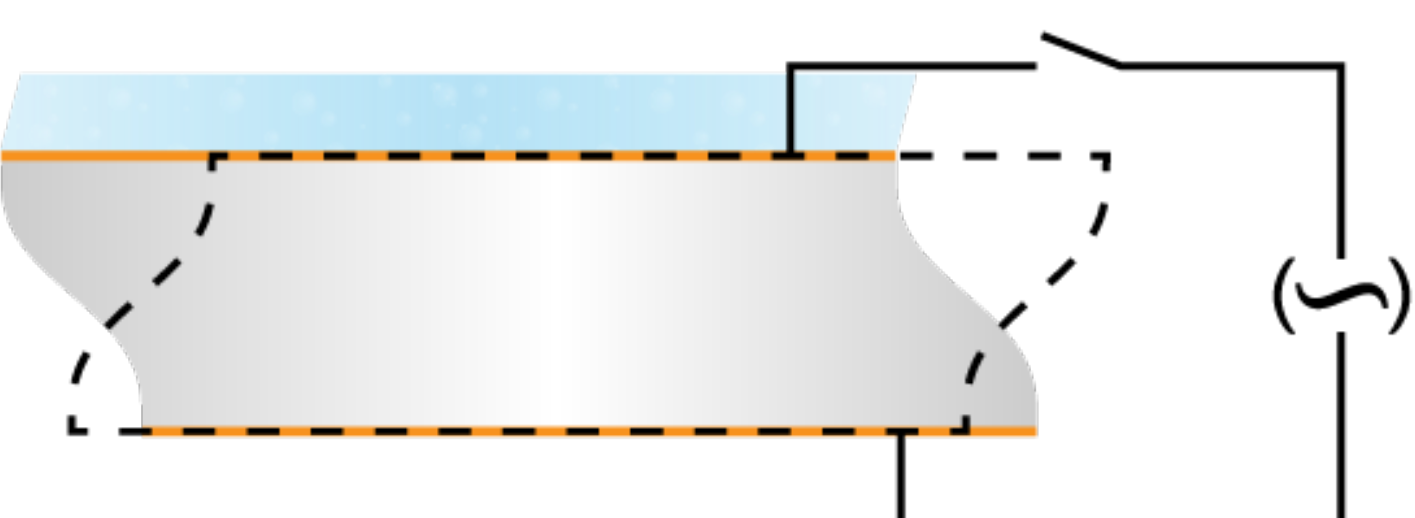


**Rigid Layer**



Rigid materials show slower decay due to stronger coupling with quartz

**Viscoelastic Layer**



Exponential decay of oscillation amplitude once voltage turned off

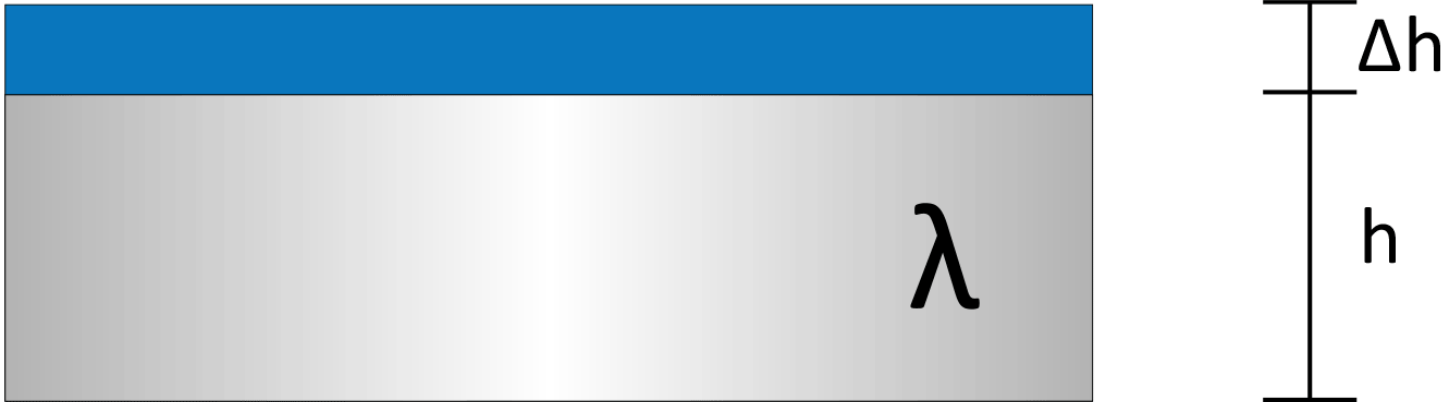
# Quartz-Crystal Microbalance With Dissipation Monitoring

Rigid films move in sync and conserves energy

Viscoelastic film deforms independently and dissipates energy

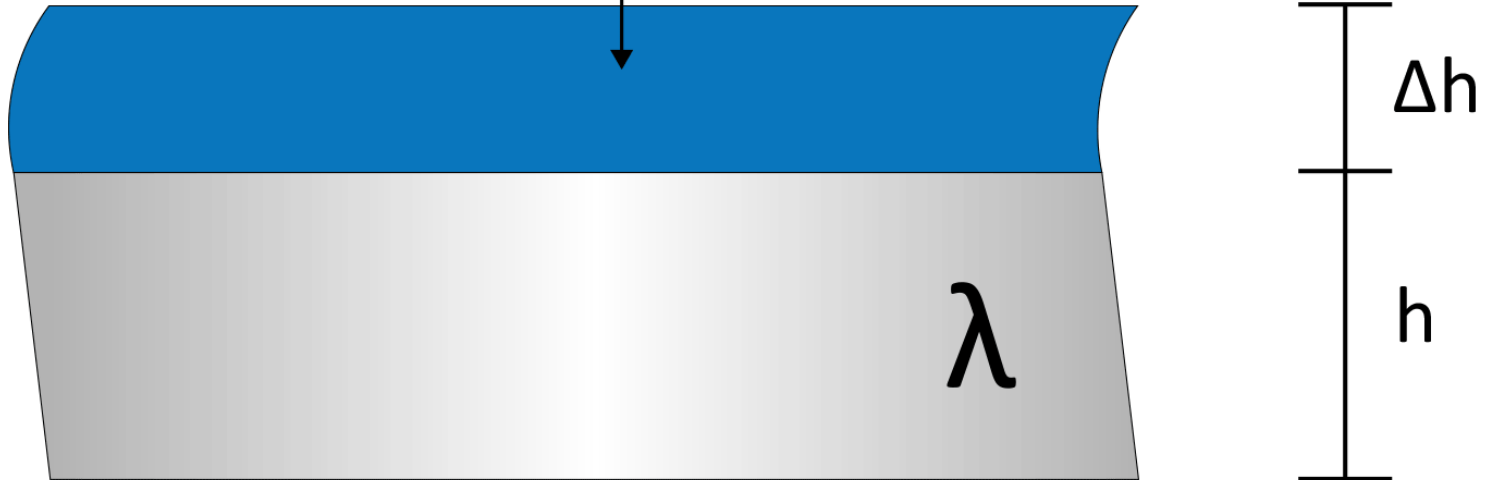
### Rigid Layer

Added Film



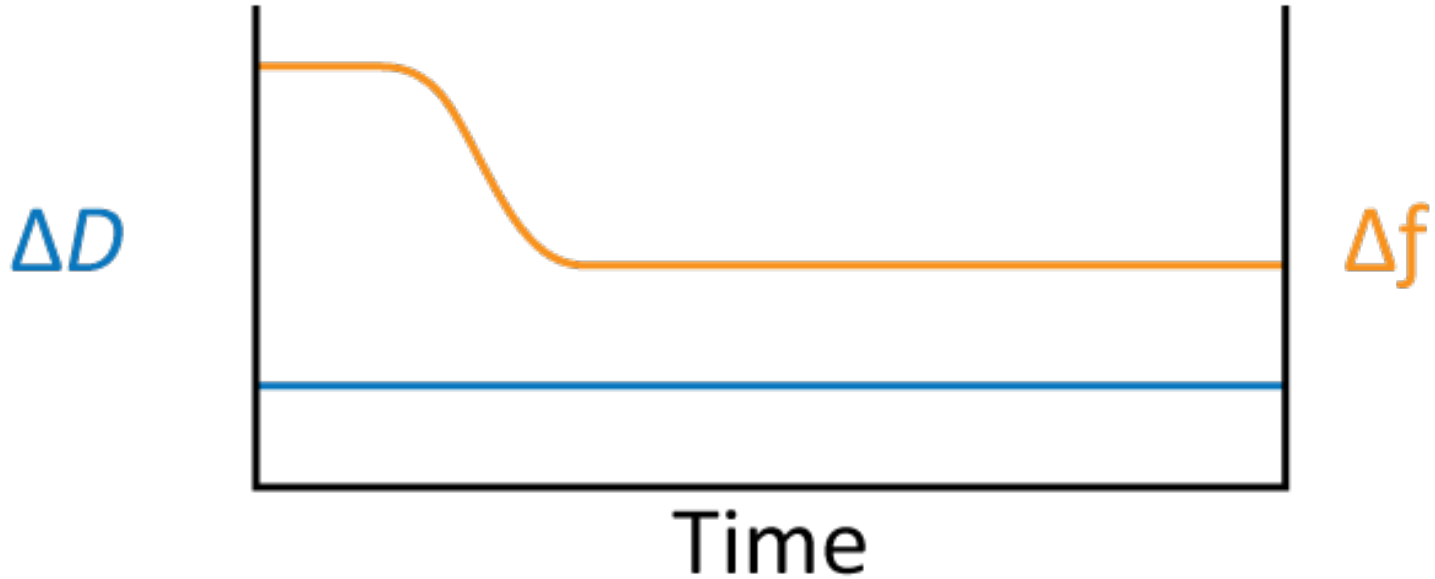
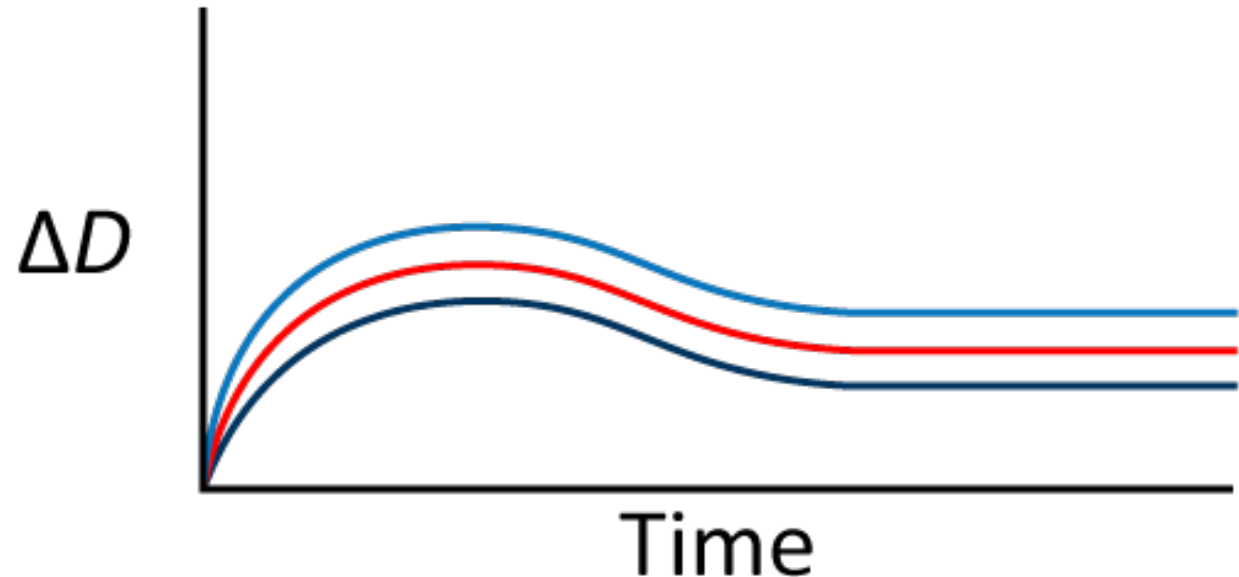
### Viscoelastic Layer

Added Film



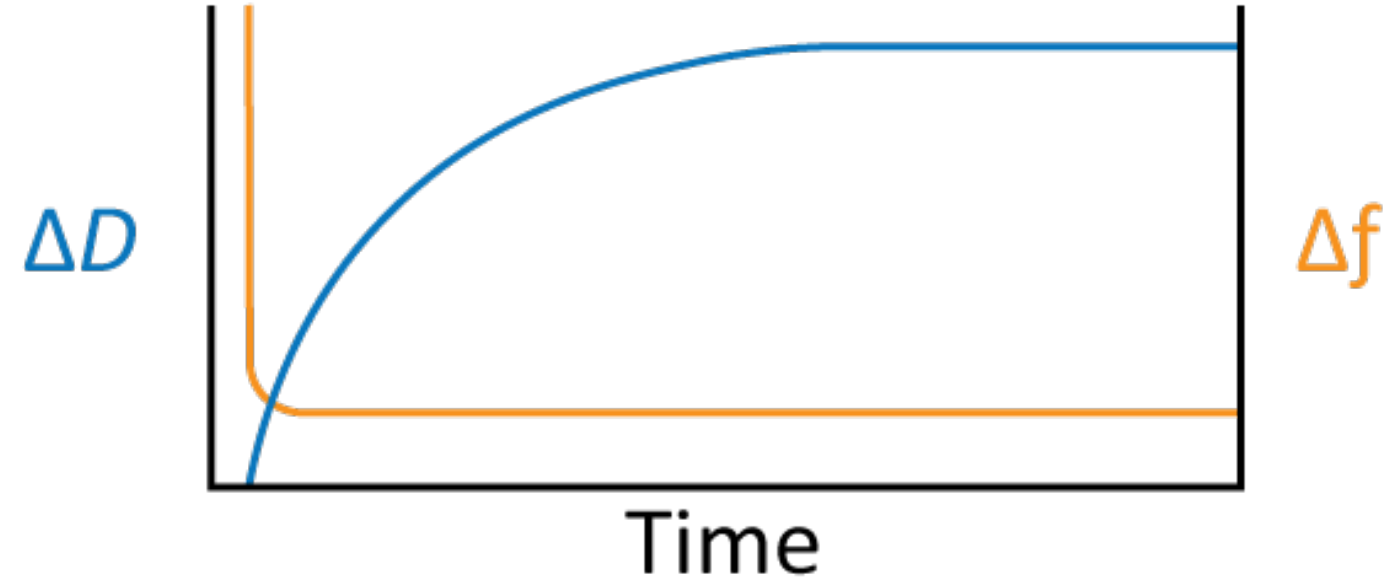
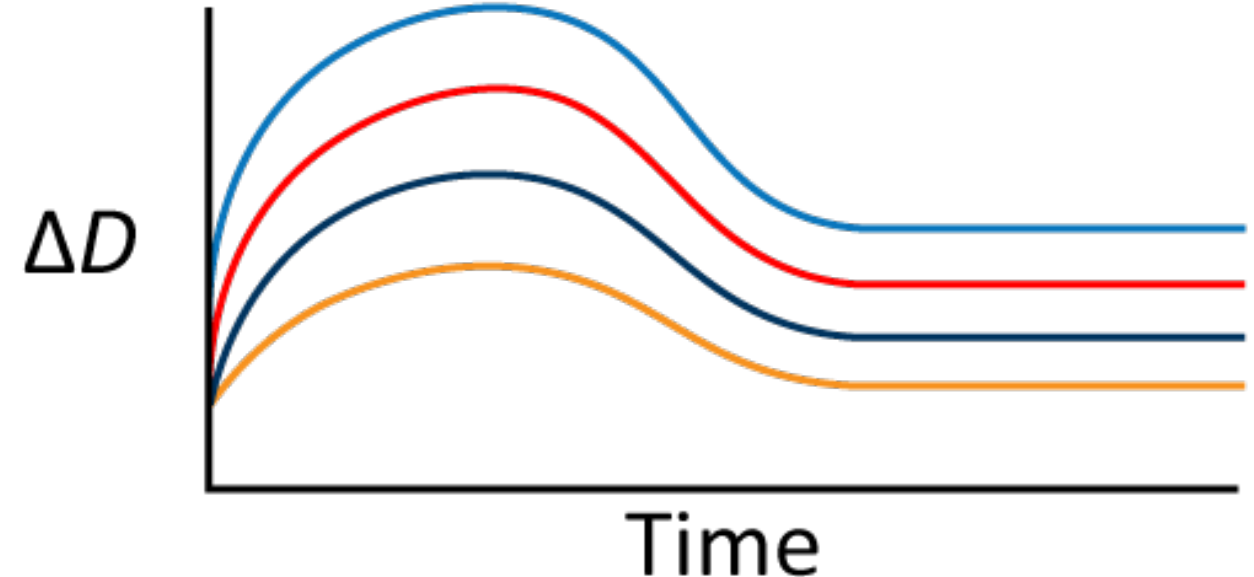
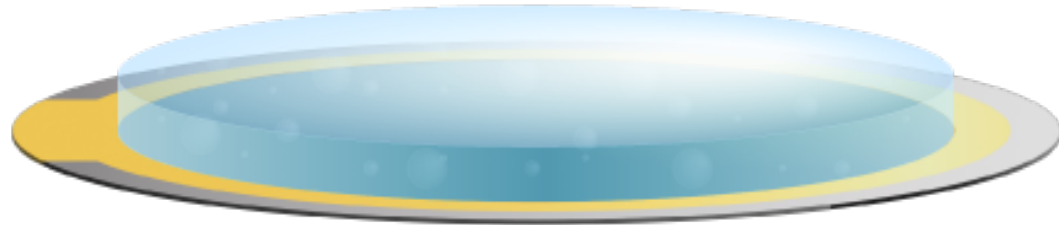
# Multi-Harmonic Data Unlocks Mechanical Properties Characterization

Rigid



Rigid layers show consistent ratios in frequency shifts with harmonic order

Viscoelastic



Viscoelastic films show increasing dissipation and nonlinear frequency behavior that varies with overtone



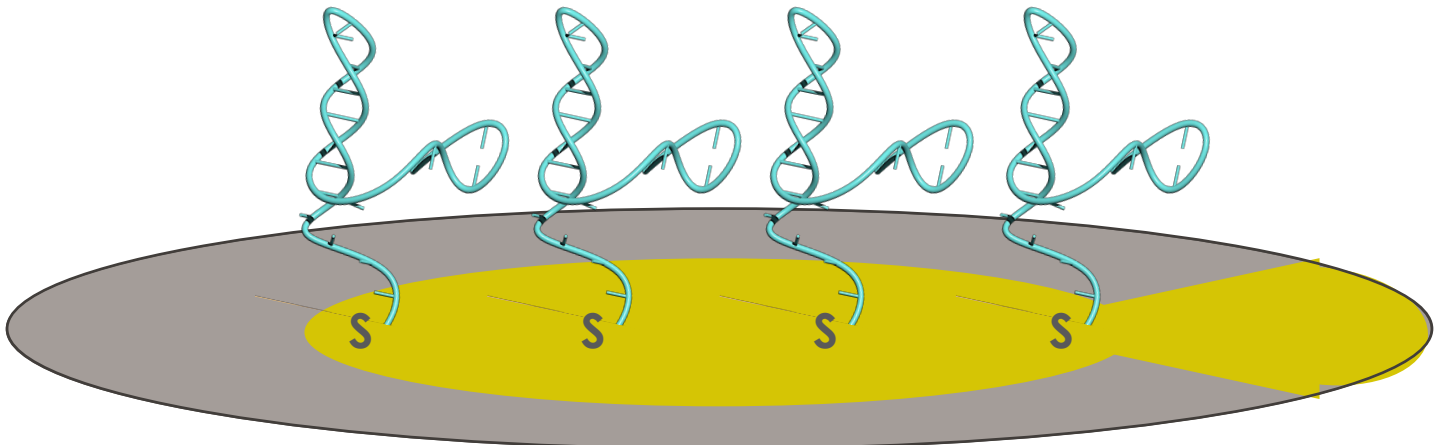
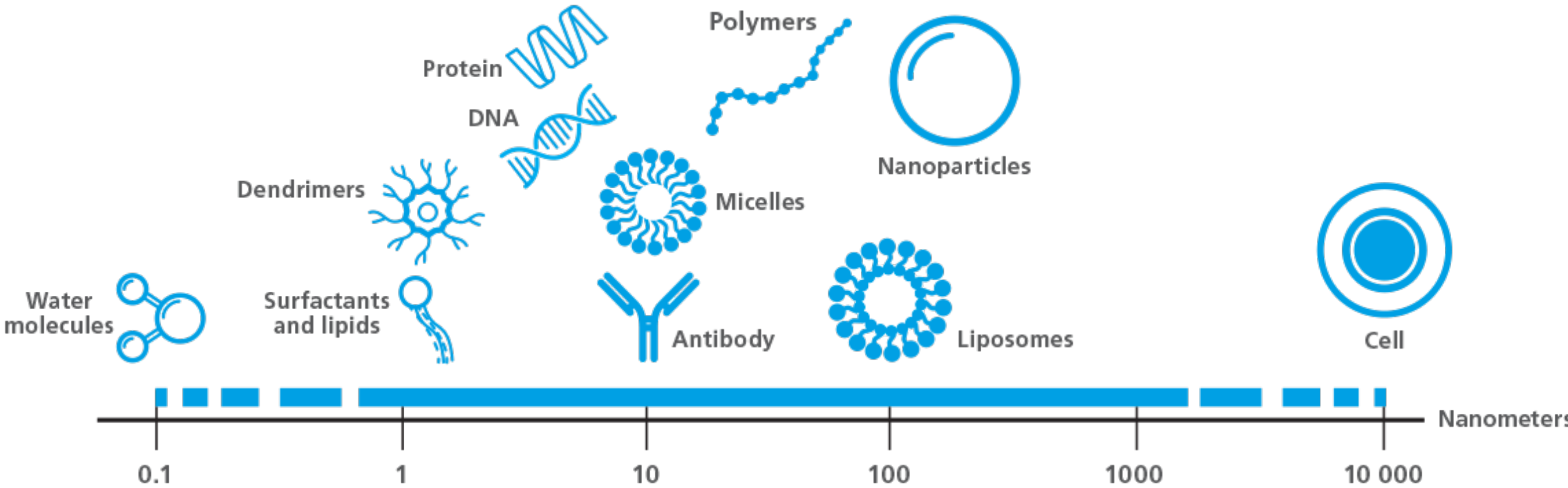
# Pros and Cons of QCM-D

QCM-D can monitor viscoelastic behavior

Real-time kinetics of molecular assembly and adsorption

Sensitive to soft layers (proteins, polymers, etc.)

QCM-D monitors “wet mass” – mass + coupled water molecules – cannot separate



No direct thickness or refractive index of material

# Key Takeaways

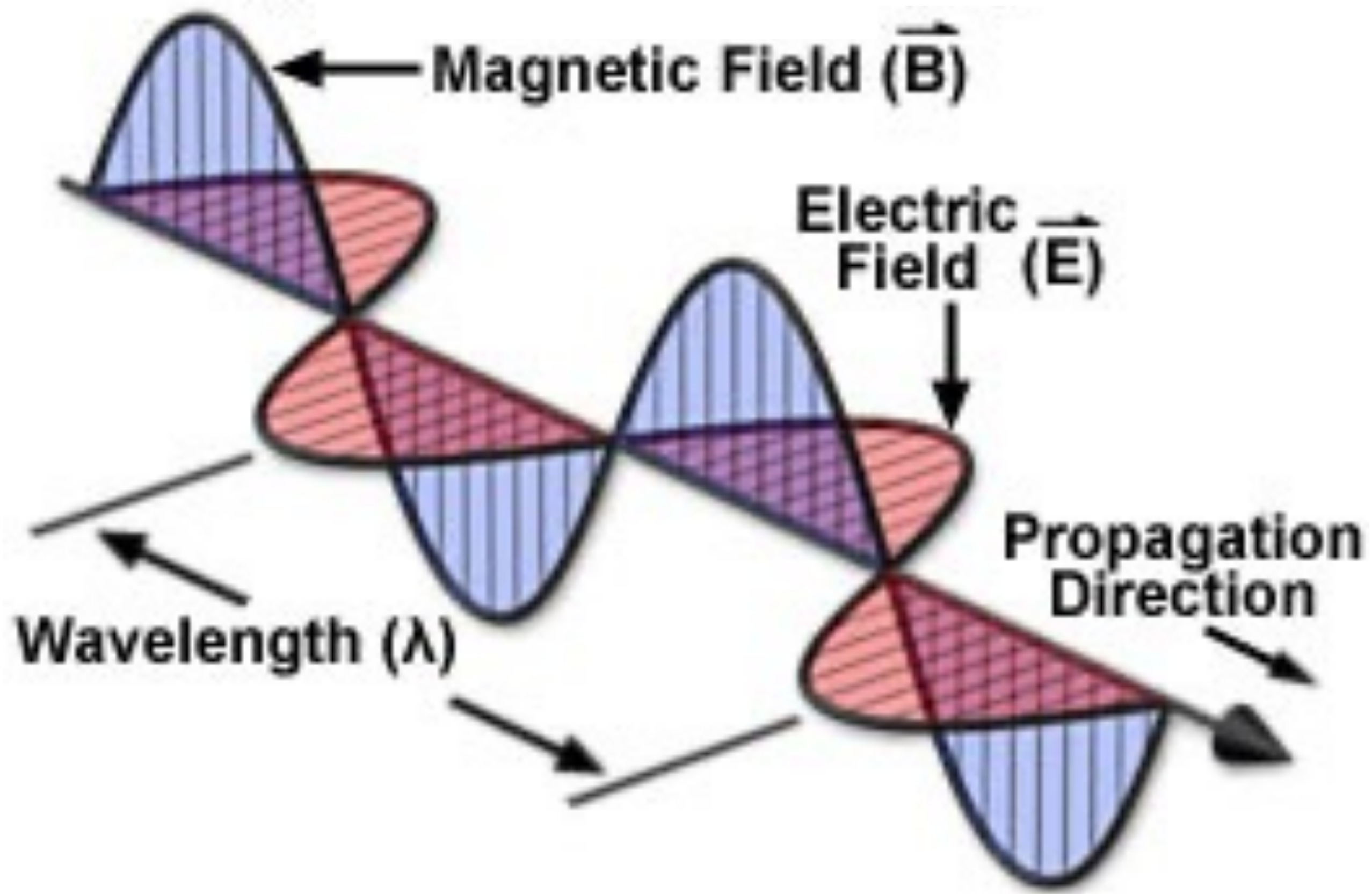
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- QCM-D is a versatile technique with detection range from 1 Å to 1 μM
- Piezoelectric quartz leads to change in frequency of oscillation = mass
  - Monitoring dissipation provides viscoelastic properties of layer
    - Characterizing rigid vs. viscoelastic films

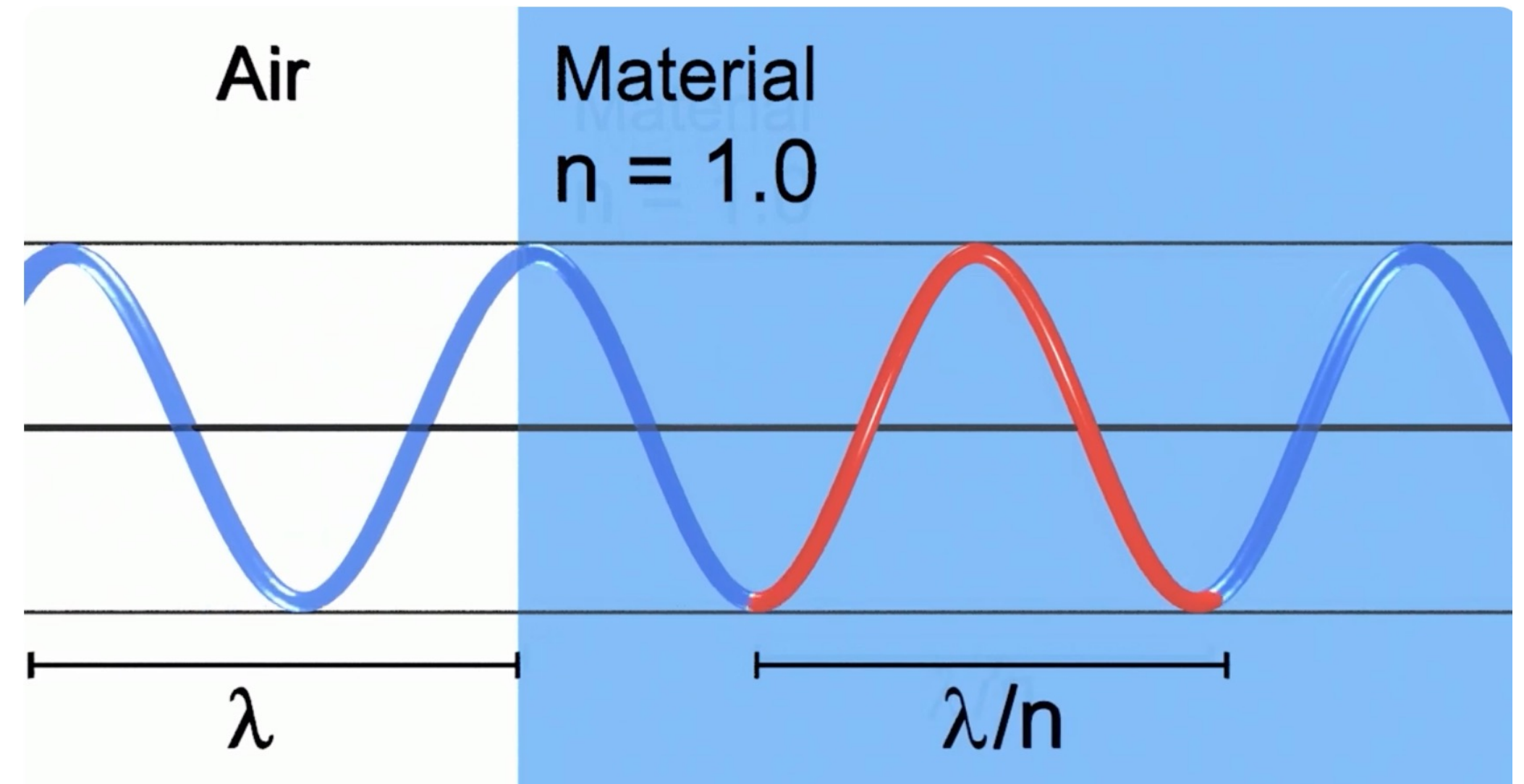
How can we characterize absolute film thickness and optical properties?

# Basic Principles of Light Propagation Through Materials

Light as an oscillating electromagnetic field



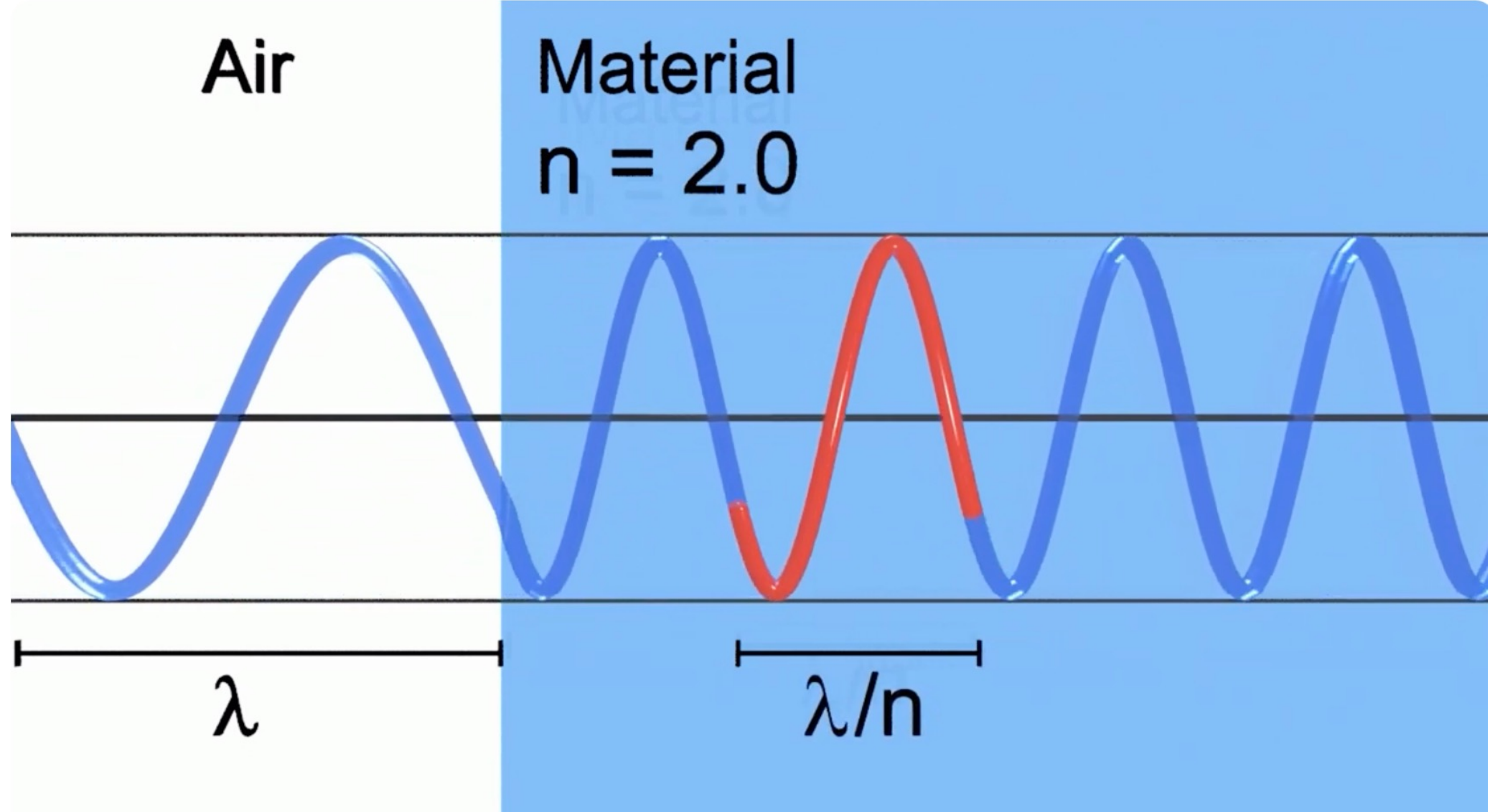
Continuous propagation through material when refractive index = 1



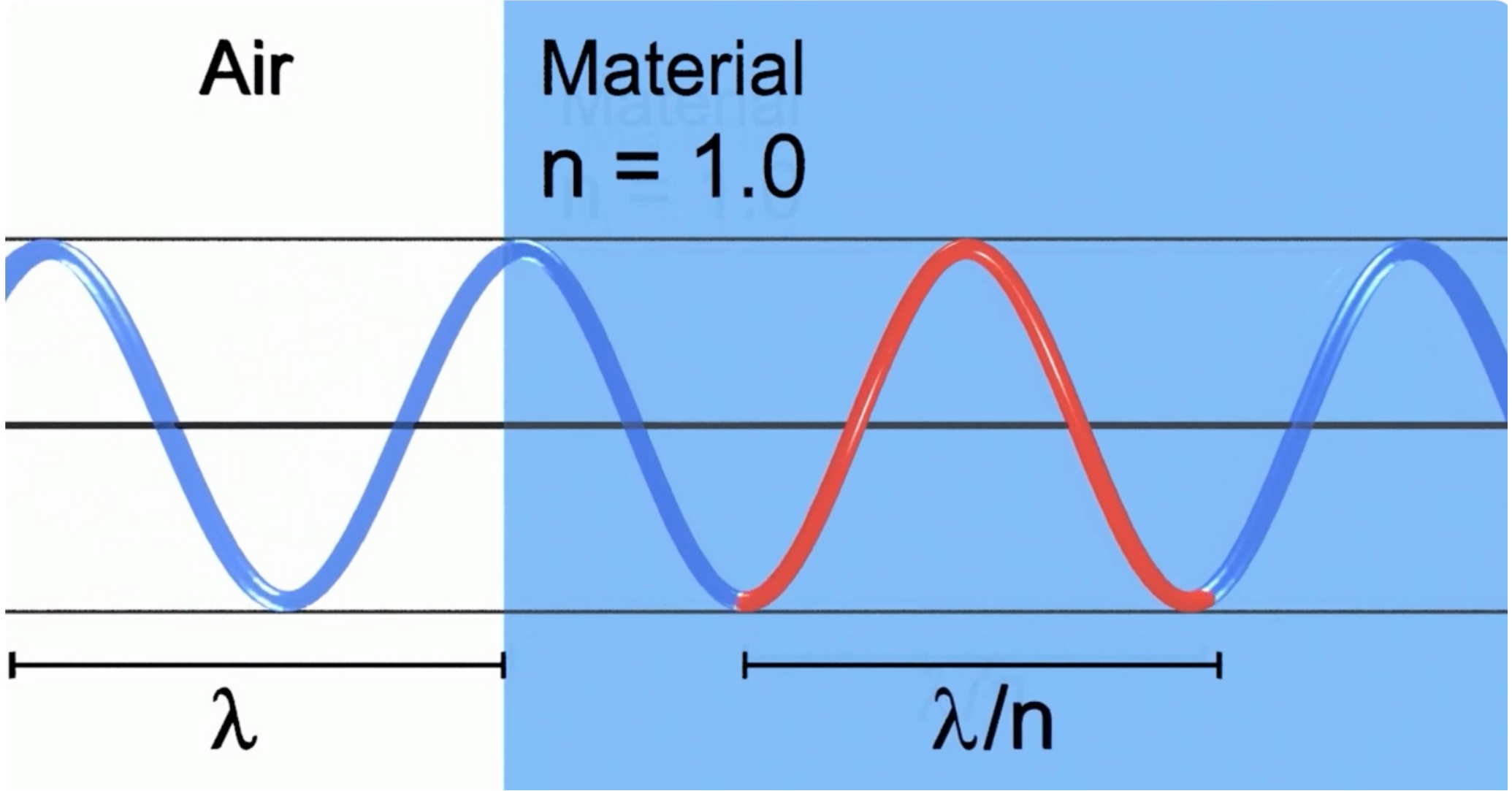
$$n = \frac{c}{v}$$

# Basic Principles of Light Propagation Through Materials

If refractive index increases, wavelength of light becomes shorter due to the light electric field and material



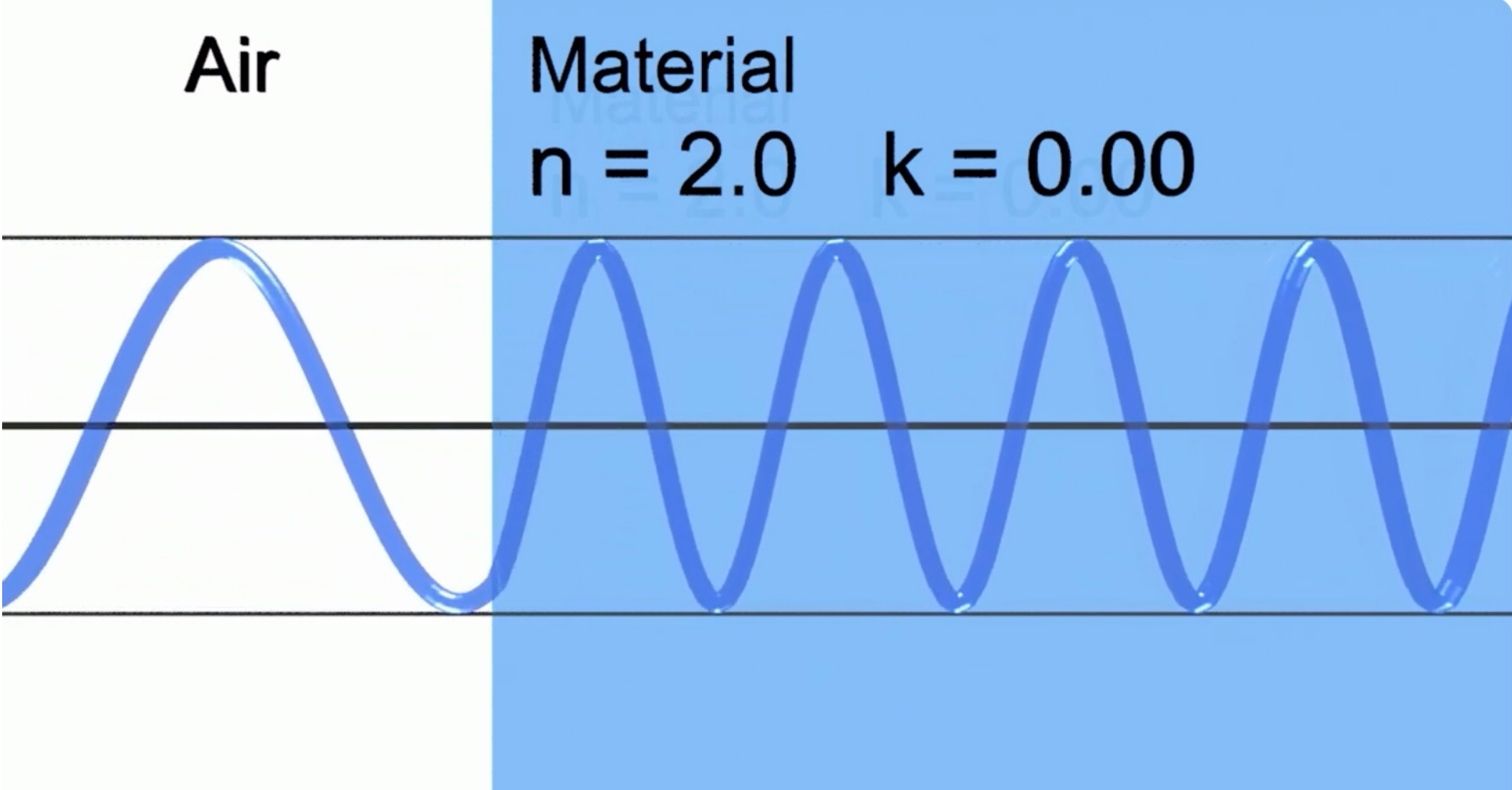
Continuous propagation through material when refractive index = 1



# Basic Principles of Light Propagation Through Materials

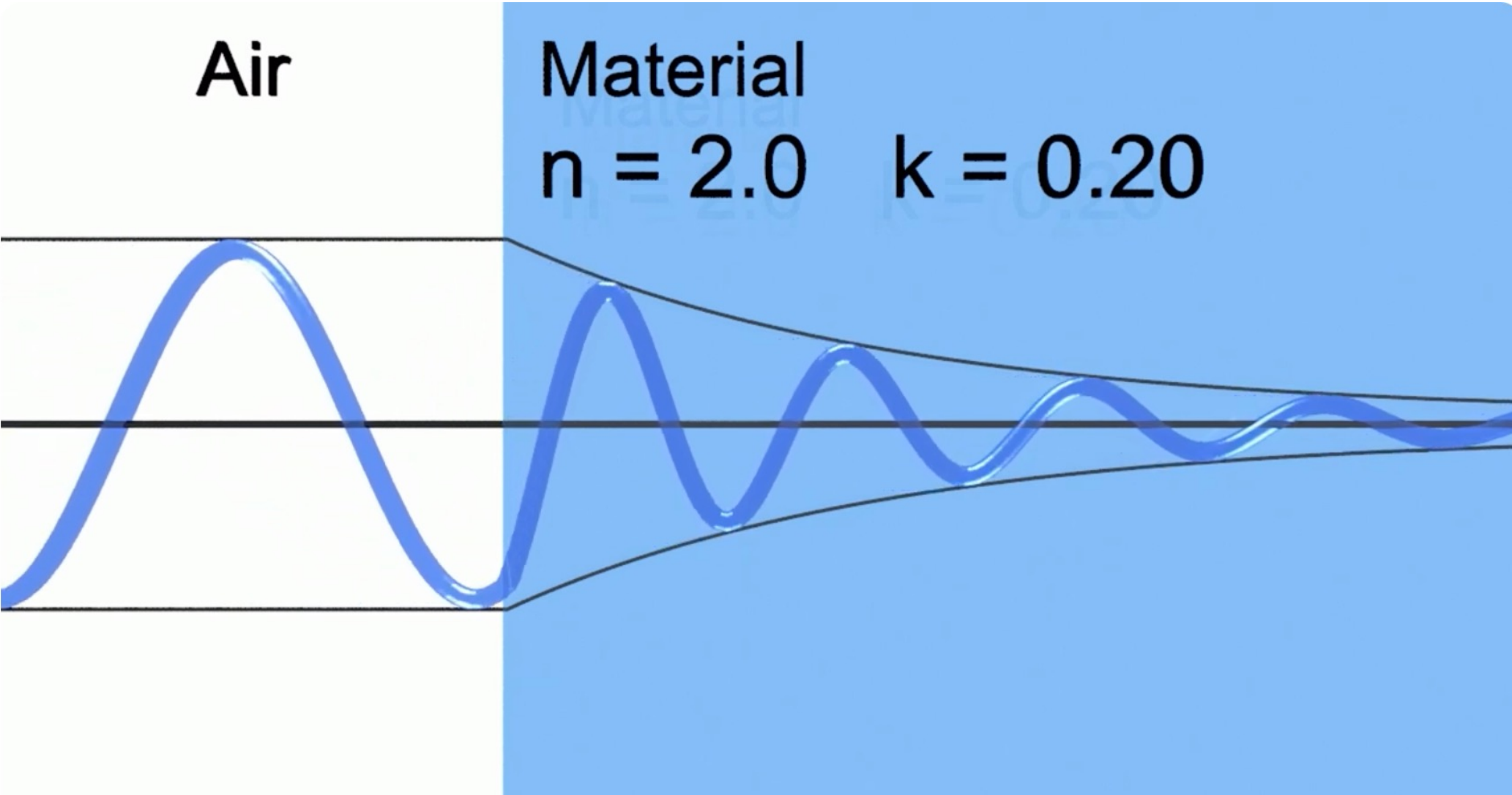
Extinction coefficient ( $k$ ) = 0

Material completely transparent  
No change in amplitude

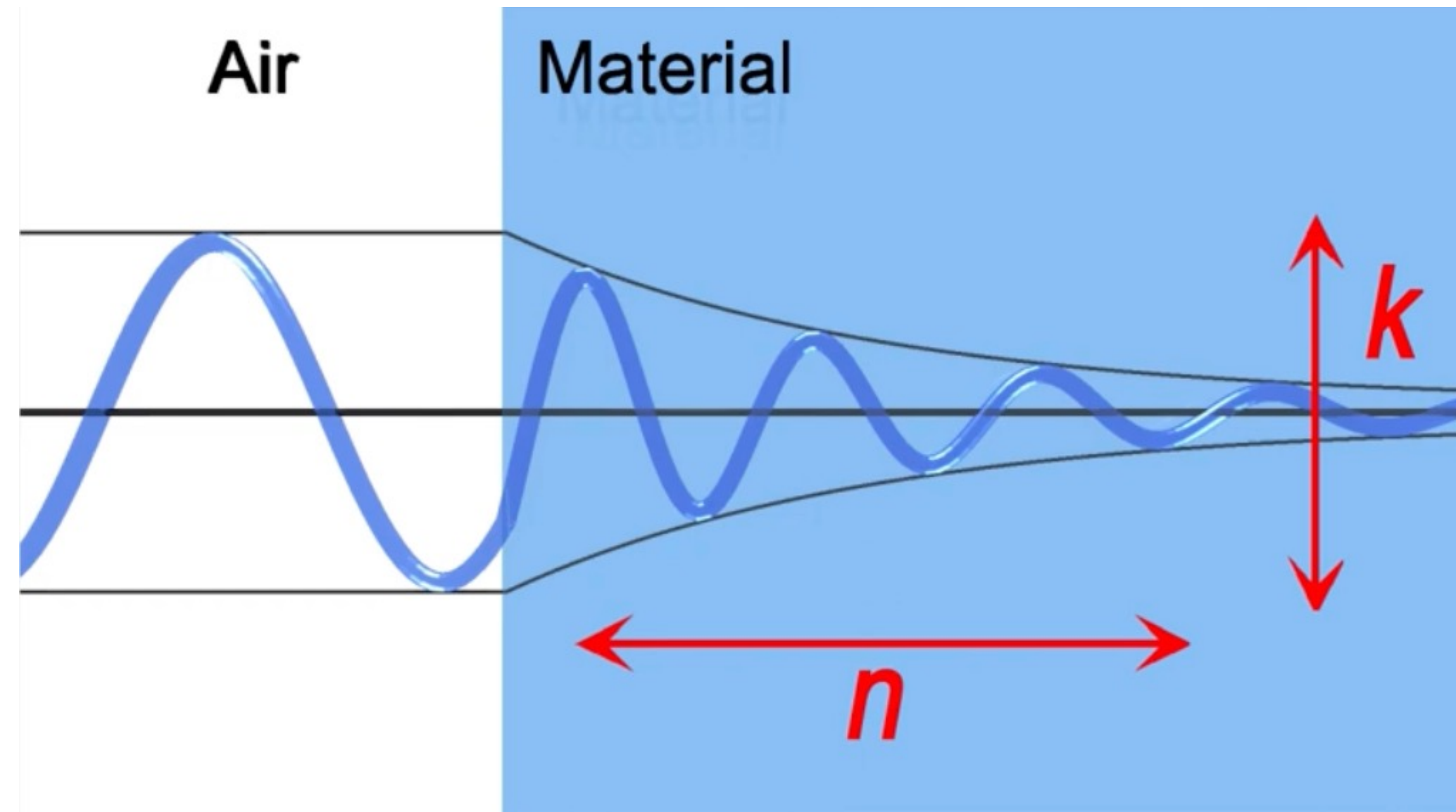


Increase  $k$

Amplitude of wave decreases based on  
light absorption in material



# Optical Constants $n$ & $k$ Define Material Optical Properties



Absorption coefficient

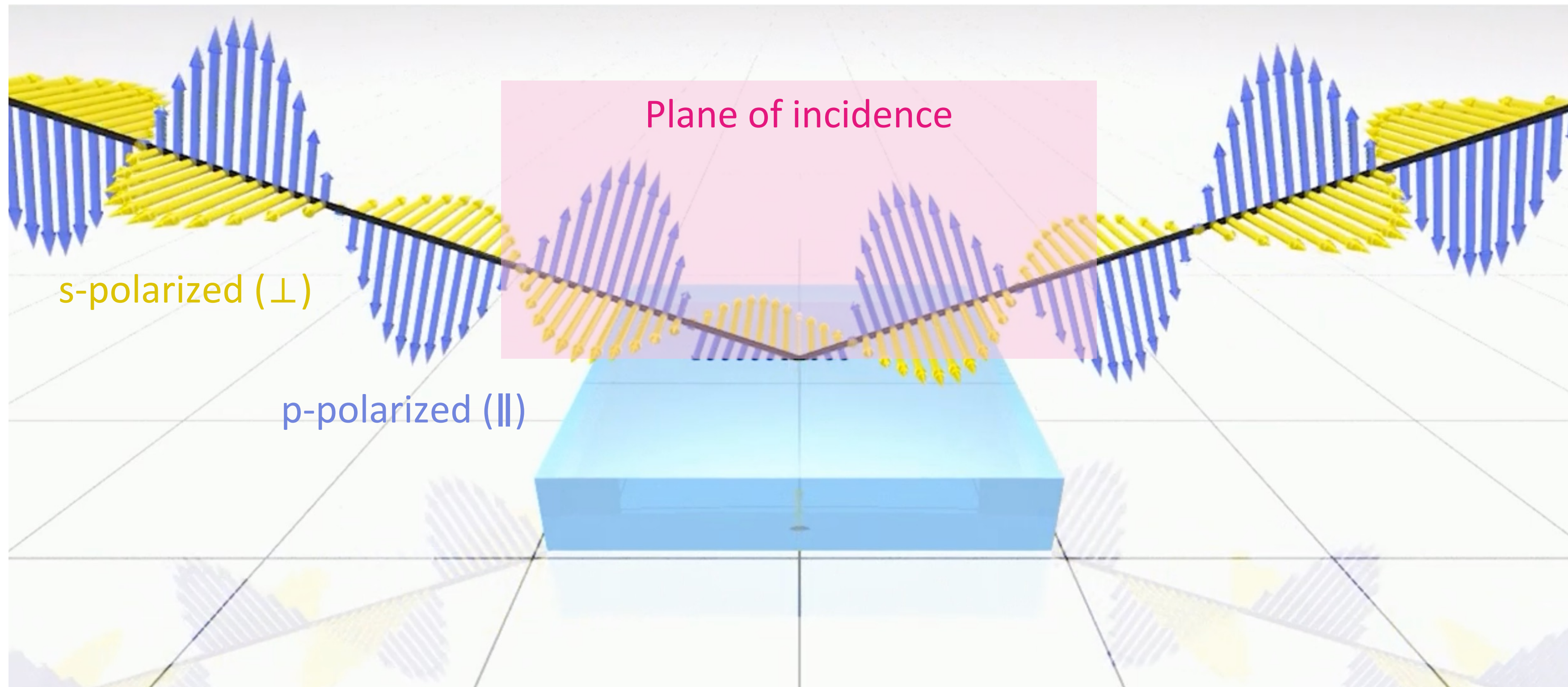
$$\alpha = \frac{4\pi}{\lambda} k$$

**Ellipsometry** is an optical instrument that determines the optical constant of materials

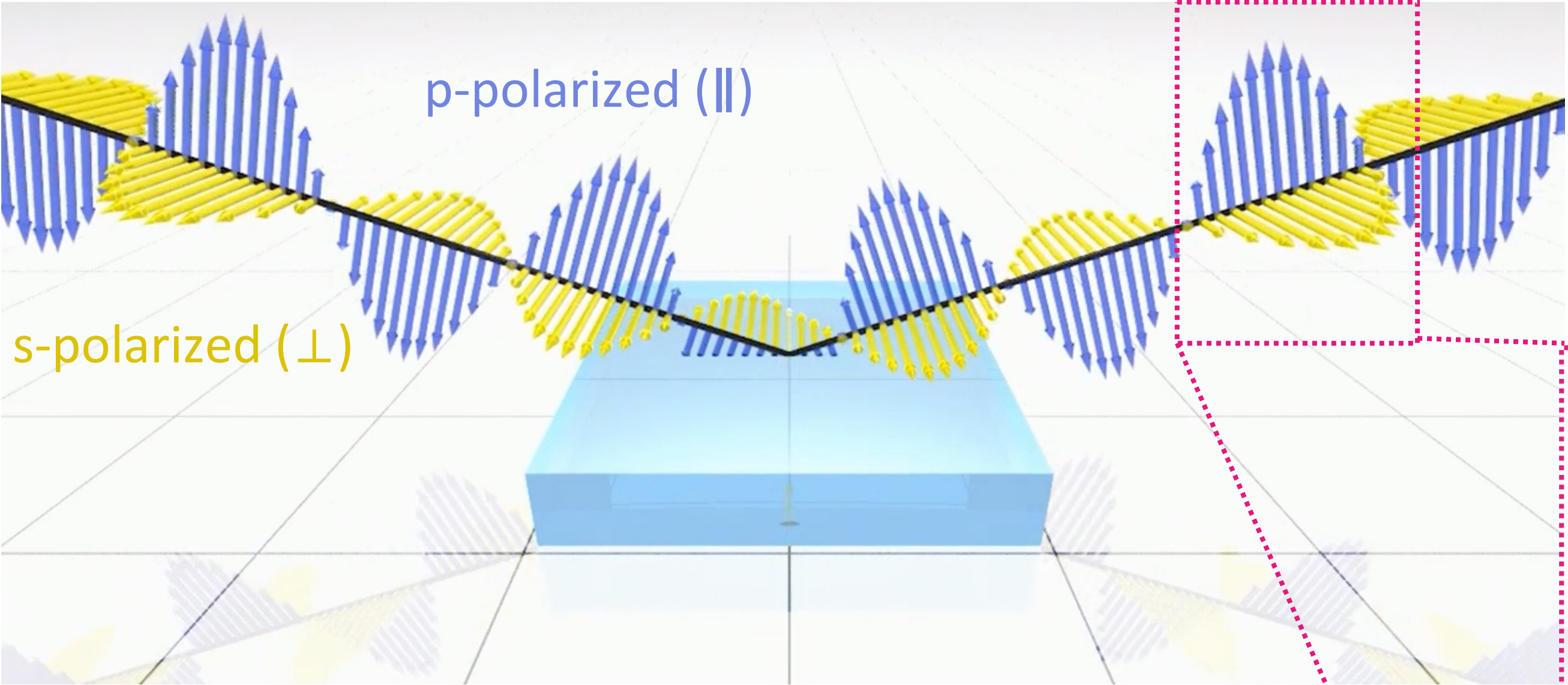
# Ellipsometry Shines Polarized Light onto Surfaces

Linearly polarized light (s and p components oscillate in phase)

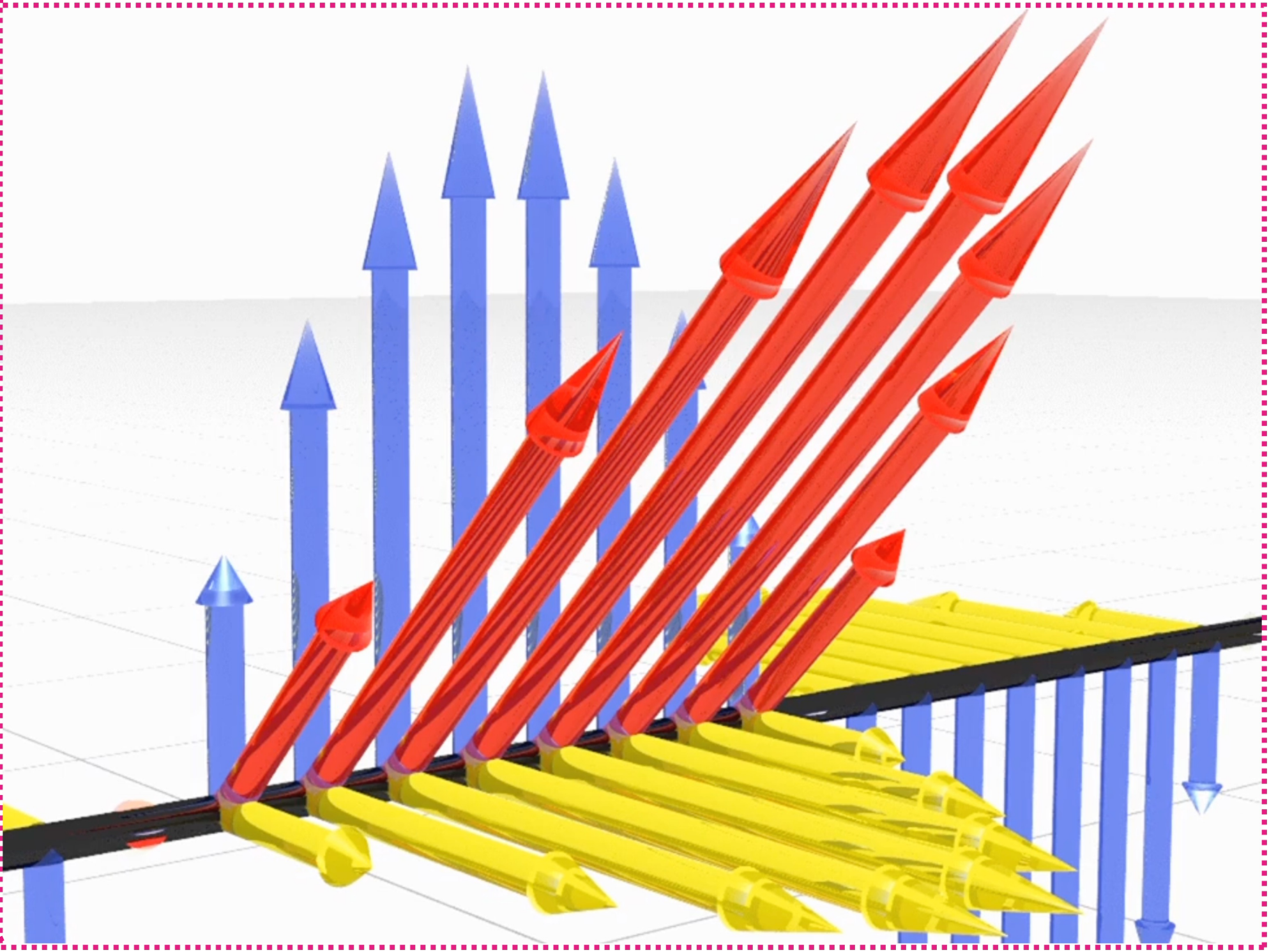
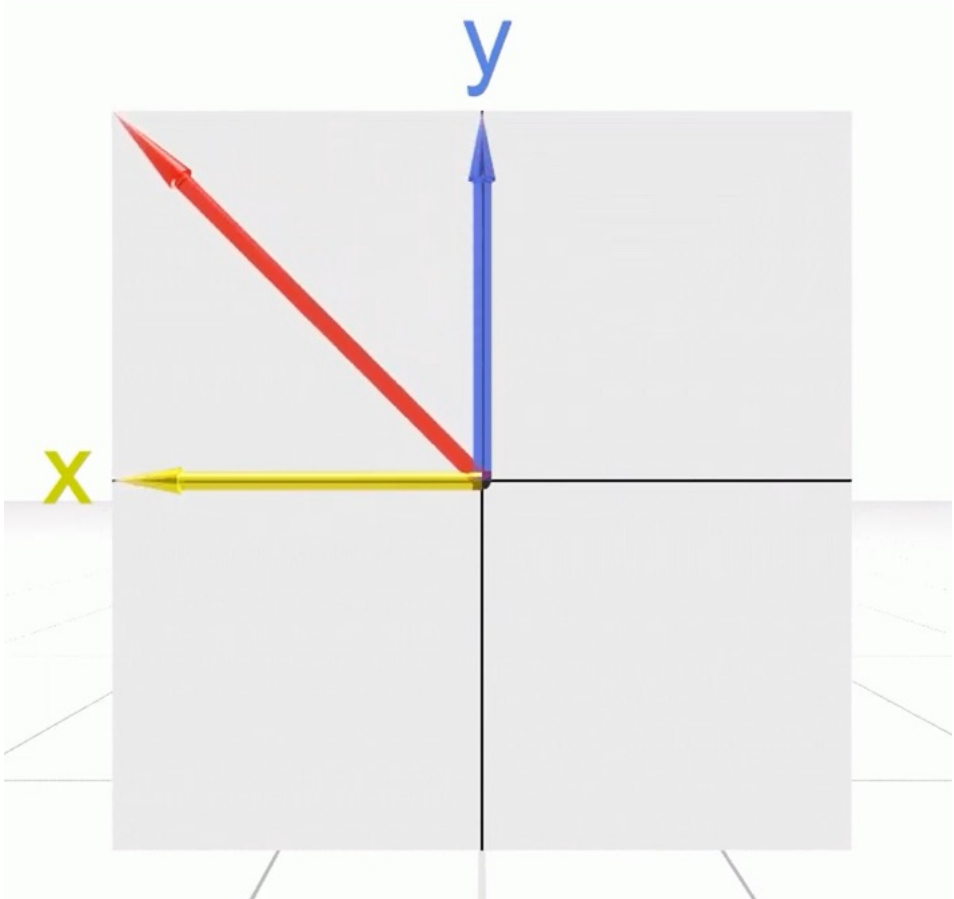
Reflected light shows a different polarization state



# Oscillation of Electric Field Components

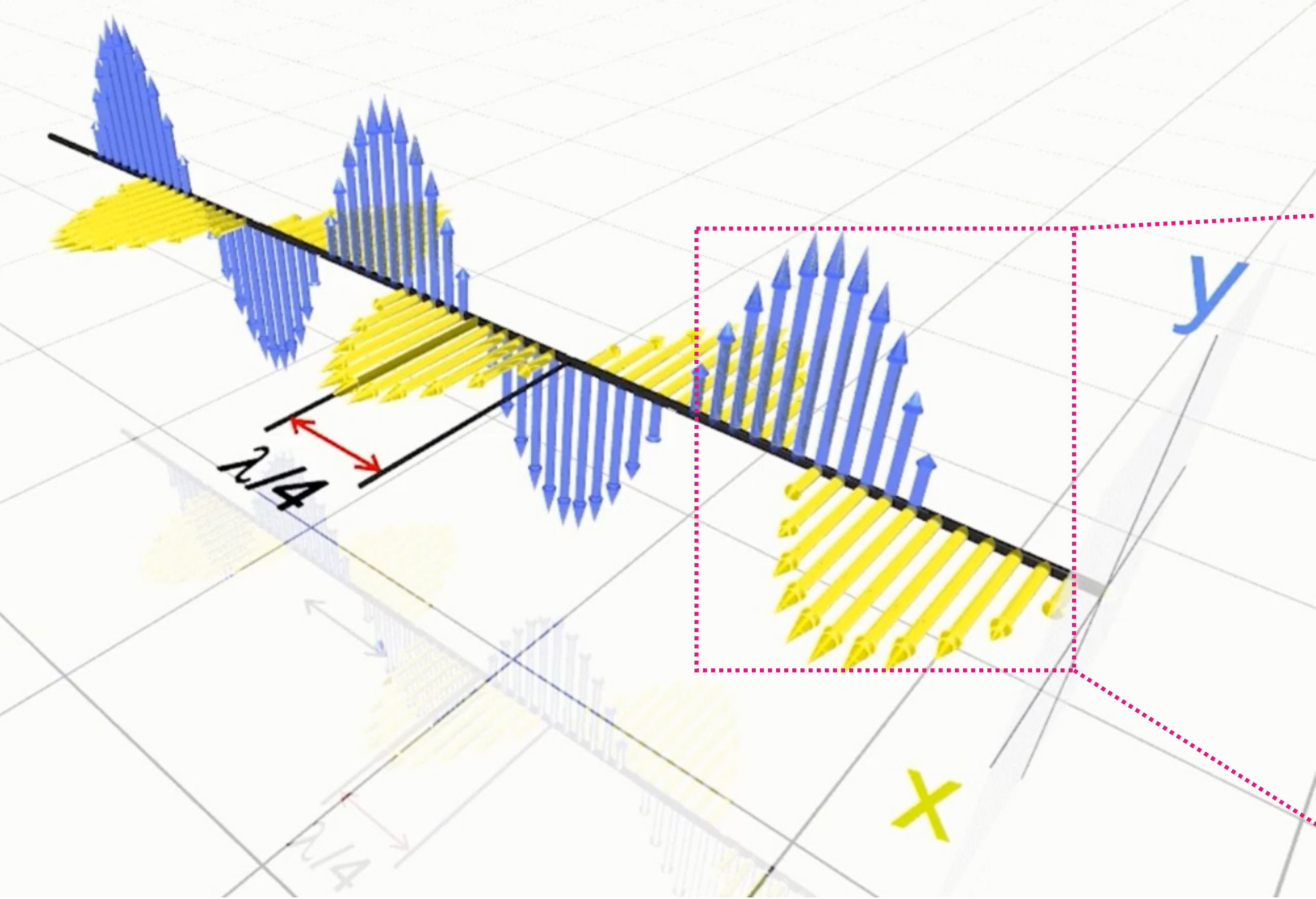


Adding electric field components in x-y directions forms a synthesized vector that oscillates linearly

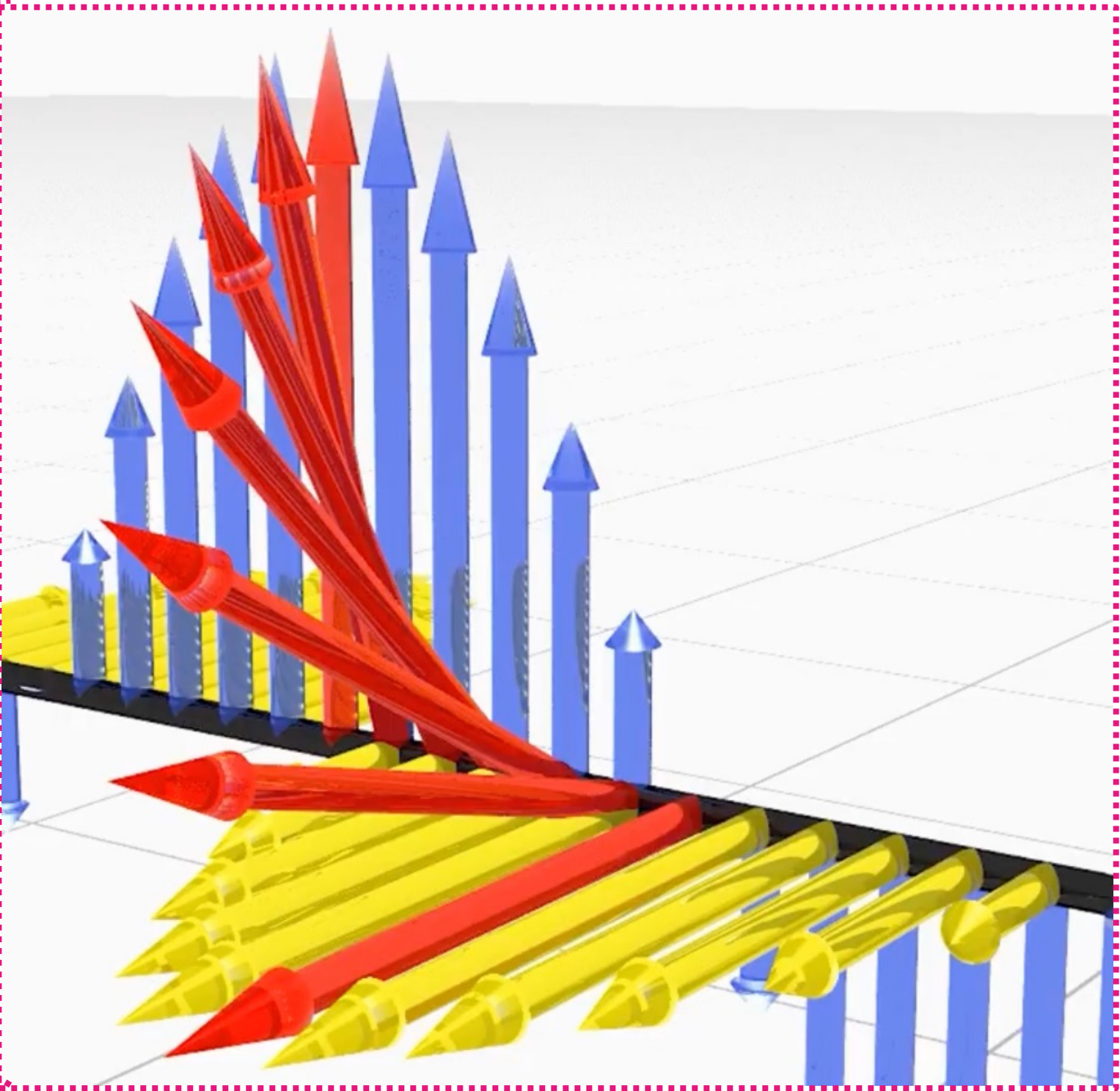


# Phase Shifts Causing Changes in Combined Vector

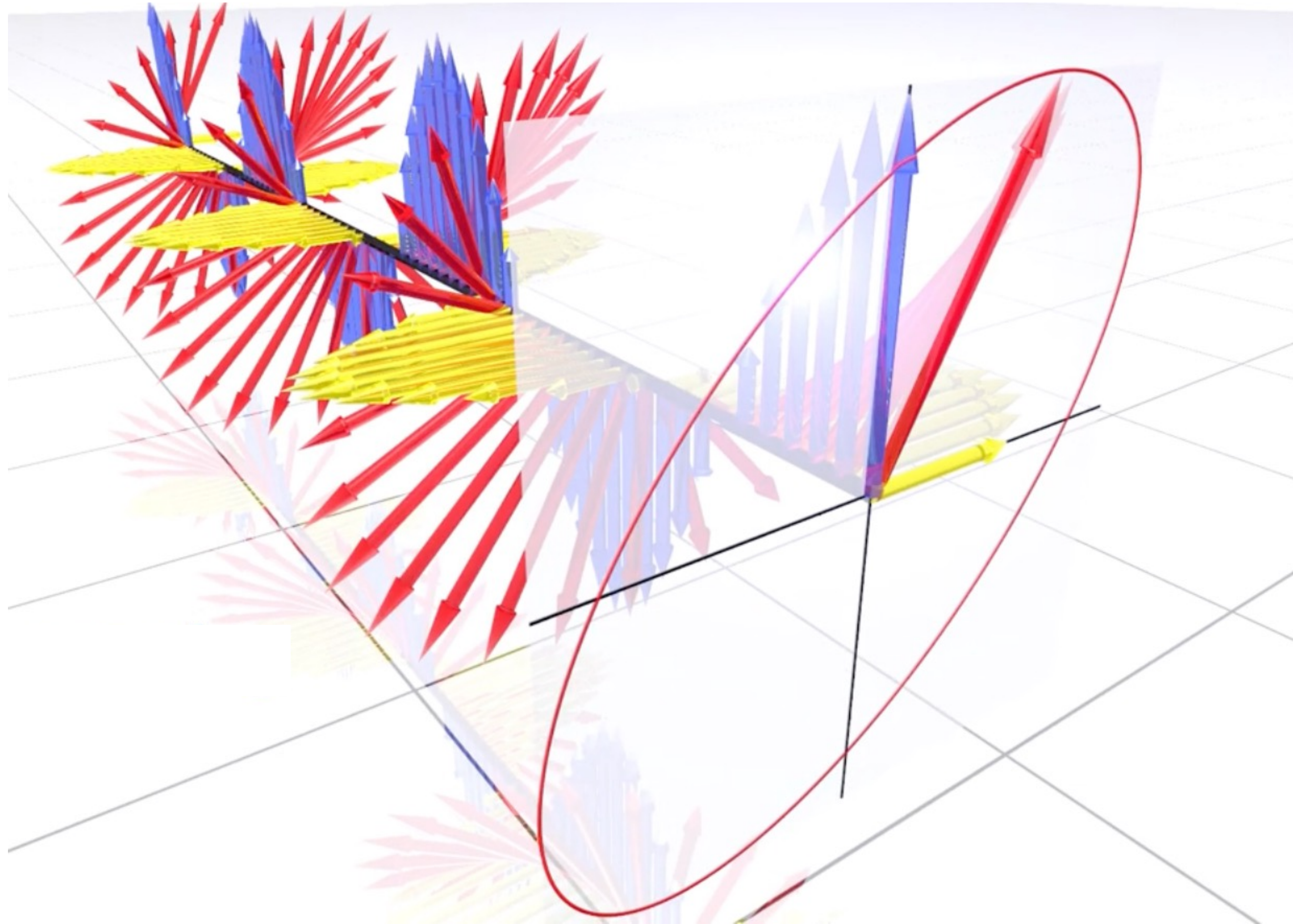
Consider wave in the x-direction advances forward compared to the y-direction with a phase difference ( $90^\circ$ )



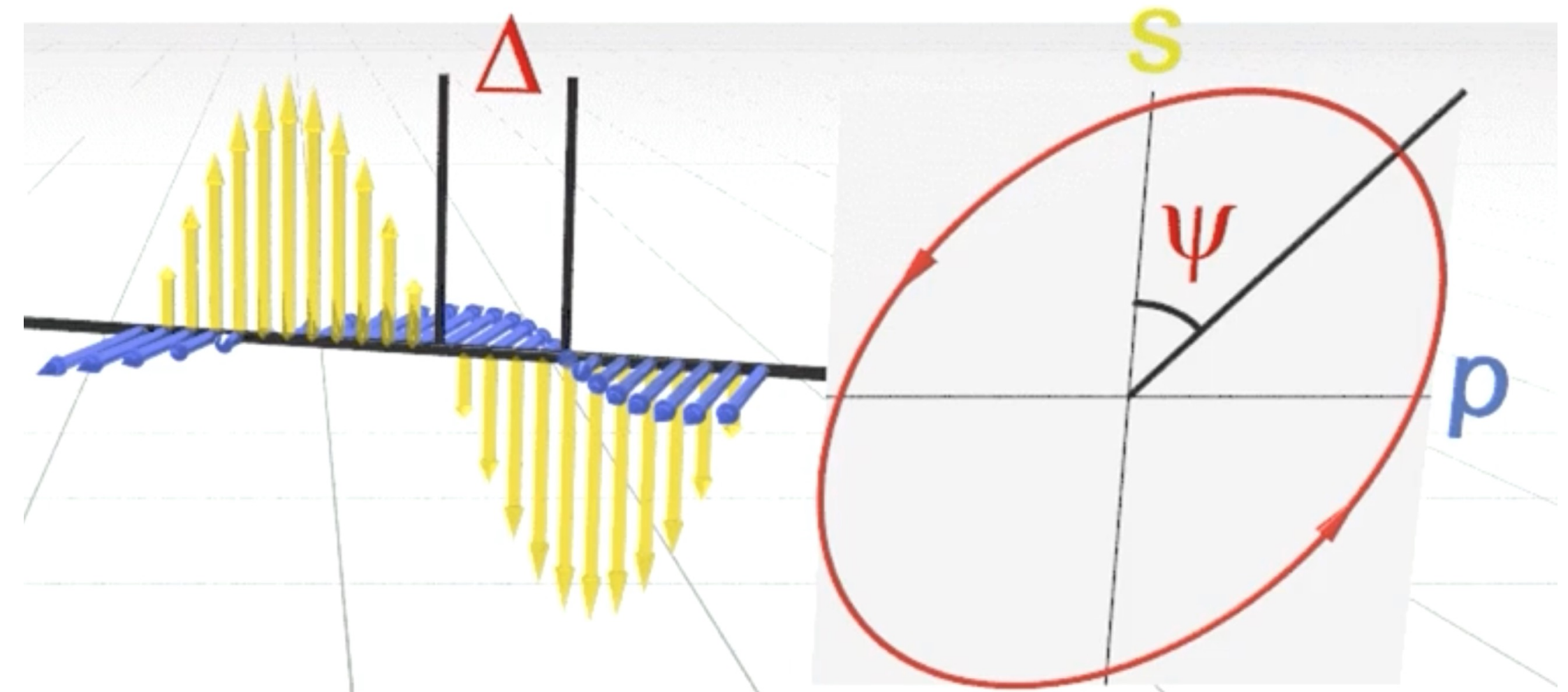
Superimpose waves in x-y direction – synthesized vector rotates continuously on x-y plane as light propagates



# “Ellipsometry” – Light Polarization Often Elliptical



Ellipsometry measures two angles:  
 $\Delta$  and  $\Psi$  of the reflected light



$\Delta$ : relative phase difference  
between s and p polarizations

$\Psi$ : angle determined by relative  
amplitude of s and p waves

Optical constants “n” and “k” determined from  $\Delta$  and  $\Psi$

# “Ellipsometry” – Light Polarization Often Elliptical

Complex ratio of reflection coefficients  
of p and s polarized light

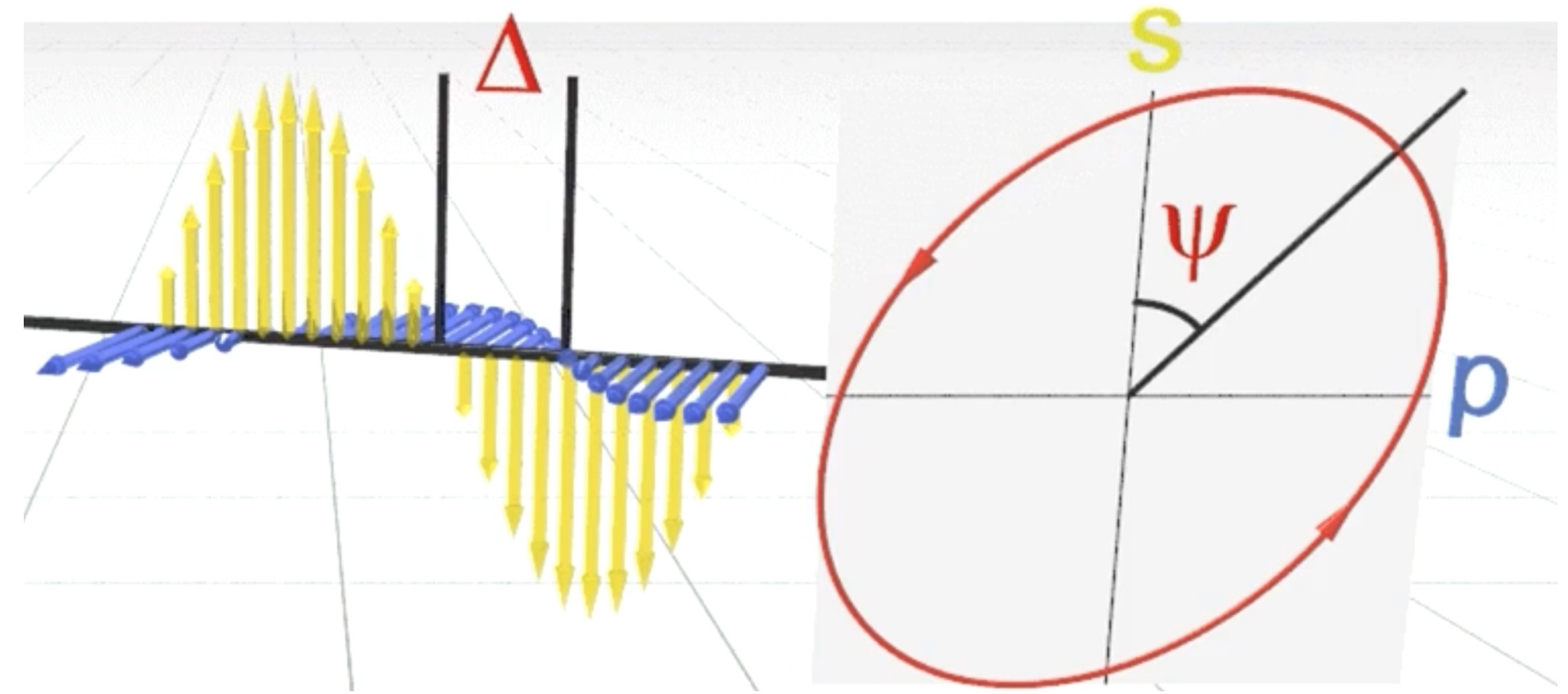
$$\frac{R_p}{R_s} = \tan \Psi e^{i\Delta}$$



Refractive index (n)  
Extinction coefficient (k)  
Thickness of the film

Ellipsometry measures two angles:

$\Delta$  and  $\Psi$  of the reflected light



$\Delta$ : relative phase difference  
between s and p polarizations

$\Psi$ : angle determined by relative  
amplitude of s and p waves

# Pros and Cons of Ellipsometry

Quantification of thin film thickness (~0.5–200 nm)

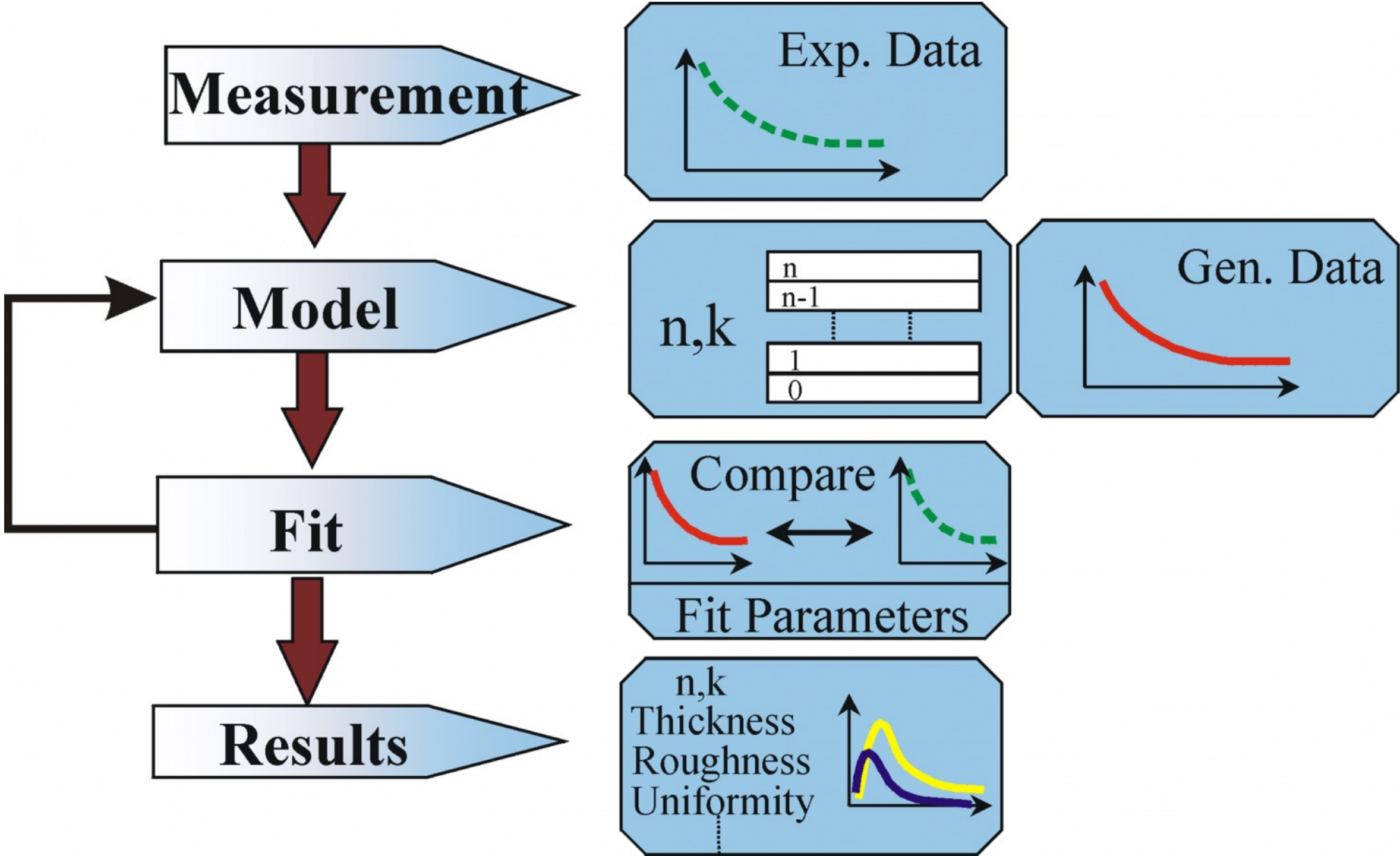
Complements QCM-D by providing dry mass and thickness

Provides refractive index – density, swelling, composition changes

Requires modeling to convert raw data to thickness

Needs uniform, smooth surfaces

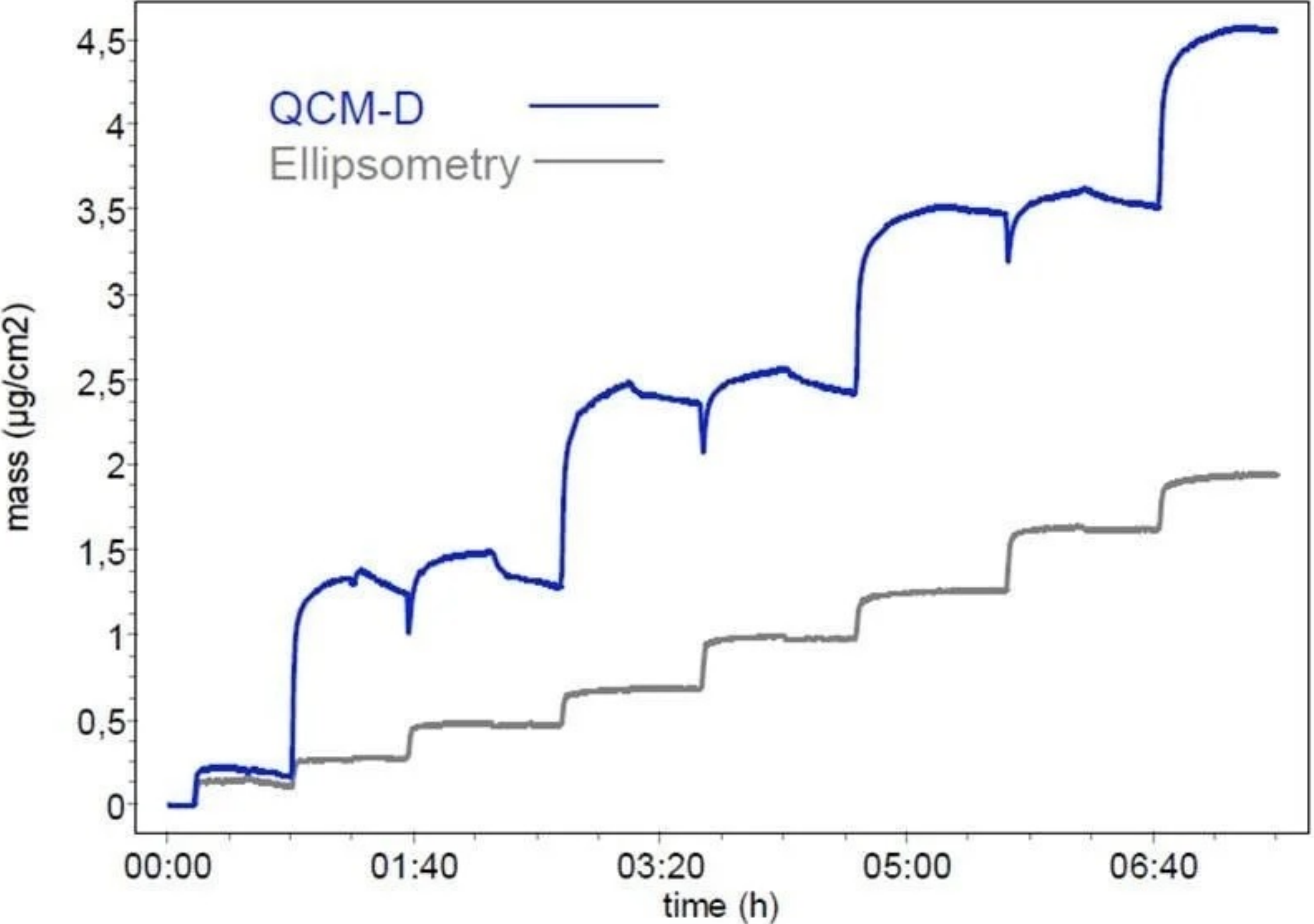
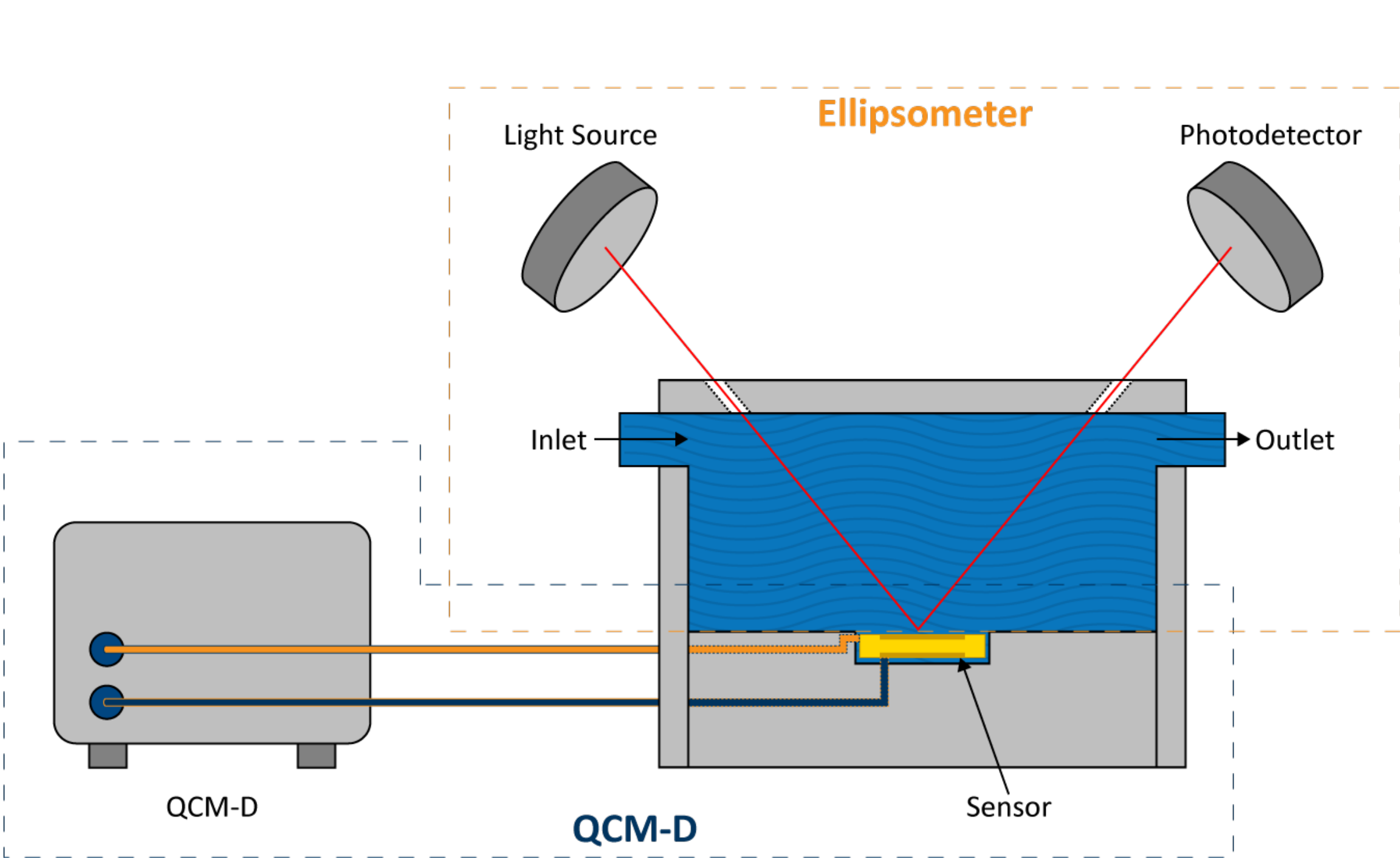
Slow acquisition speed – cannot conduct fast kinetics



# Combinatorial Measurements: QCM-D + Ellipsometry

**QCM-D** measures real-time mass changes and viscoelastic properties at surfaces



**Ellipsometry** measures changes in the polarization of reflected light to determine film thickness, refractive index, and optical properties

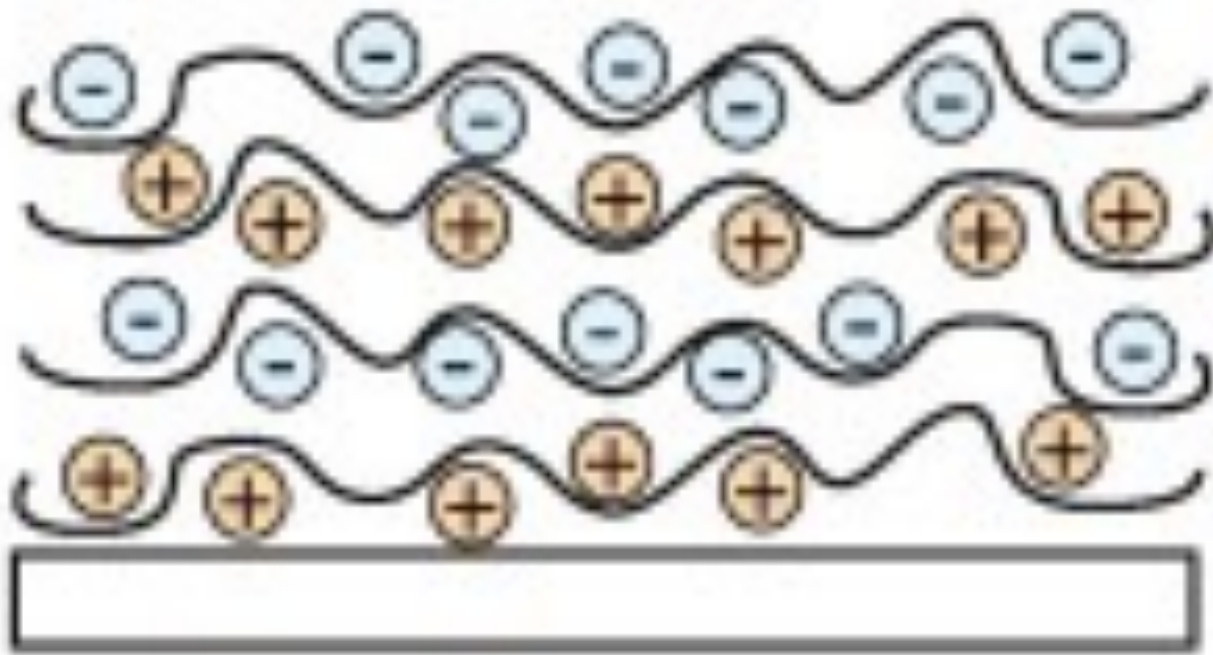


# Combinatorial Measurements: QCM-D + Ellipsometry

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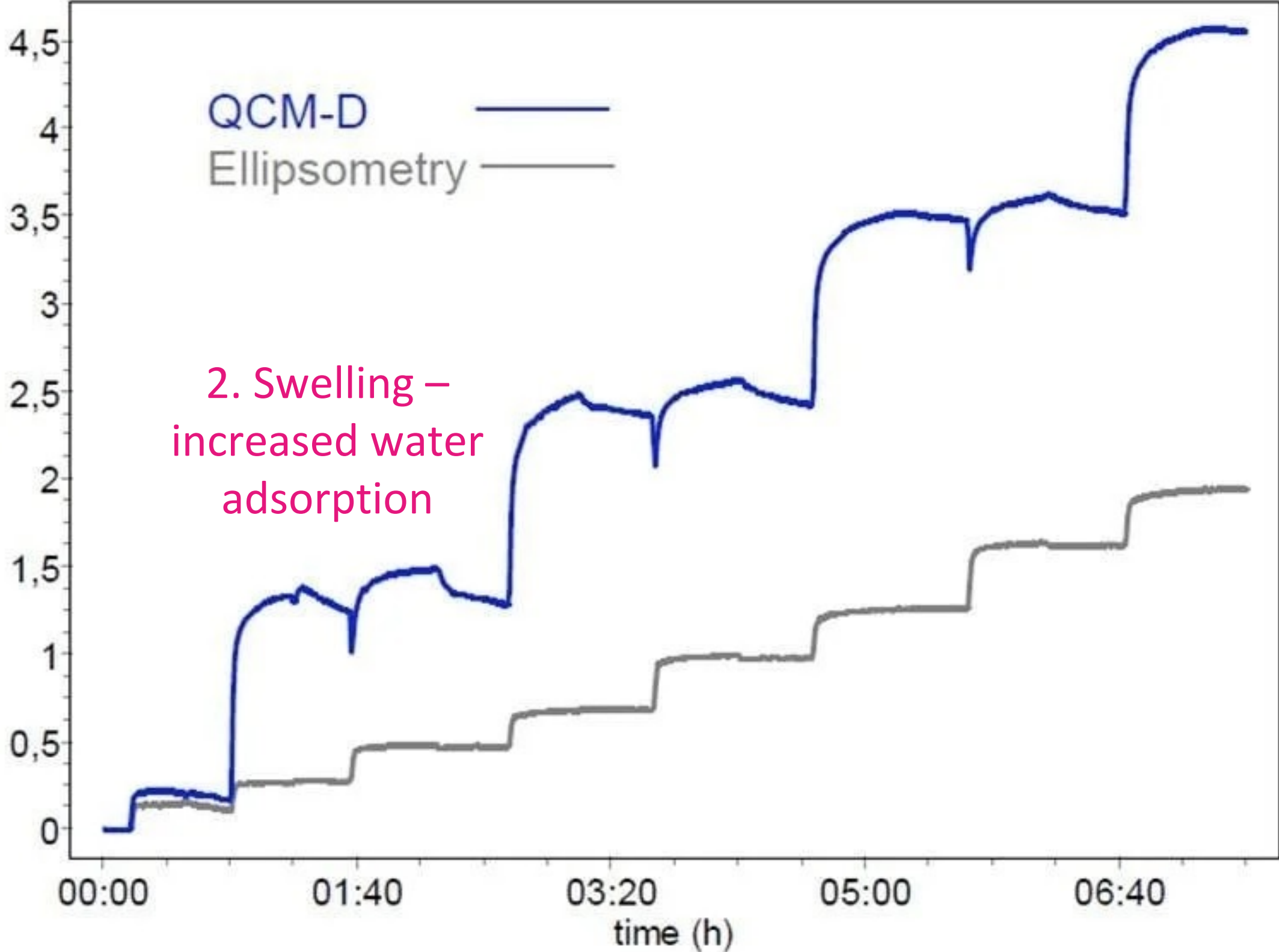
-  Negative polyelectrolyte
-  Positive polyelectrolyte



**Polyelectrolyte multilayer**

De Boer & Schroën | Sep. Purif. Tech. | 2024

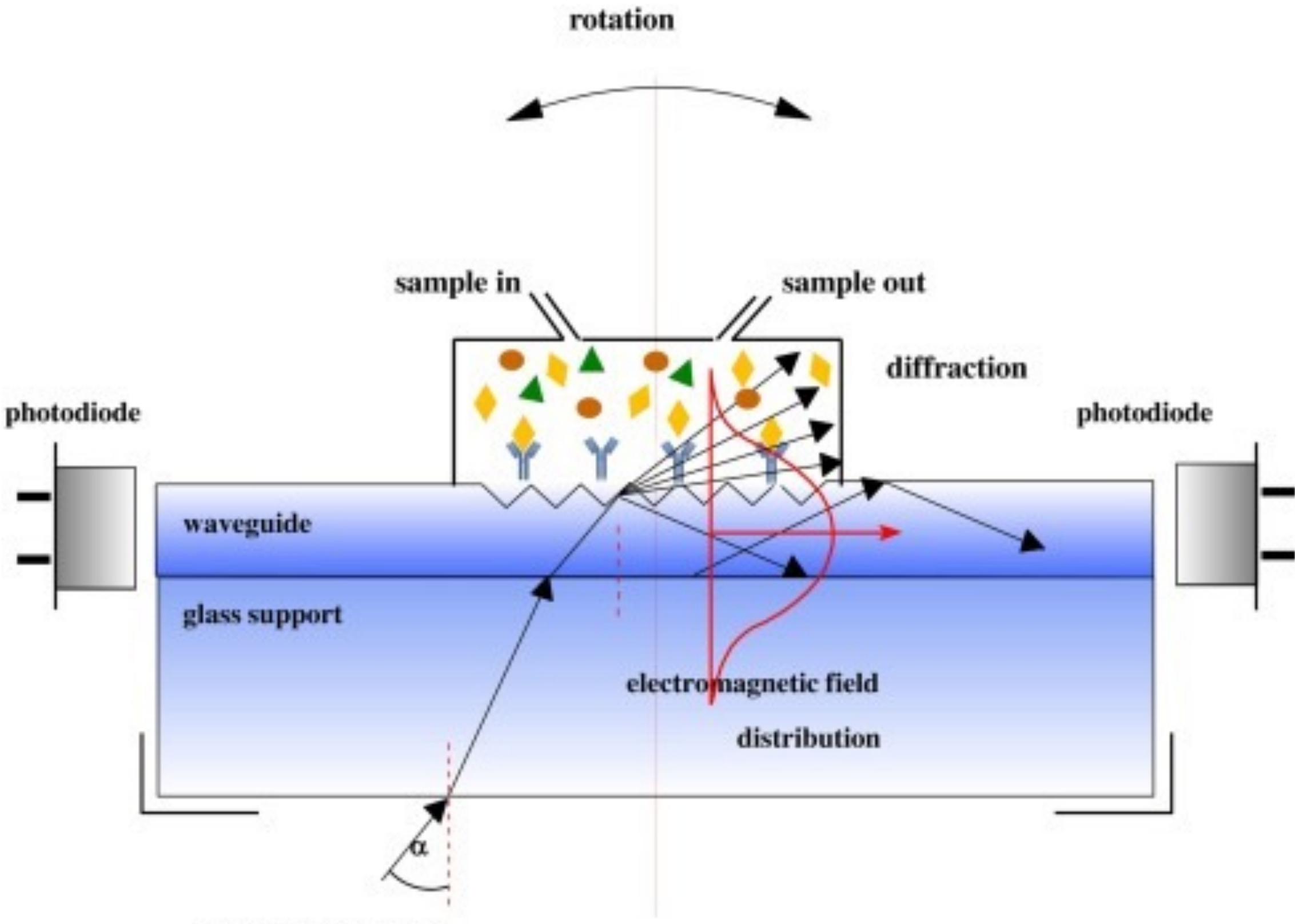
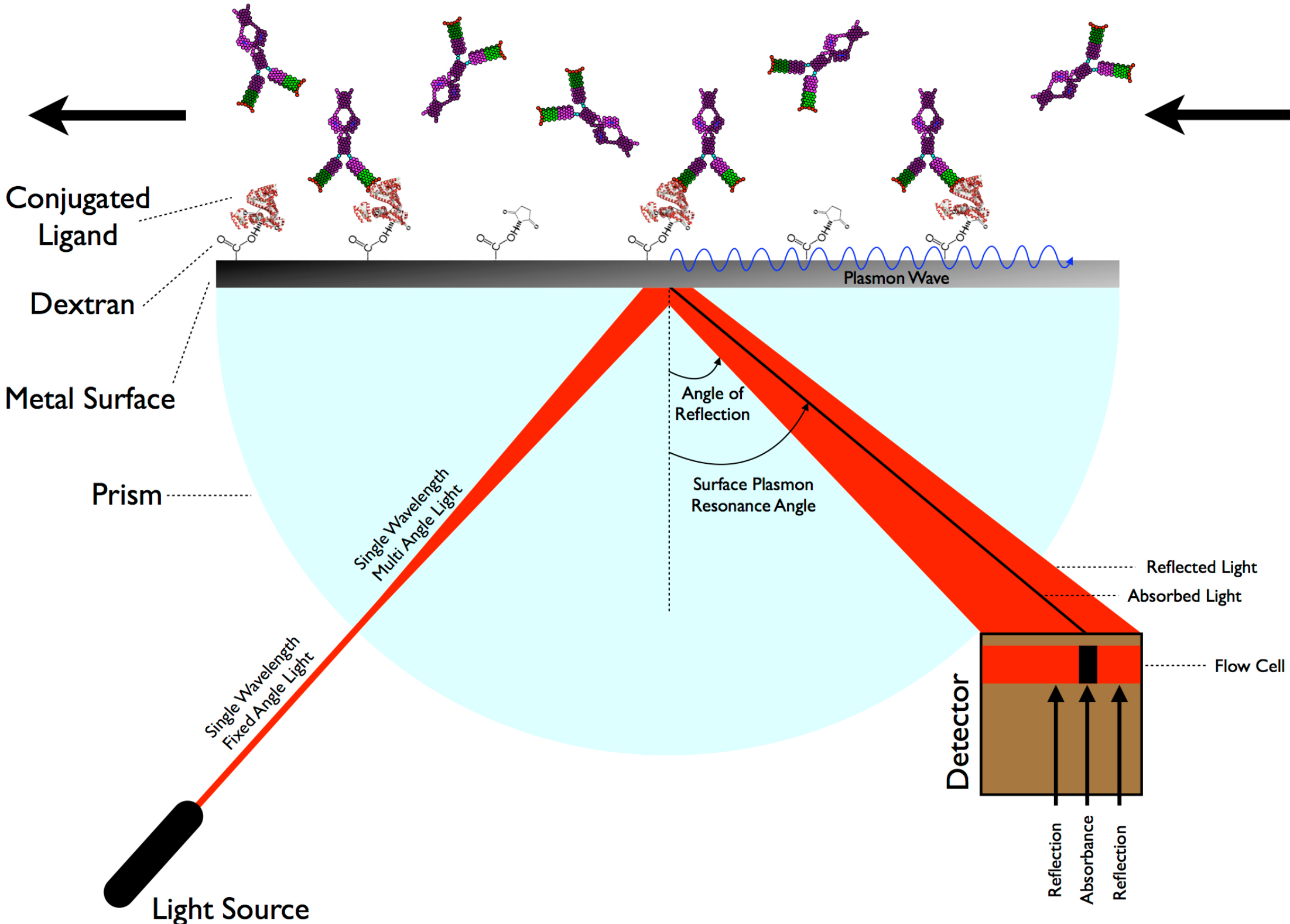
1. Compact anchor layer



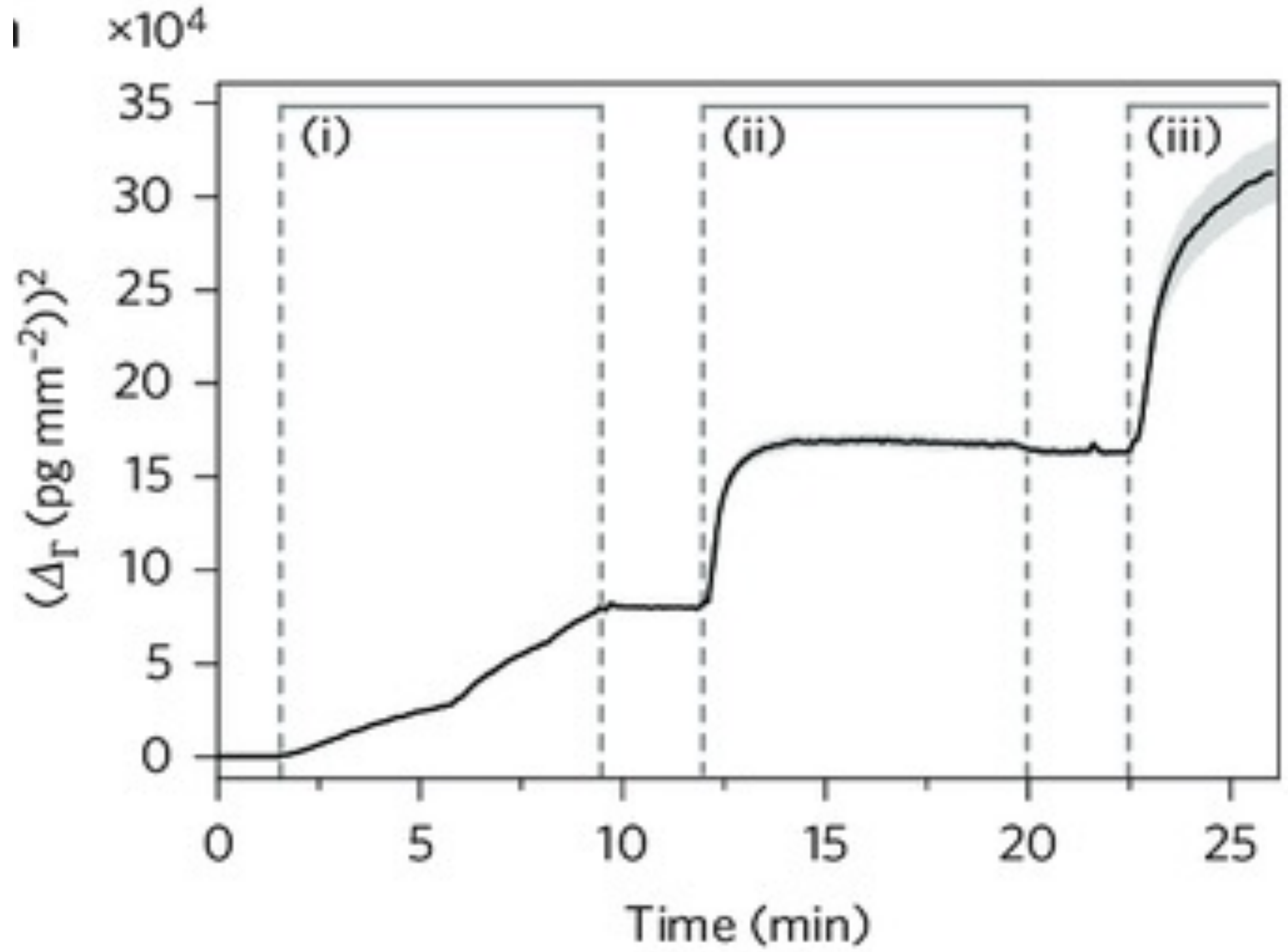
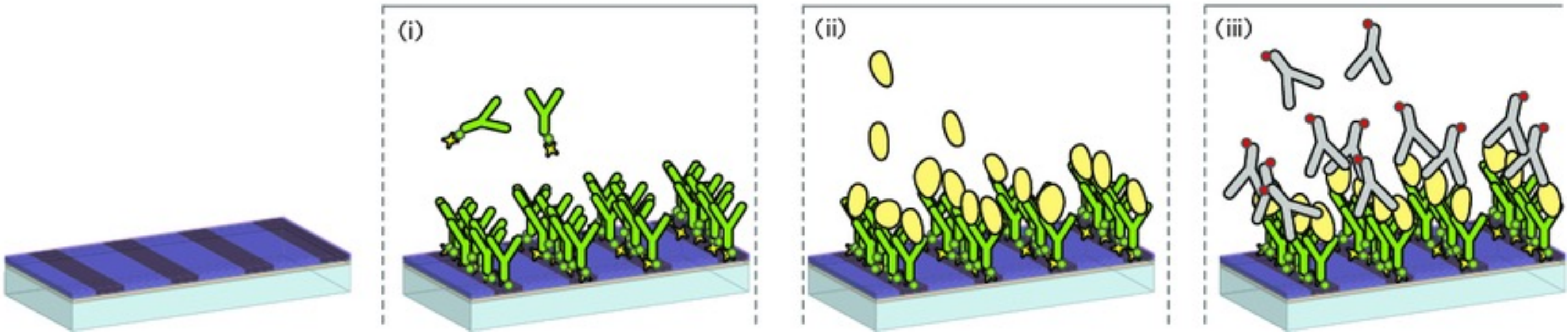
# OWLS and SPR – Binding Kinetics and True Dry Mass Changes

**OWLS:** Optical waveguide light-assisted spectroscopy  
**SPR:** Surface plasmon resonance spectroscopy

Measure changes in refractive index near a surface as molecules bind



# OWLS and SPR – Binding Kinetics and True Dry Mass Changes



# OWLS vs. SPR – Binding Kinetics and True Dry Mass Changes

Feature	SPR	OWLS
Optical mode	Surface plasmons on gold	Guided modes in a waveguide
Sensing depth	~200 nm	~150–200 nm
Substrate	Gold	SiO <sub>2</sub> /TiO <sub>2</sub> -based waveguides
Sensitivity	0.1 ng/cm <sup>2</sup>	1 ng/cm <sup>2</sup>
Strength	Kinetic measurements (fast interactions)	Quantitative surface mass density (pg/mm <sup>2</sup> )
Weakness	Susceptible to environmental changes (temperature, buffer changes)	Susceptible to environmental changes (temperature, buffer changes)

# Key Takeaways

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- We recapped the basic principles of light propagation through materials
- For ellipsometry, optical properties and layer thickness are determined
- Ellipsometry can be combined with QCM-D for both dry and wet mass
- Real-time monitoring of dry mass changes can be conducted by SPR/OWLS
- Choosing the technique is often dependent on the system you are probing

# Summary of Today's Class

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We expanded our toolbox of surface characterization techniques:

- Atomic force microscopy/Fluid force microscopy
- Quartz crystal microbalance with dissipation monitoring
- Ellipsometry
- Surface plasmon resonance and optical waveguide lightmode spectroscopy

Different surface properties (viscoelasticity, mechanical, thickness) can be explored using a combination of these techniques at interfaces

Prof. Nako Nakatsuka  
[nako.nakatsuka@epfl.ch](mailto:nako.nakatsuka@epfl.ch)

EPFL  
Laboratory of Chemical Nanotechnology  
Campus Biotech  
Chemin des Mines 9  
1202, Geneva

<https://www.epfl.ch/labs/chemina/>

